

Tools and Techniques for Prototyping Haptic Interfaces

Sensors and Sensor Processing



Katherine J. Kuchenbecker, Ph.D.

General Robotics, Automation, Sensing, and Perception Lab (GRASP)
MEAM Department, SEAS, University of Pennsylvania



My definition of a haptic interface:

My definition of a haptic interface:

Senses a physical quantity from the user,
such as motion or force

My definition of a haptic interface:

Senses a physical quantity from the user,
such as motion or force

Physically acts on the user via a variable actuator

My definition of a haptic interface:

Senses a physical quantity from the user,
such as motion or force

Physically acts on the user via a variable actuator

Connects sensing to acting with fast processing

My definition of a haptic interface:

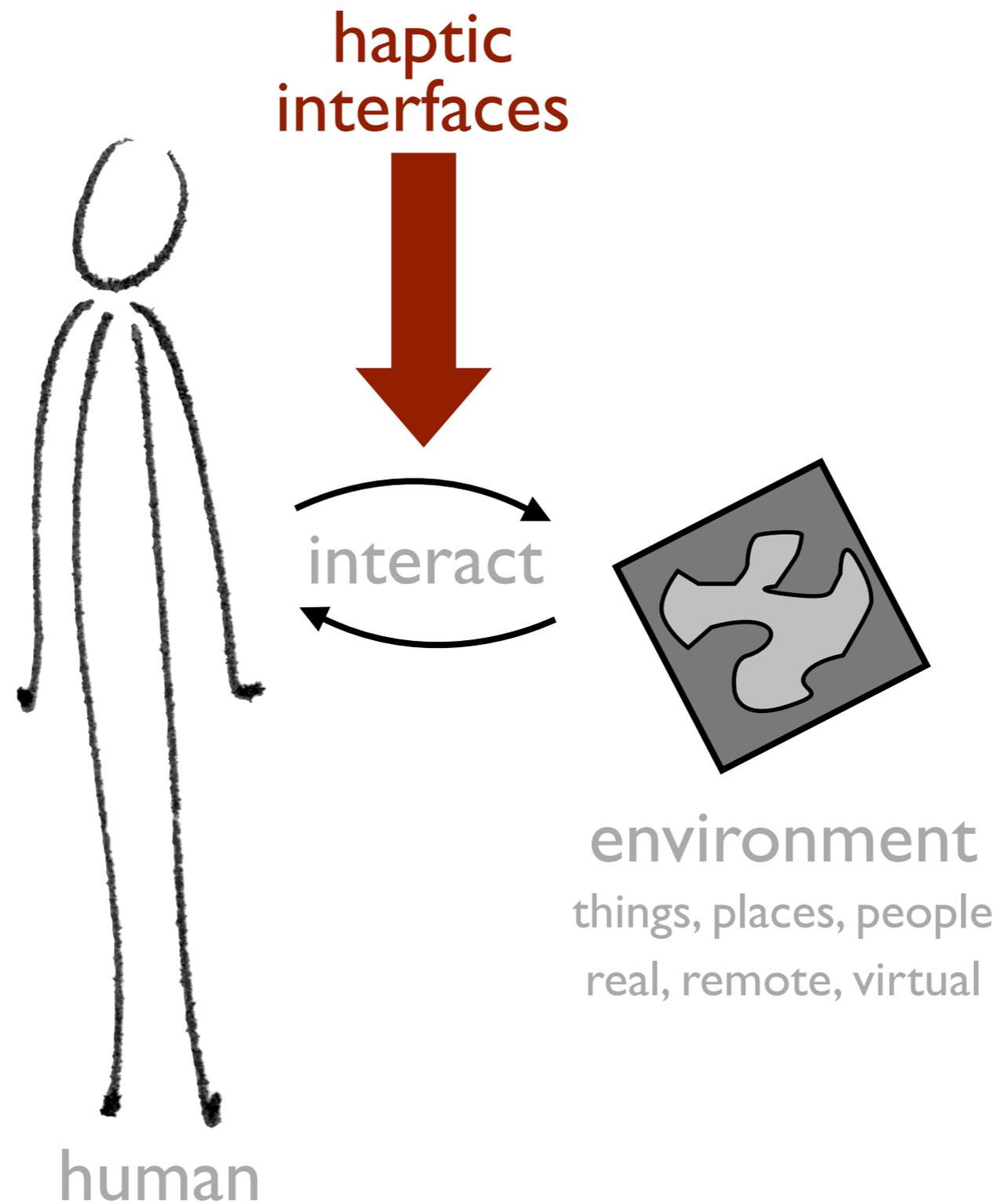
Senses a physical quantity from the user,
such as motion or force

Physically acts on the user via a variable actuator

Connects sensing to acting with fast processing

it's all about physical interaction with a user..

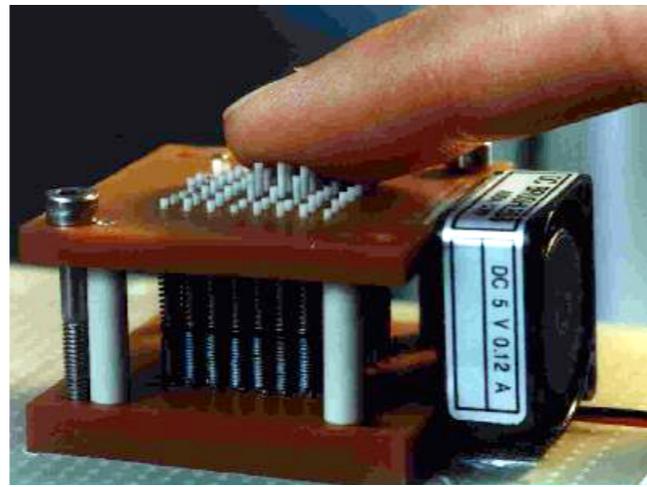
it's all about physical interaction with a user..



it's all about physical interaction with a user..

Haptic Interfaces

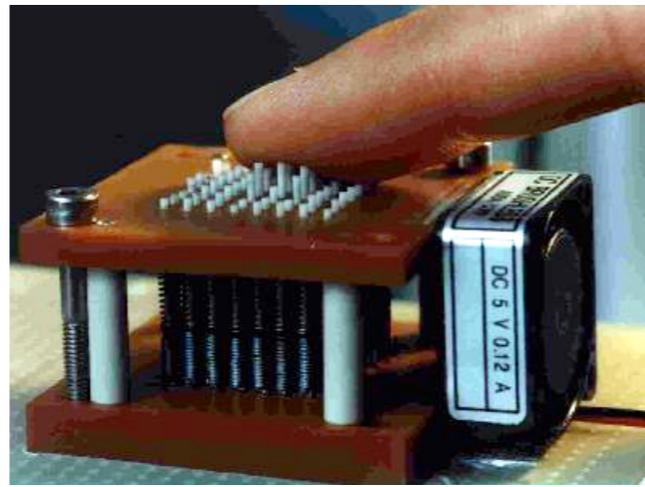
Haptic Interfaces



Tactile Devices

Stimulate skin to create contact sensations

Haptic Interfaces



Tactile Devices

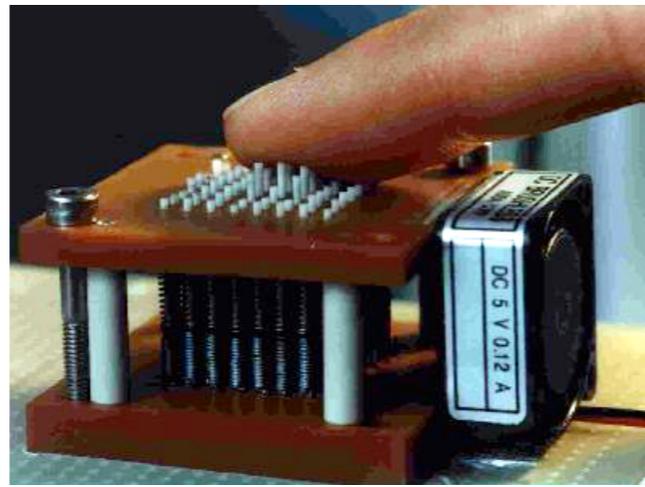
Stimulate skin to create contact sensations



Kinesthetic Devices

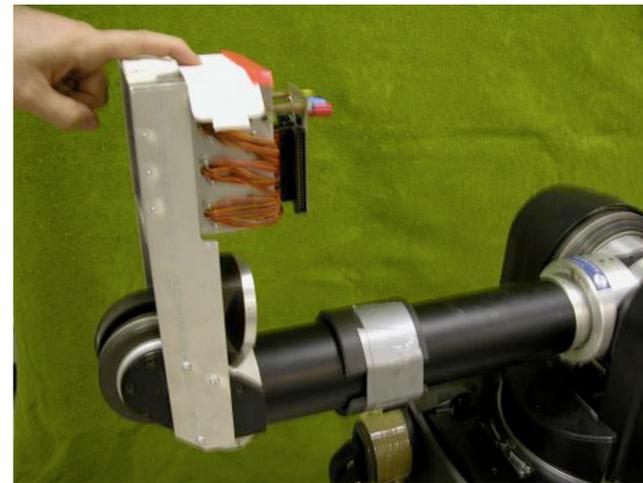
Apply forces to guide or inhibit body movement

Haptic Interfaces



Tactile Devices

Stimulate skin to create contact sensations



Hybrid Devices

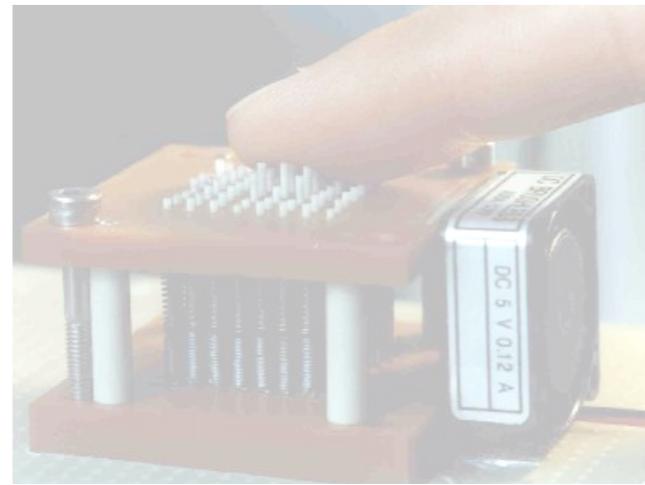
Attempt to combine tactile and kinesthetic feedback



Kinesthetic Devices

Apply forces to guide or inhibit body movement

Haptic Interfaces



Tactile Devices

Stimulate skin to create contact sensations



Hybrid Devices

Attempt to combine tactile and kinesthetic feedback



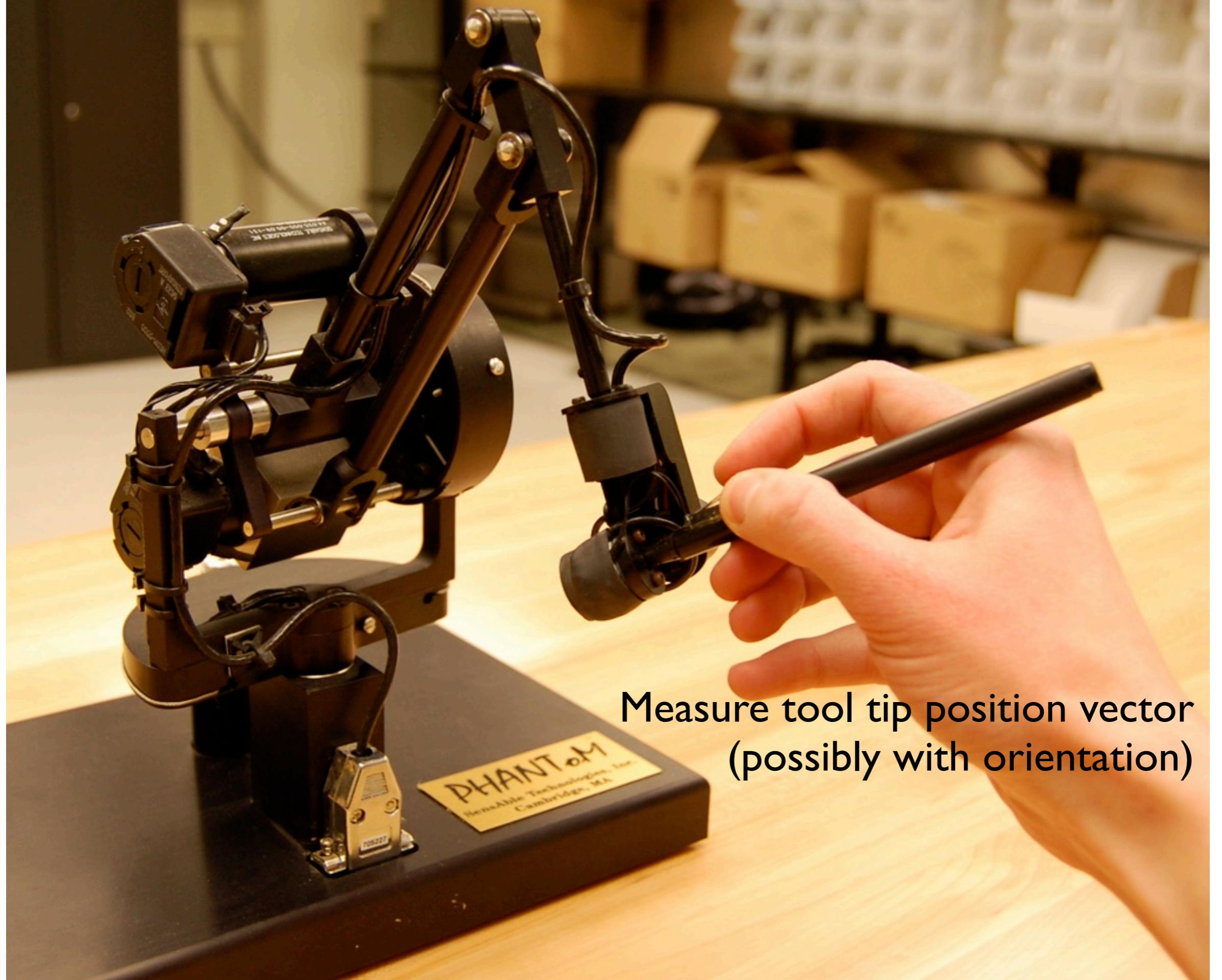
Kinesthetic Devices

Apply forces to guide or inhibit body movement

SensAble PHANToM Premium 1.0

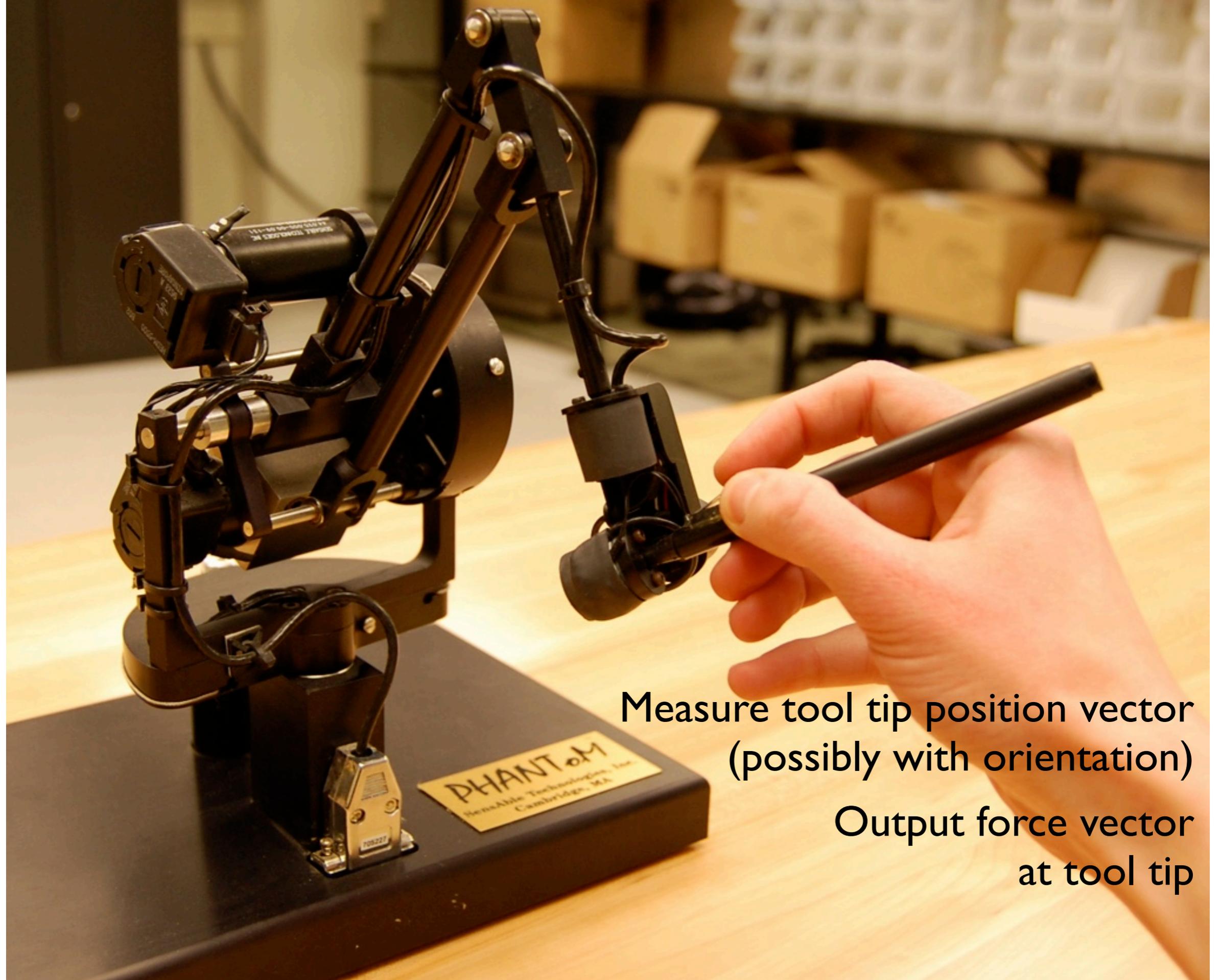


SensAble PHANToM Premium 1.0



Measure tool tip position vector
(possibly with orientation)

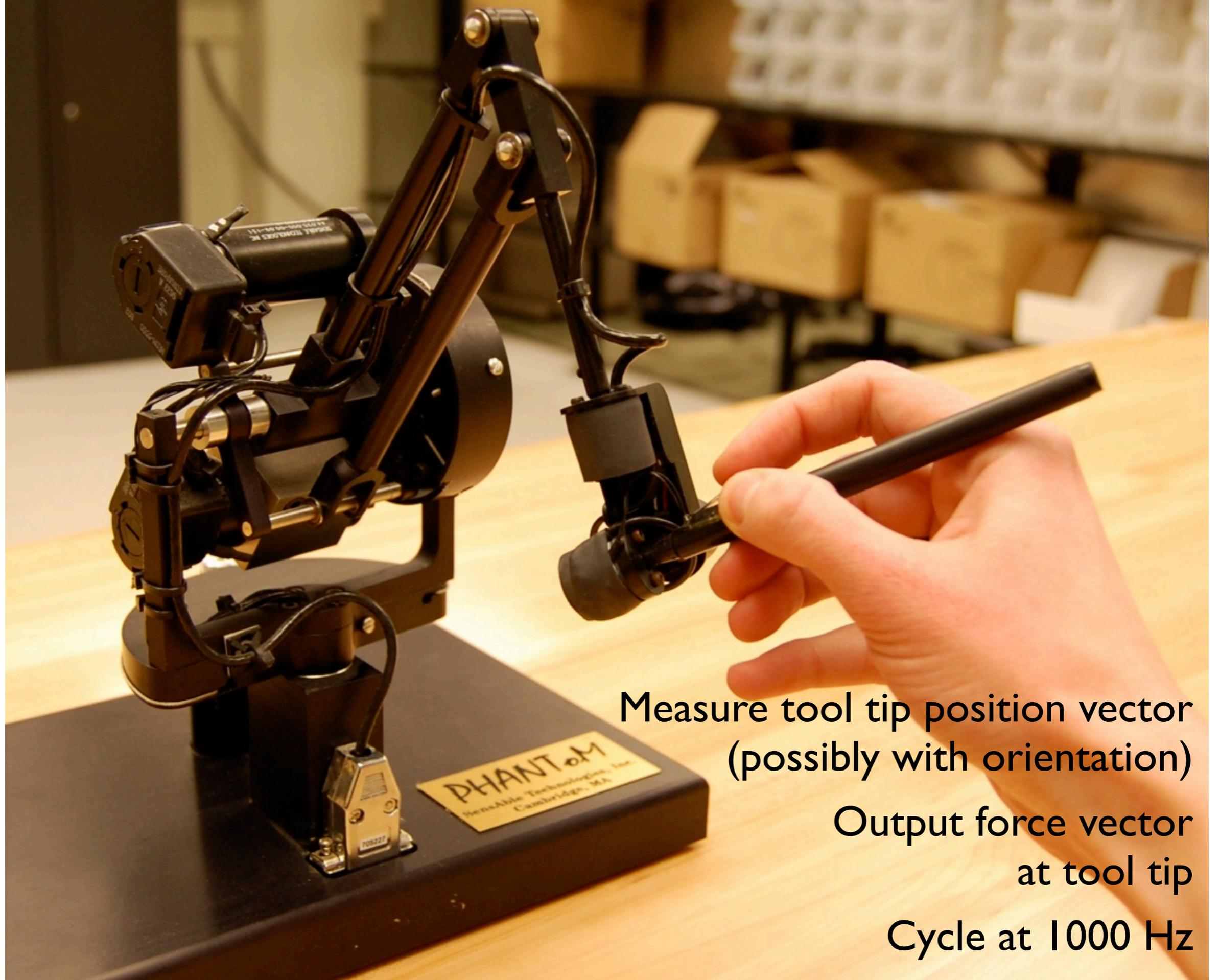
SensAble PHANToM Premium 1.0



Measure tool tip position vector
(possibly with orientation)

Output force vector
at tool tip

SensAble PHANToM Premium 1.0



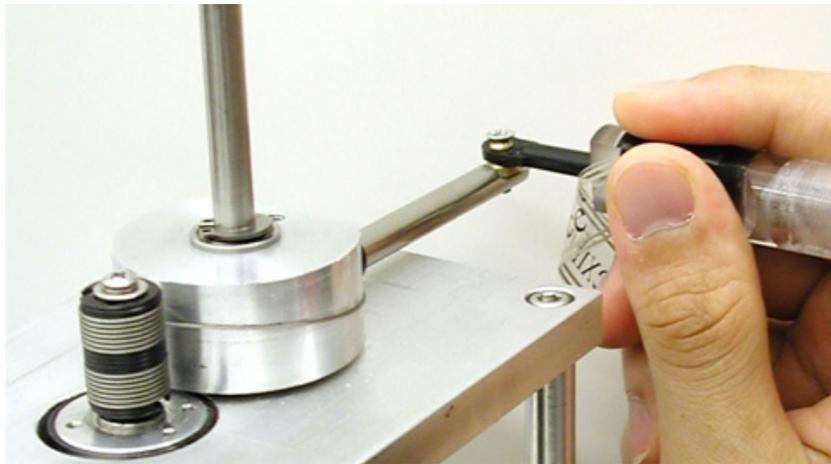
Measure tool tip position vector
(possibly with orientation)

Output force vector
at tool tip

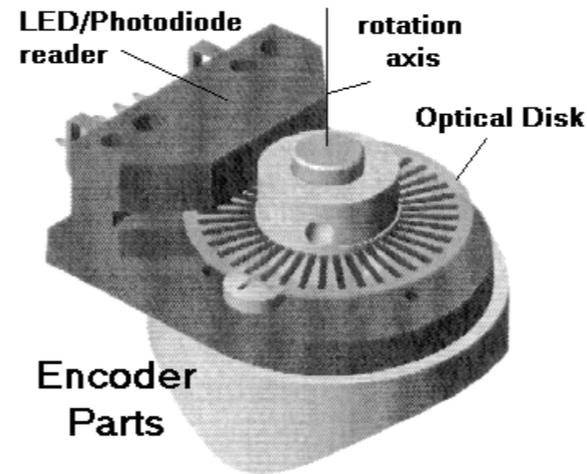
Cycle at 1000 Hz

Typical Components of Kinesthetic Haptic Interfaces

Typical Components of Kinesthetic Haptic Interfaces



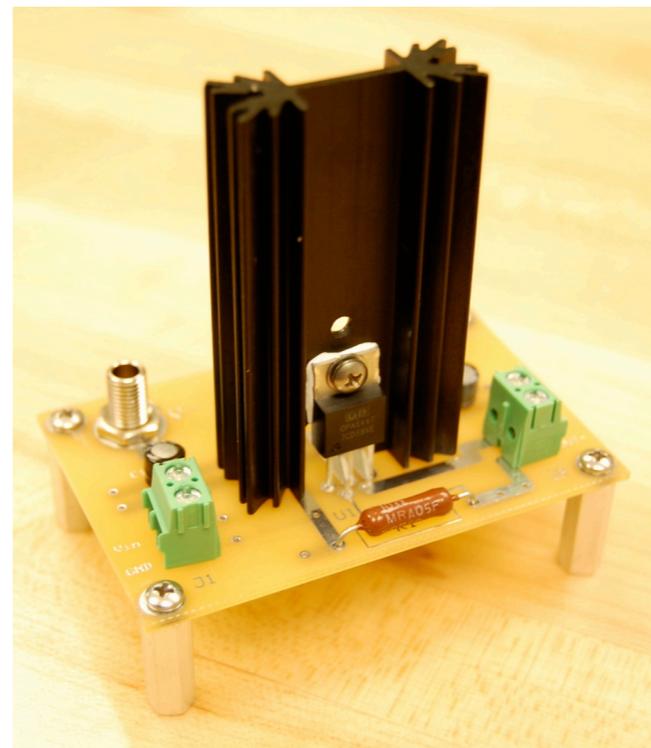
Capstan & Cable Drive
Stiff Metal Linkages



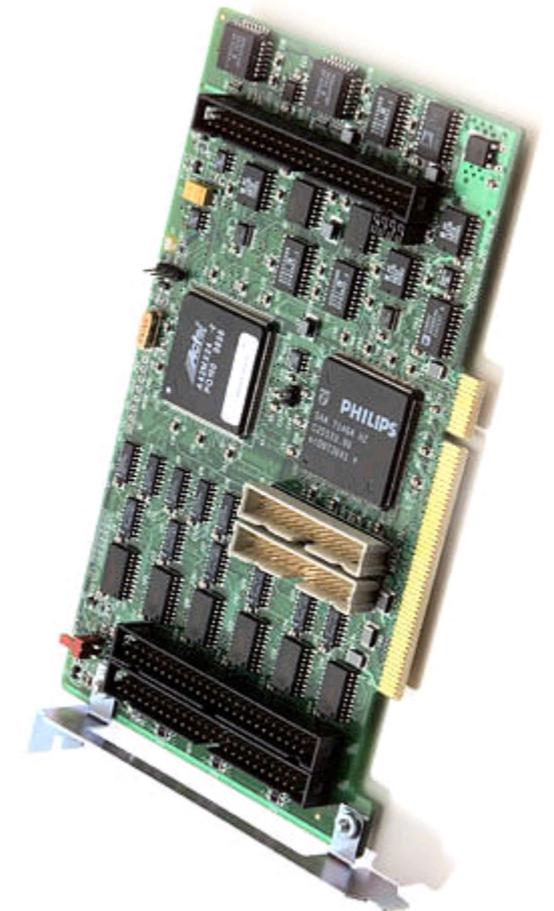
Incremental
Optical Encoder



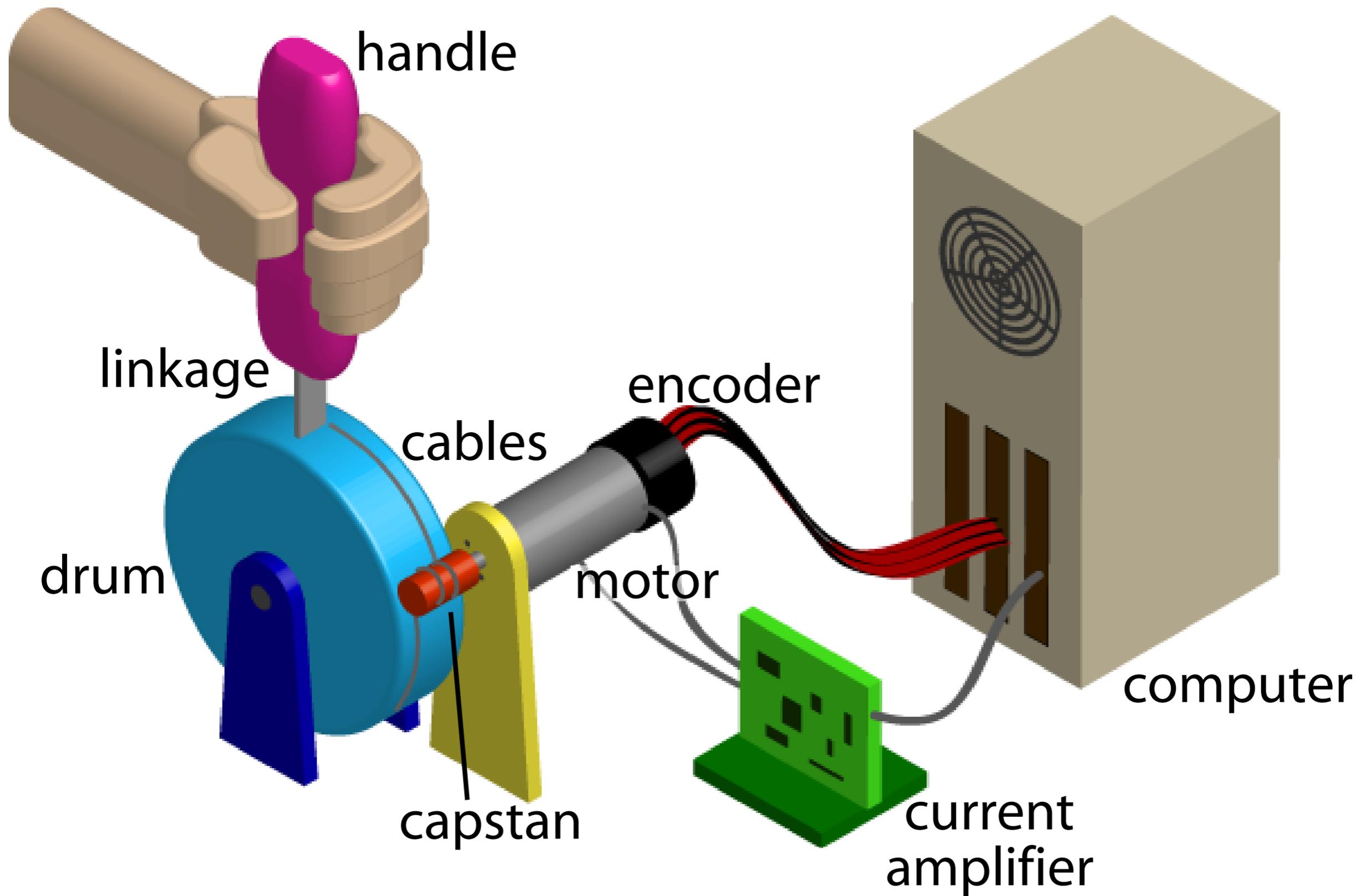
Brushed Permanent Magnet
Direct Current Motor



Current Amplifier



Computer Interface Card



Elements of Haptic Interfaces

Katherine J. Kuchenbecker
Department of Mechanical Engineering and Applied Mechanics
University of Pennsylvania
kuchenbe@seas.upenn.edu

*Course Notes for MEAM 625, University of Pennsylvania
Adapted from Section 3.1 of Professor Kuchenbecker's Ph.D. thesis [3].*

A haptic interface plays the important role of connecting the user to the controller during interactions with remote and virtual objects. Such systems incorporate mechanical, electrical, and computational elements, which all interact to create the touch-based sensations experienced by the user. This document is concerned specifically with actuated impedance-type interfaces, which currently dominate the field due to their excellent free-space characteristics and their widespread use in a variety of applications. During an interaction, the controller of an impedance-type device must measure the user's hand motion and apply an appropriate force in response. Impedance-type haptic interfaces vary in design, but they usually include a series of electrical and mechanical elements between the handle and the computer, as described below.

Overview

Haptic interfaces typically provide two or three degrees of freedom in position, sensing the user's motion and applying feedback forces within this workspace. Many devices also permit changes in the orientation of the end effector; these rotational degrees of freedom can be unsensed, sensed but not actuated, or sensed and actuated. The remainder of this discussion will focus on translation rather than orientation, though the described design features can be applied to either.

Figure 1 illustrates the chain of elements typically present in each axis of a haptic interface. For clarity, the illustration depicts a device with a single degree of freedom, but typical systems combine several degrees of freedom in parallel or series to allow unrestricted translation and/or orientation. Although differences exist, individual position axes of most mechanisms can be represented by such an arrangement. The terms "haptic interface" and "master" are often used interchangeably to represent all electrical and mechanical elements depicted in Figure 1, extending from the amplifier and encoder to the handle.

SensAble PHANToM Premium 1.0



SensAble PHANToM Premium 1.0

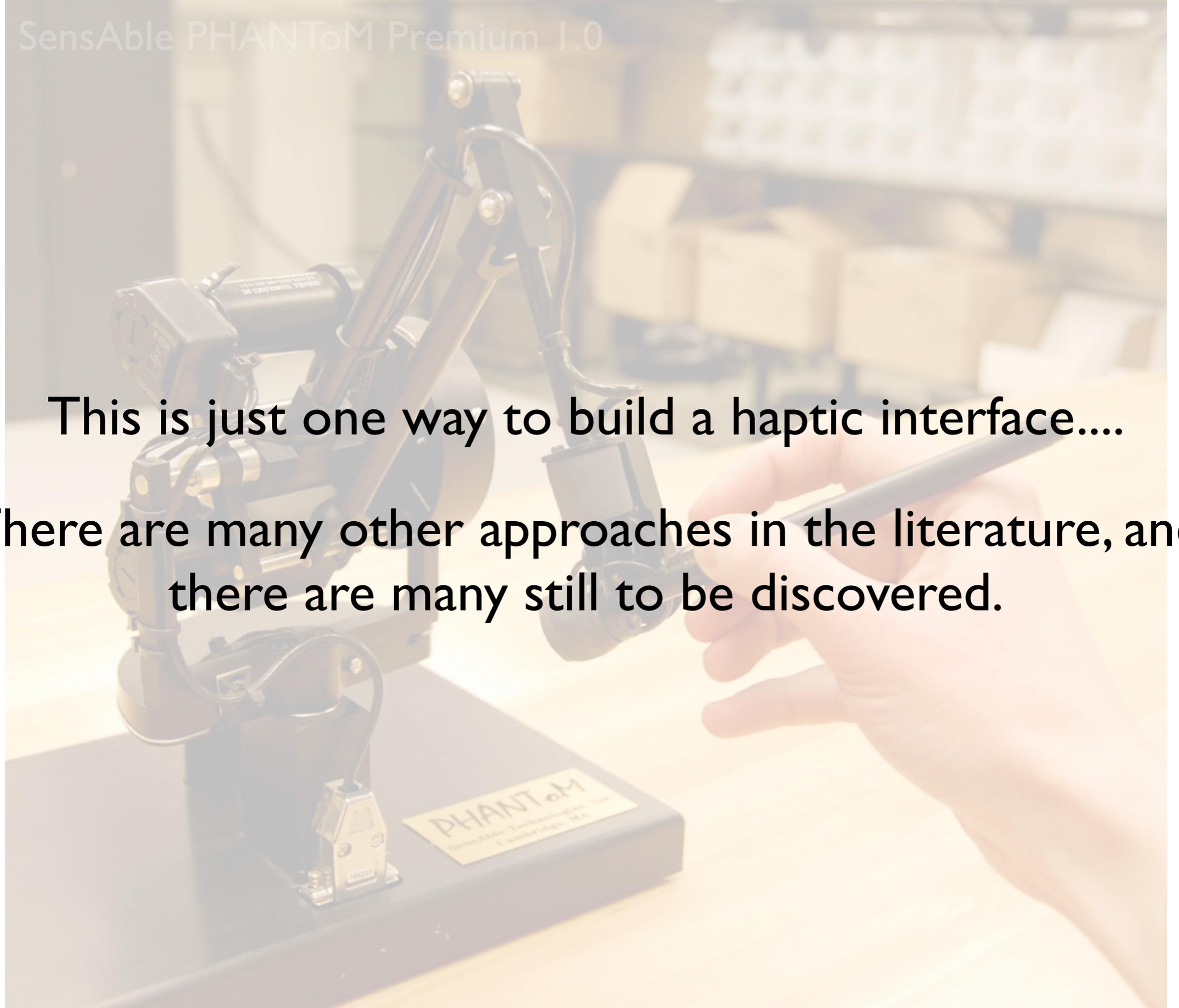


This is just one way to build a haptic interface...



This is just one way to build a haptic interface....

There are many other approaches in the literature, and there are many still to be discovered.



My definition of a haptic interface:

Senses a physical quantity from the user,
such as motion or force

Physically acts on the user via a variable actuator

Connects sensing to acting with fast processing

My definition of a haptic interface:

Senses a physical quantity from the user,
such as motion or force

Physically acts on the user via a variable actuator

Connects sensing to acting with fast processing

Sensors

Dictionary

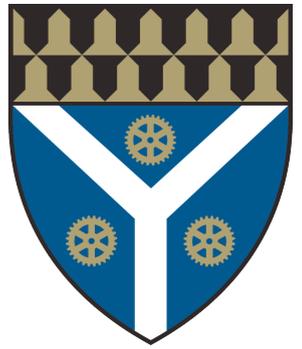
sen•sor |'sensər|
noun
S a device that detects or measures a physical property and records, indicates, or otherwise responds to it.

ORIGIN 1950s: from SENSORY , on the pattern of *motor*.

i



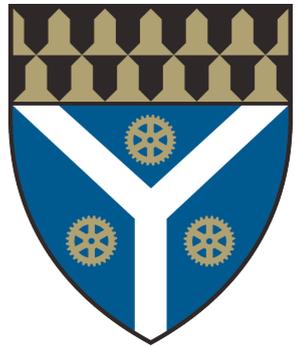
Sensors



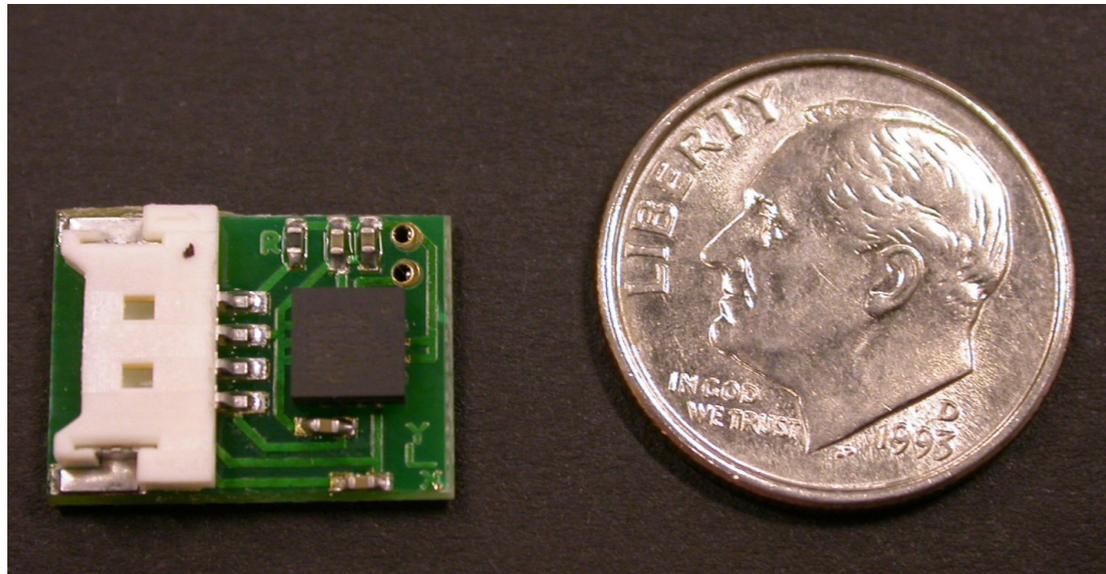
- Sensor Specifications
- Sensor Types
- Read the Datasheet



Sensors

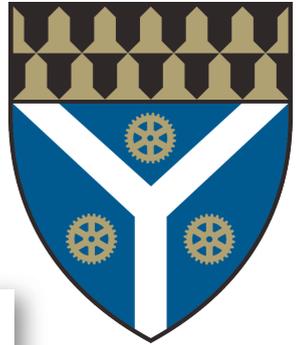


- Sensor Specifications
- Sensor Types
- Read the Datasheet

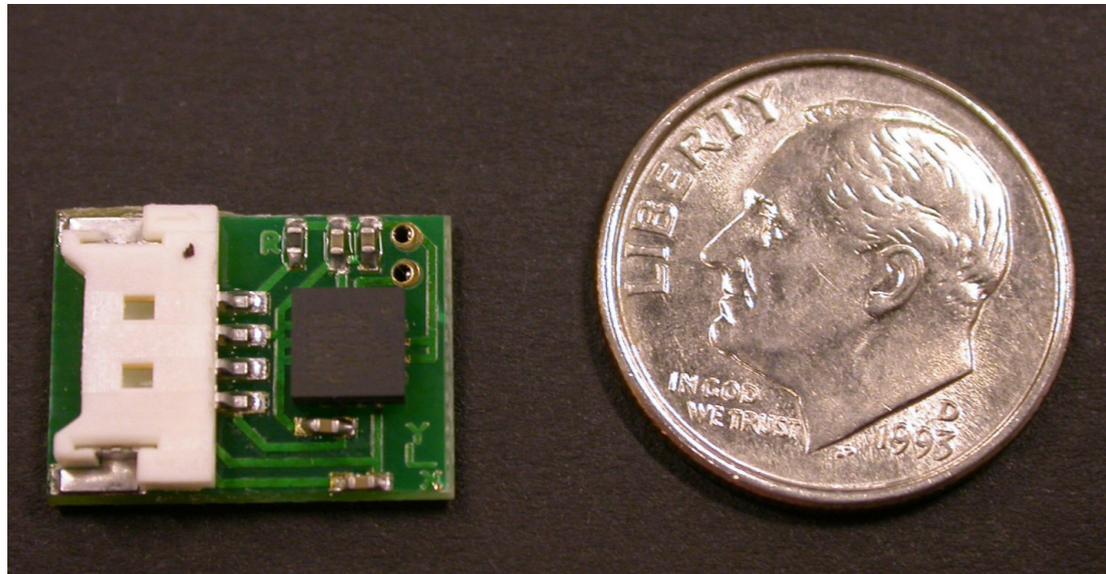




Sensors



- Sensor Specifications
- Sensor Types
- Read the Datasheet



Small and Thin $\pm 18 g$ Accelerometer

ADXL321

FEATURES

Small and thin
4 mm \times 4 mm \times 1.45 mm LFCSP package
3 mg resolution at 50 Hz
Wide supply voltage range: 2.4 V to 6 V
Low power: 350 μ A at $V_s = 2.4$ V (typ)
Good zero g bias stability
Good sensitivity accuracy
X-axis and Y-axis aligned to within 0.1° (typ)
BW adjustment with a single capacitor
Single-supply operation
10,000 g shock survival
Compatible with Sn/Pb and Pb-free solder processes

APPLICATIONS

Vibration monitoring and compensation
Abuse event detection
Sports equipment

GENERAL DESCRIPTION

The ADXL321 is a small and thin, low power, complete dual-axis accelerometer with signal conditioned voltage outputs, which is all on a single monolithic IC. The product measures acceleration with a full-scale range of $\pm 18 g$ (typical). It can also measure both dynamic acceleration (vibration) and static acceleration (gravity).

The ADXL321's typical noise floor is 320 μ g/ $\sqrt{\text{Hz}}$, allowing signals below 3 mg to be resolved in tilt-sensing applications using narrow bandwidths (< 50 Hz).

The user selects the bandwidth of the accelerometer using capacitors C_x and C_y at the X_{OUT} and Y_{OUT} pins. Bandwidths of 0.5 Hz to 2.5 kHz may be selected to suit the application.

The ADXL321 is available in a very thin 4 mm \times 4 mm \times 1.45 mm, 16-lead, plastic LFCSP.

FUNCTIONAL BLOCK DIAGRAM

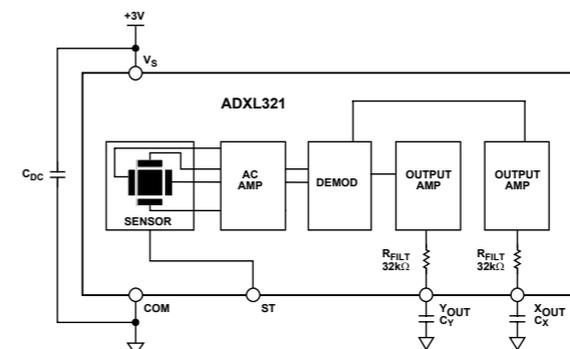
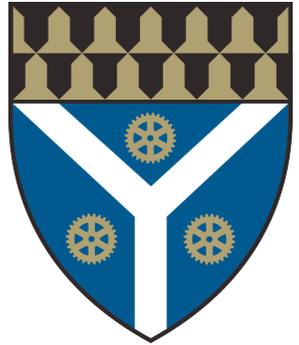


Figure 1.

Rev. 0
Information furnished by Analog Devices is believed to be accurate and reliable. However, no responsibility is assumed by Analog Devices for its use, nor for any infringements of patents or other rights of third parties that may result from its use. Specifications subject to change without notice. No license is granted by implication or otherwise under any patent or patent rights of Analog Devices. Trademarks and registered trademarks are the property of their respective owners.

One Technology Way, P.O. Box 9106, Norwood, MA 02062-9106, U.S.A.
Tel: 781.329.4700 www.analog.com
Fax: 781.326.8703 © 2007 Analog Devices, Inc. All rights reserved.



SPECIFICATIONS¹

T_A = 25°C, V_S = 3 V, C_X = C_Y = 0.1 μF, Acceleration = 0 g, unless otherwise noted.

Table 1.

Parameter	Conditions	Min	Typ	Max	Unit
SENSOR INPUT					
Measurement Range	Each axis		±18		g
Nonlinearity	% of full scale		±0.2		%
Package Alignment Error			±1		Degrees
Alignment Error	X sensor to Y sensor		±0.1		Degrees
Cross Axis Sensitivity			±2		%
SENSITIVITY (RATIOMETRIC)²					
Sensitivity at X _{OUT} , Y _{OUT}	Each axis V _S = 3 V	51	57	63	mV/g
Sensitivity Change due to Temperature ³	V _S = 3 V		0.01		%/°C
ZERO g BIAS LEVEL (RATIOMETRIC)					
0 g Voltage at X _{OUT} , Y _{OUT}	Each axis V _S = 3 V	1.4	1.5	1.6	V
0 g Offset vs. Temperature			±2		mg/°C
NOISE PERFORMANCE					
Noise Density	@ 25°C		320		μg/√Hz rms
FREQUENCY RESPONSE⁴					
C _X , C _Y Range ⁵		0.002		10	μF
R _{FILT} Tolerance			32 ± 15%		kΩ
Sensor Resonant Frequency			5.5		kHz
SELF-TEST⁶					
Logic Input Low			0.6		V
Logic Input High			2.4		V
ST Input Resistance to Ground			50		kΩ
Output Change at X _{OUT} , Y _{OUT}	Self-test 0 to 1		18		mV
OUTPUT AMPLIFIER					
Output Swing Low	No load		0.3		V
Output Swing High	No load		2.6		V
POWER SUPPLY					
Operating Voltage Range		2.4		6	V
Quiescent Supply Current			0.49		mA
Turn-On Time ⁷			20		ms
TEMPERATURE					
Operating Temperature Range		-20		+70	°C

¹ All minimum and maximum specifications are guaranteed. Typical specifications are not guaranteed.

² Sensitivity is essentially ratiometric to V_S.

³ Defined as the change from ambient-to-maximum temperature or ambient-to-minimum temperature.

⁴ Actual frequency response controlled by user-supplied external capacitor (C_X, C_Y).

⁵ Bandwidth = 1/(2 × π × 32 kΩ × C). For C_X, C_Y = 0.002 μF, bandwidth = 2500 Hz. For C_X, C_Y = 10 μF, bandwidth = 0.5 Hz. Minimum/maximum values are not tested.

⁶ Self-test response changes cubically with V_S.

⁷ Larger values of C_X, C_Y increase turn-on time. Turn-on time is approximately 160 × C_X or C_Y + 4 ms, where C_X, C_Y are in μF.

SPECIFICATIONS¹

$T_A = 25^\circ\text{C}$, $V_S = 3\text{ V}$, $C_X = C_Y = 0.1\ \mu\text{F}$, Acceleration = 0 g, unless otherwise noted.

Table 1.

Parameter	Conditions	Min	Typ	Max	Unit
SENSOR INPUT					
Measurement Range	Each axis		±18		g
Nonlinearity	% of full scale		±0.2		%
Package Alignment Error			±1		Degrees
Alignment Error	X sensor to Y sensor		±0.1		Degrees
Cross Axis Sensitivity			±2		%
SENSITIVITY (RATIOMETRIC)²					
Sensitivity at X_{OUT} , Y_{OUT}	Each axis $V_S = 3\text{ V}$	51	57	63	mV/g
Sensitivity Change due to Temperature ³	$V_S = 3\text{ V}$		0.01		%/°C
ZERO g BIAS LEVEL (RATIOMETRIC)					
0 g Voltage at X_{OUT} , Y_{OUT}	Each axis $V_S = 3\text{ V}$	1.4	1.5	1.6	V
0 g Offset vs. Temperature			±2		mg/°C
NOISE PERFORMANCE					
Noise Density	@ 25°C		320		μg/√Hz rms
FREQUENCY RESPONSE⁴					
C_X , C_Y Range ⁵		0.002		10	μF
R_{FILT} Tolerance			32 ± 15%		kΩ
Sensor Resonant Frequency			5.5		kHz
SELF-TEST⁶					
Logic Input Low			0.6		V
Logic Input High			2.4		V
ST Input Resistance to Ground			50		kΩ
Output Change at X_{OUT} , Y_{OUT}	Self-test 0 to 1		18		mV
OUTPUT AMPLIFIER					
Output Swing Low	No load		0.3		V
Output Swing High	No load		2.6		V
POWER SUPPLY					
Operating Voltage Range		2.4		6	V
Quiescent Supply Current			0.49		mA
Turn-On Time ⁷			20		ms
TEMPERATURE					
Operating Temperature Range		-20		+70	°C

SENSOR INPUT	Each axis				
Measurement Range			±18		<i>g</i>
Nonlinearity	% of full scale		±0.2		%
Package Alignment Error			±1		Degrees
Alignment Error	X sensor to Y sensor		±0.1		Degrees
Cross Axis Sensitivity			±2		%
SENSITIVITY (RATIOMETRIC) ²	Each axis				
Sensitivity at X _{OUT} , Y _{OUT}	V _S = 3 V	51	57	63	mV/ <i>g</i>
Sensitivity Change due to Temperature ³	V _S = 3 V		0.01		%/°C
ZERO <i>g</i> BIAS LEVEL (RATIOMETRIC)	Each axis				
0 <i>g</i> Voltage at X _{OUT} , Y _{OUT}	V _S = 3 V	1.4	1.5	1.6	V
0 <i>g</i> Offset vs. Temperature			±2		mg/°C
NOISE PERFORMANCE					
Noise Density	@ 25°C		320		μg/√Hz rms
FREQUENCY RESPONSE ⁴					
C _X , C _Y Range ⁵		0.002		10	μF
R _{FILT} Tolerance			32 ± 15%		kΩ
Sensor Resonant Frequency			5.5		kHz
SELF-TEST ⁶					
Logic Input Low			0.6		V
Logic Input High			2.4		V
ST Input Resistance to Ground			50		kΩ
Output Change at X _{OUT} , Y _{OUT}	Self-test 0 to 1		18		mV
OUTPUT AMPLIFIER					
Output Swing Low	No load		0.3		V
Output Swing High	No load		2.6		V
POWER SUPPLY					
Operating Voltage Range		2.4		6	V
Quiescent Supply Current			0.49		mA
Turn-On Time ⁷			20		ms
TEMPERATURE					
Operating Temperature Range		-20		+70	°C

¹ All minimum and maximum specifications are guaranteed. Typical specifications are not guaranteed.

² Sensitivity is essentially ratiometric to V_S.

³ Defined as the change from ambient-to-maximum temperature or ambient-to-minimum temperature.

⁴ Actual frequency response controlled by user-supplied external capacitor (C_X, C_Y).

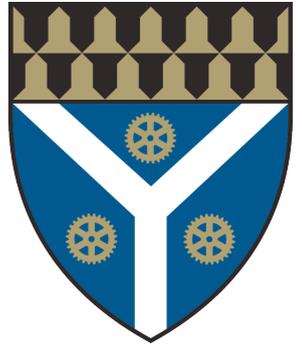
⁵ Bandwidth = 1/(2 × π × 32 kΩ × C). For C_X, C_Y = 0.002 μF, bandwidth = 2500 Hz. For C_X, C_Y = 10 μF, bandwidth = 0.5 Hz. Minimum/maximum values are not tested.

⁶ Self-test response changes cubically with V_S.

⁷ Larger values of C_X, C_Y increase turn-on time. Turn-on time is approximately 160 × C_X or C_Y + 4 ms, where C_X, C_Y are in μF.



Sensor Specifications



Static Measures

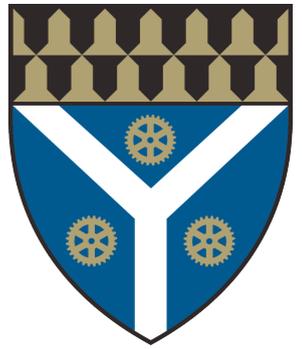
- Range: minimum to maximum of measurable physical quantity, e.g., 10-20 PSI
- Span: the limits between minimum and maximum value the sensor can measure
- Error: measured value minus true value, often associated with a specific cause
- Accuracy: total of the effects of all errors
- Sensitivity: Gain (output divided by input), may be ratiometric with supply voltage

Dynamic Measures

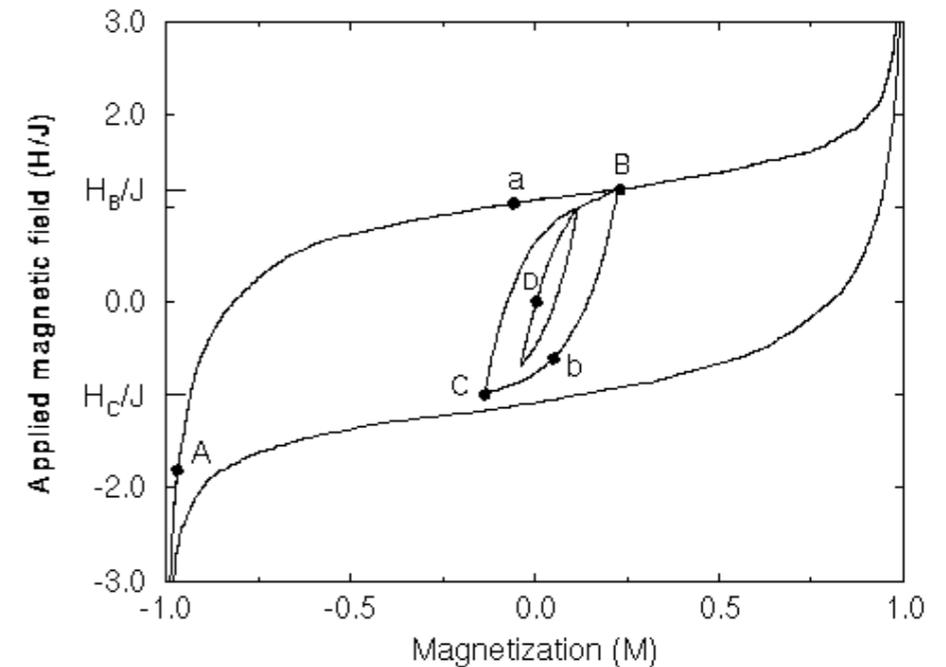
- Response Time - time to achieve 95% of final value
- Time Constant - time to achieve 63% of final value
- Rise time - time from 10% to 90% of final value
- Settling time - time to get and stay within 2% of final value



Imperfections

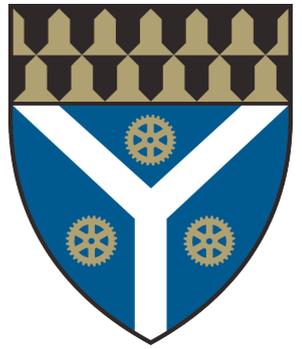


- Hysteresis: Sensitivity to direction of change
- Nonlinearity: deviation from linear relationship (constant gain)
- Repeatability: produces the same output for the same input (not the same as accuracy)
- Stability: holding the same value over a period of time
- Deadband/Dead Time: period or range of input where no output occurs
- Resolution: Smallest change in input that will cause a change in output
- Output Impedance: ability to deliver current, lower is better



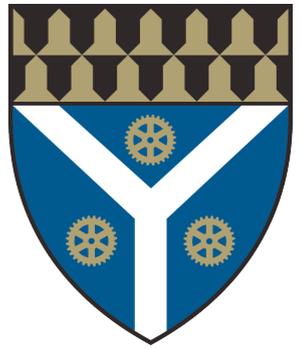


Sensor Types





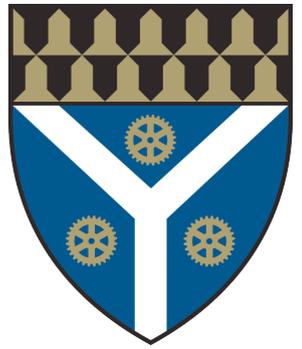
Sensor Types



- All convert a physical effect into an electrical signal



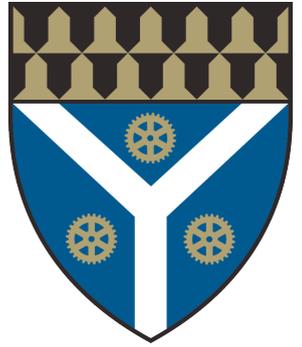
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance



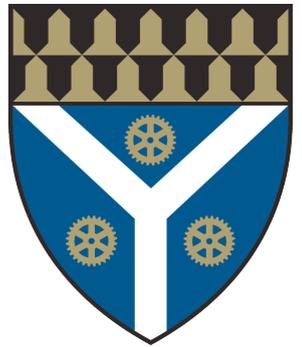
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.



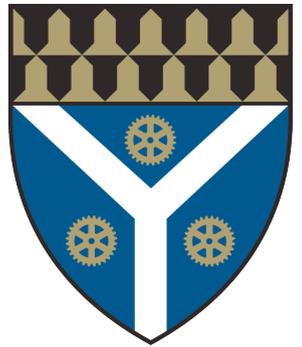
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.
- Choosing a sensor is always about:



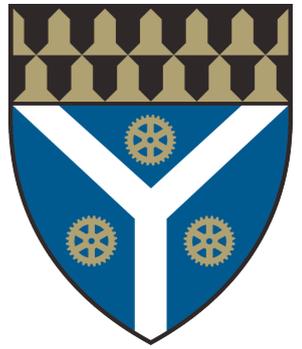
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.
- Choosing a sensor is always about:
 - Cost



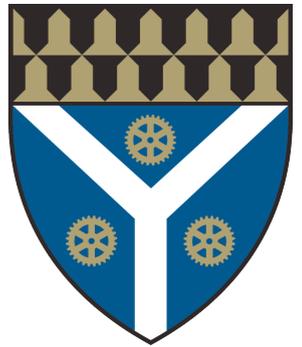
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.
- Choosing a sensor is always about:
 - Cost
 - Size



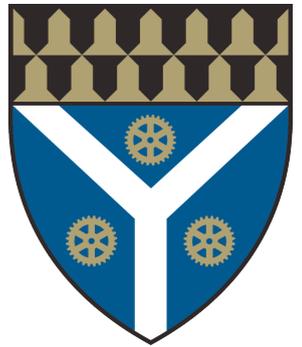
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.
- Choosing a sensor is always about:
 - Cost
 - Size
 - Accuracy



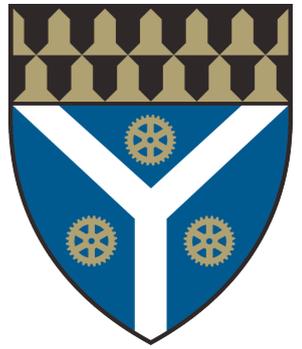
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.
- Choosing a sensor is always about:
 - Cost
 - Size
 - Accuracy
 - Durability



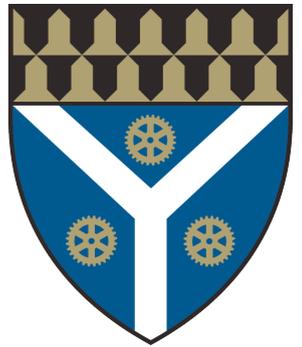
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.
- Choosing a sensor is always about:
 - Cost
 - Size
 - Accuracy
 - Durability
 - Availability



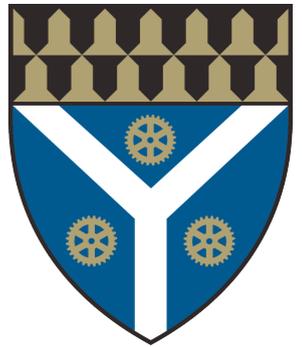
Sensor Types



- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.
- Choosing a sensor is always about:
 - Cost
 - Size
 - Accuracy
 - Durability
 - Availability
 - Compatibility with rest of system (interference, communication)



Sensor Types

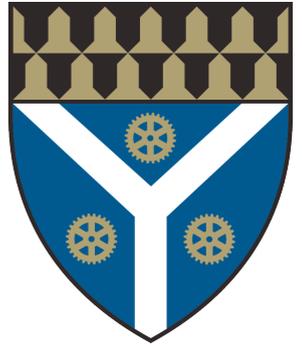


- All convert a physical effect into an electrical signal
 - Measure a voltage or current using capacitance, resistance, inductance
 - May output analog voltage, digital signal, serial comm., current, etc.
- Choosing a sensor is always about:
 - Cost
 - Size
 - Accuracy
 - Durability
 - Availability
 - Compatibility with rest of system (interference, communication)
 - Other concerns?



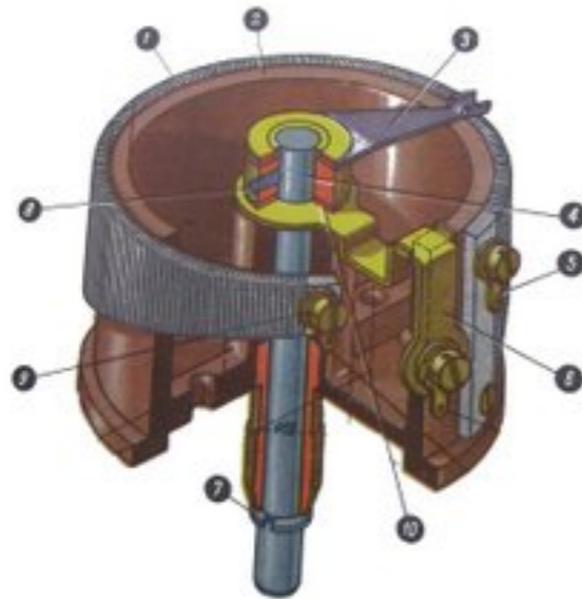
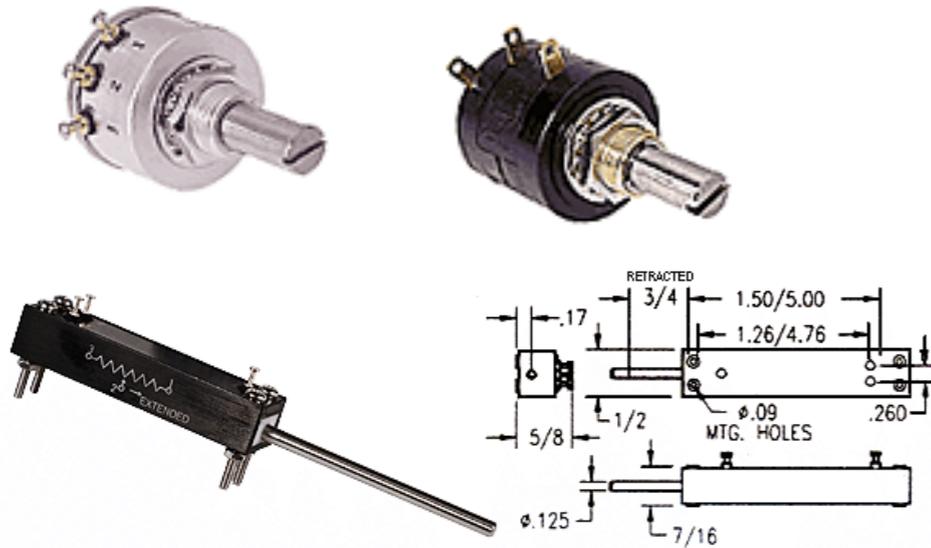
Mechanical Trackers

- Ground-based linkages most commonly used
- Position Sensors
 - Analog: potentiometers or Hall-effect (magnetic)
 - Digital: encoders (optical or MR)



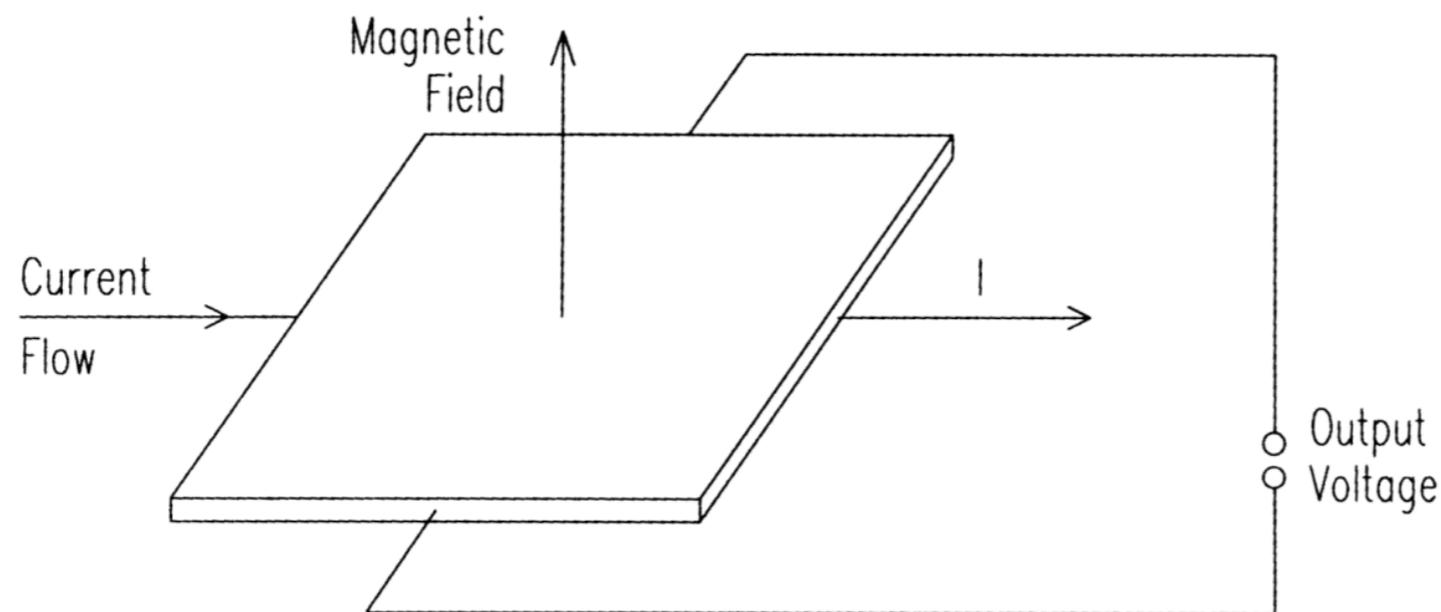
Potentiometers

- Typically rotary, but linear exist.
- Cheap and easy.
- Moving parts means it can wear out.
- Hard to waterproof or dustproof.
- Has non-negligible friction.



Hall-Effect Sensors

- How do they work?
 - A small transverse voltage is generated across a current-carrying conductor in the presence of a magnetic field



(Discovery made in 1879, but not useful until the advent of semiconductor technology)



Hall-Effect Sensors

$$V_h = \frac{R_h IB}{t}$$

V_h = Hall voltage

R_h = Hall coefficient

I = Current

B = Magnetic flux density

t = Element thickness

- Amount of voltage output related to the strength of magnetic field passing through.
- Linear over small range of motion
 - Need to be calibrated
- Affected by temperature, other magnetic objects in the environments

Hall-Effect Sensors



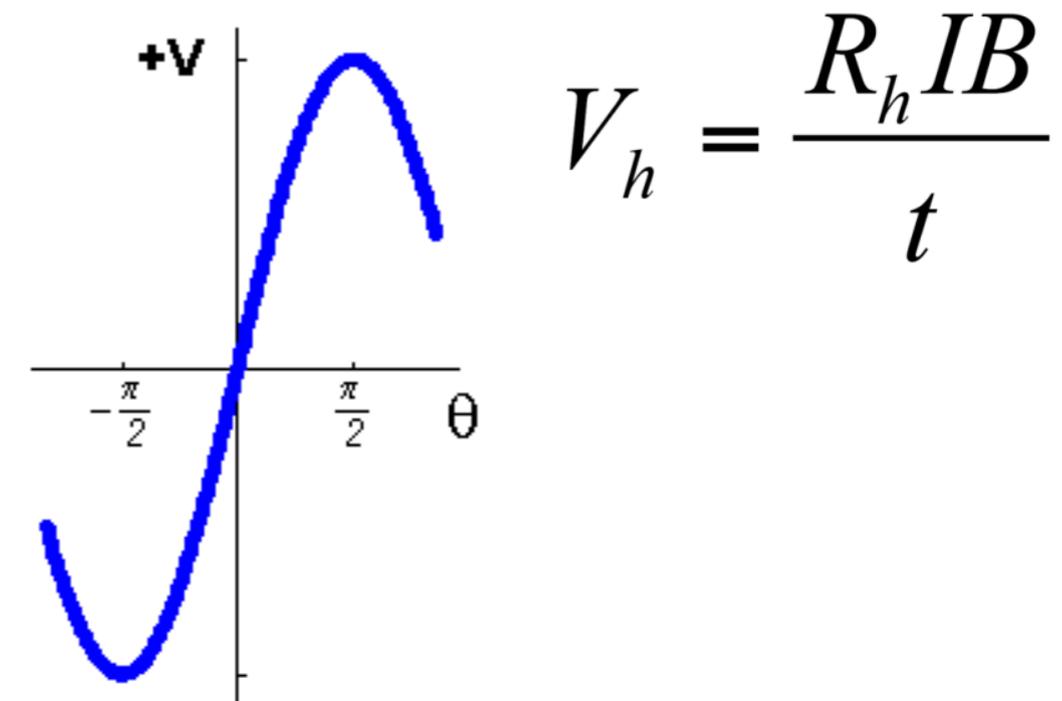
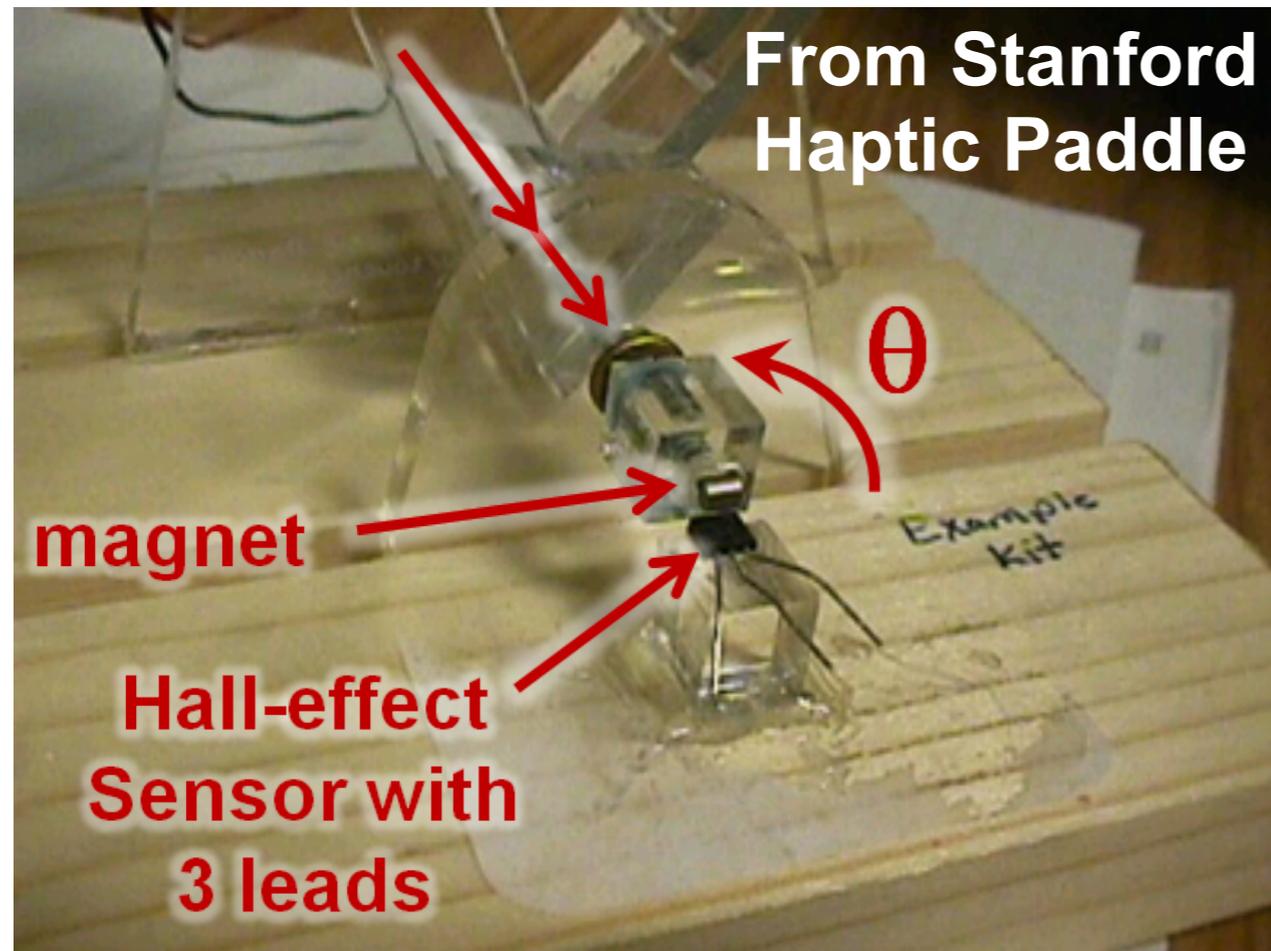
V_h = Hall voltage

R_h = Hall coefficient

I = Current

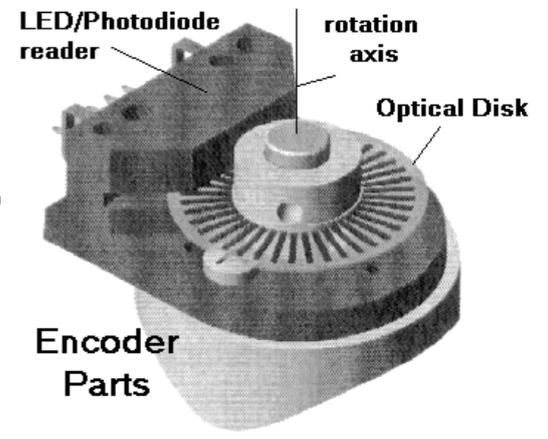
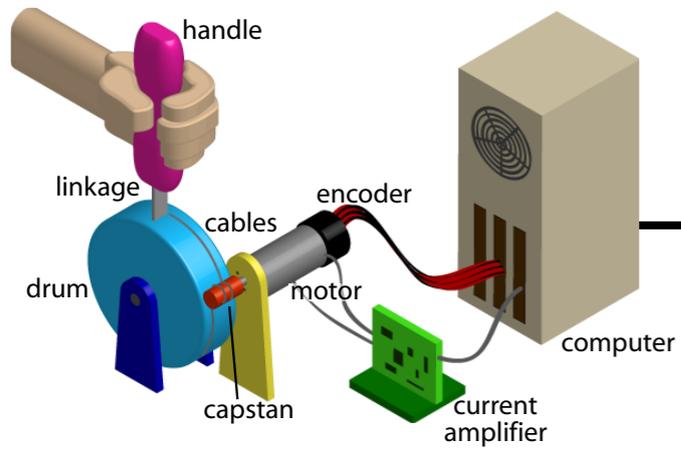
B = Magnetic flux density

t = Element thickness

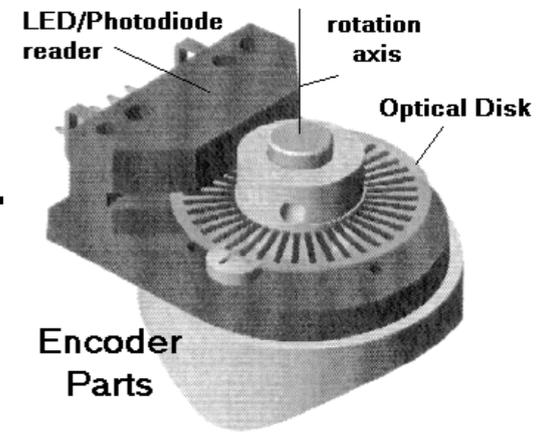
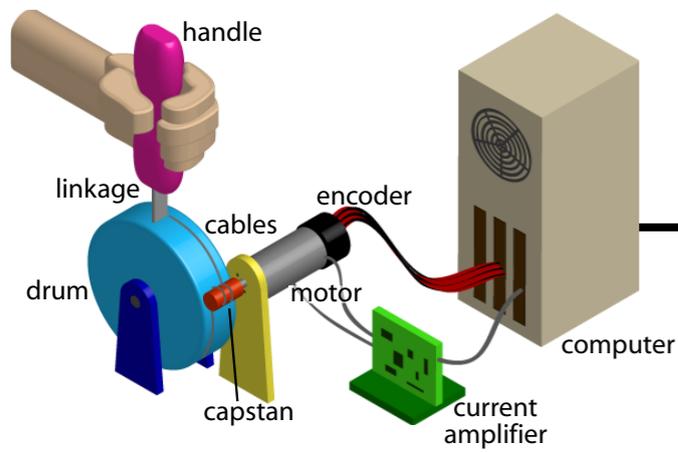


- The voltage varies sinusoidally with rotation angle

Encoder

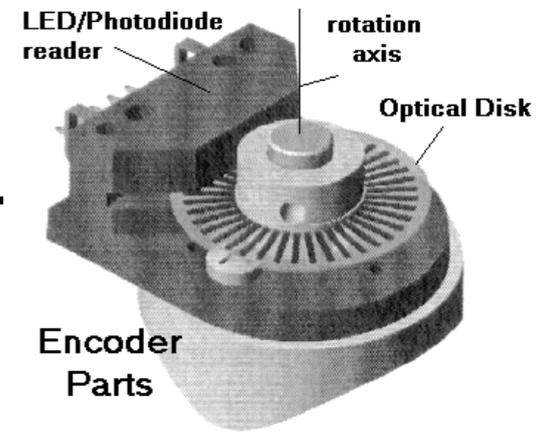
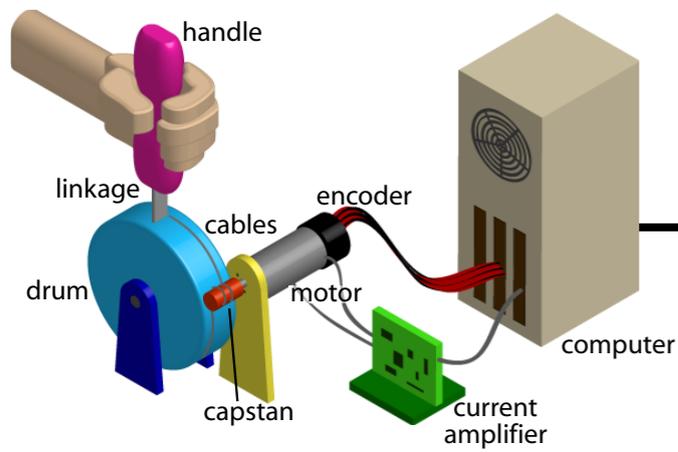


Encoder



The most common motion sensor in haptics is the incremental optical encoder, often by Agilent.

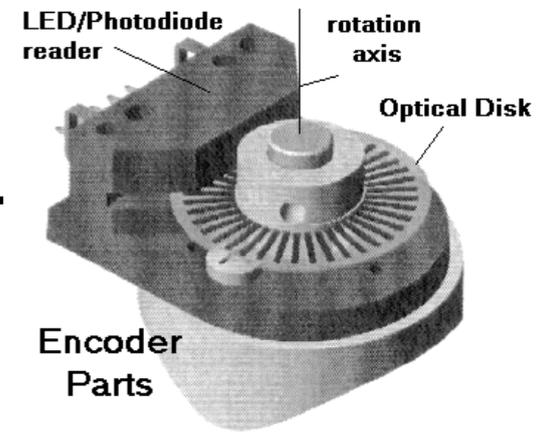
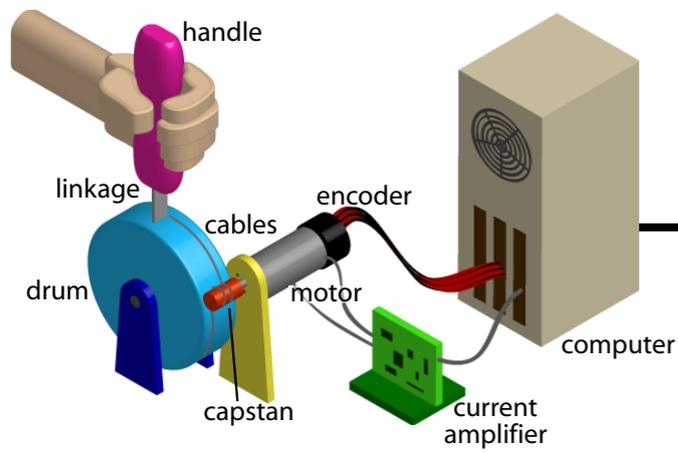
Encoder



The most common motion sensor in haptics is the incremental optical encoder, often by Agilent.

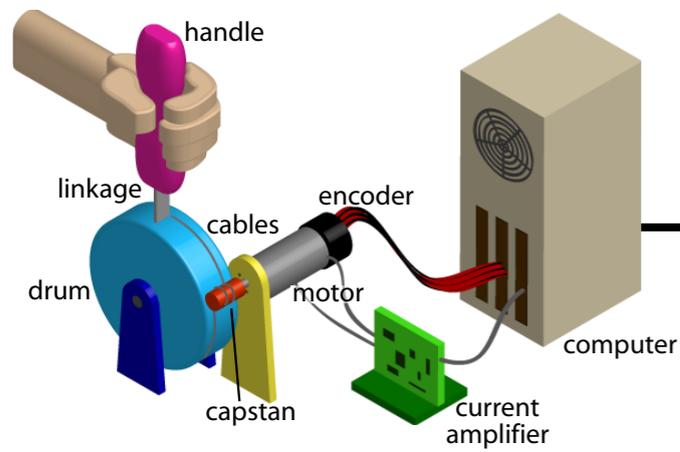
- A thin disk is attached to the rotating shaft whose angle you want to measure, usually the motor.

Encoder

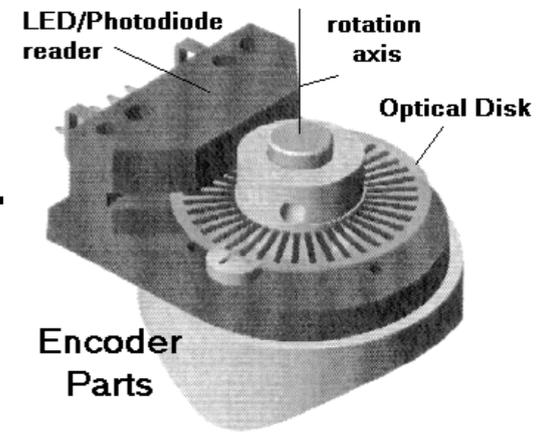


The most common motion sensor in haptics is the incremental optical encoder, often by Agilent.

- A thin disk is attached to the rotating shaft whose angle you want to measure, usually the motor.
- The disk has slits cut into it in a regular pattern.

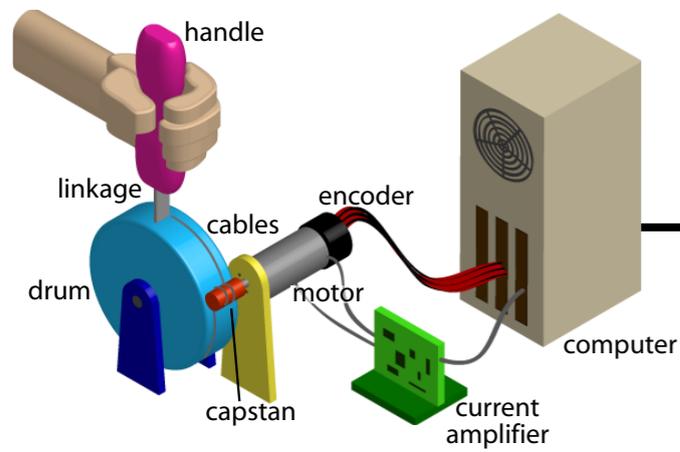


Encoder

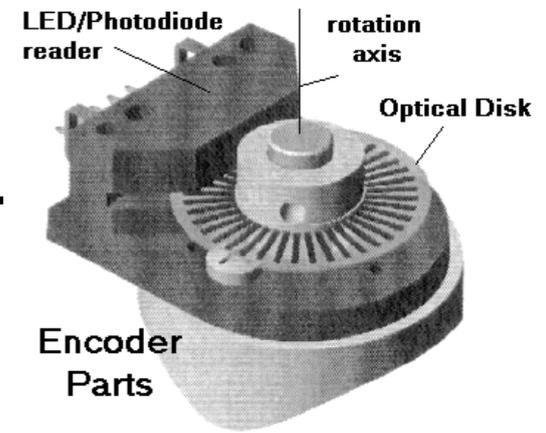


The most common motion sensor in haptics is the incremental optical encoder, often by Agilent.

- A thin disk is attached to the rotating shaft whose angle you want to measure, usually the motor.
- The disk has slits cut into it in a regular pattern.
- A light shines on the disk on one side, and photo sensors are located on the opposite side.



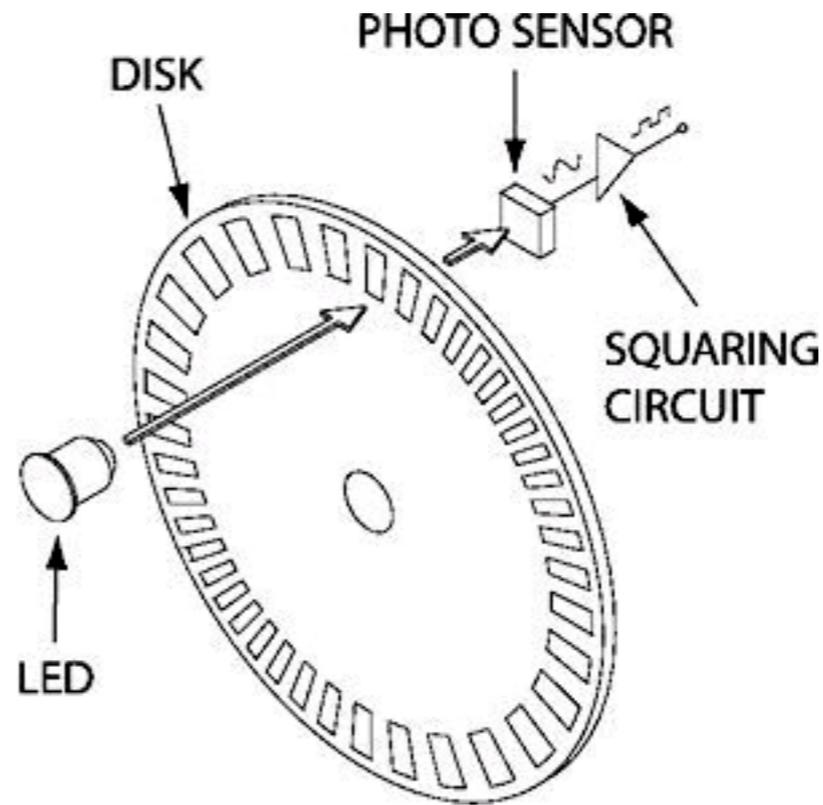
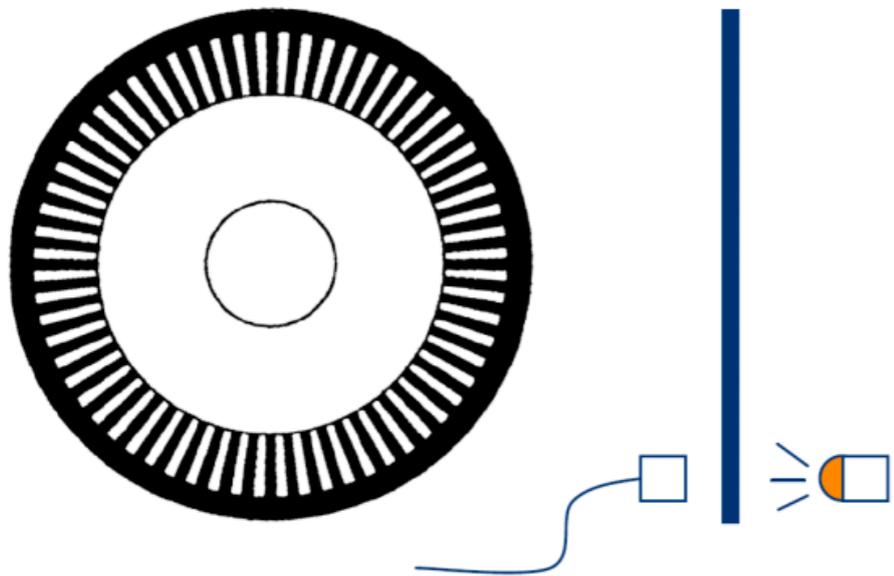
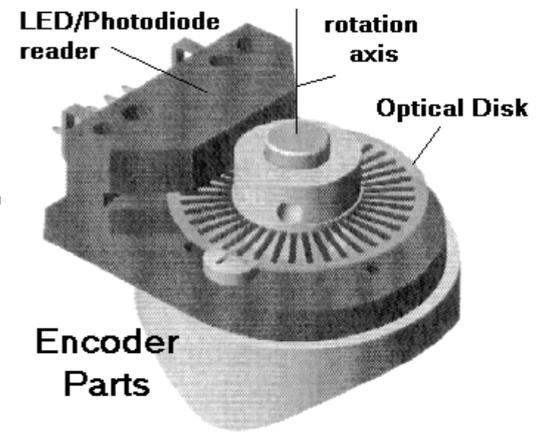
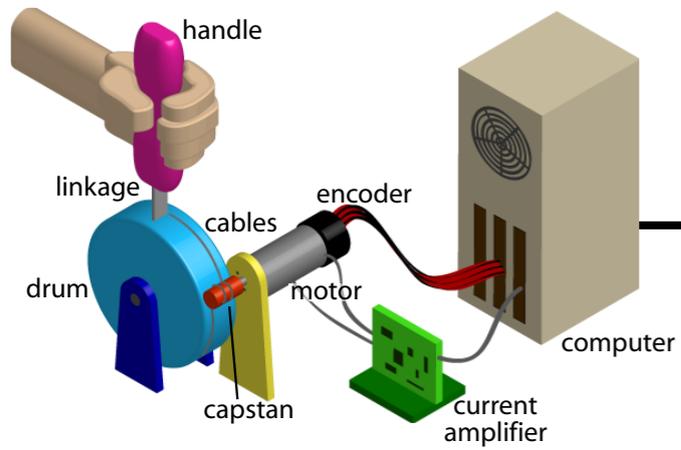
Encoder



The most common motion sensor in haptics is the incremental optical encoder, often by Agilent.

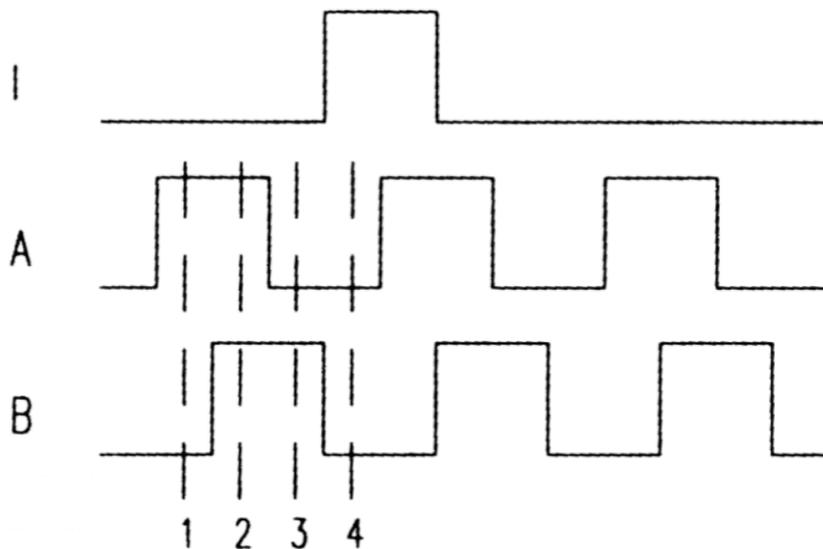
- A thin disk is attached to the rotating shaft whose angle you want to measure, usually the motor.
- The disk has slits cut into it in a regular pattern.
- A light shines on the disk on one side, and photo sensors are located on the opposite side.
- Produces a number of pulses per revolution, with higher resolution being more expensive.

Encoder



$$\Delta = \frac{2\pi}{4n}$$

Two channels of pulses, 90 degrees out of phase: quadrature



State	Ch A	Ch B
S ₁	High	Low
S ₂	High	High
S ₃	Low	High
S ₄	Low	Low

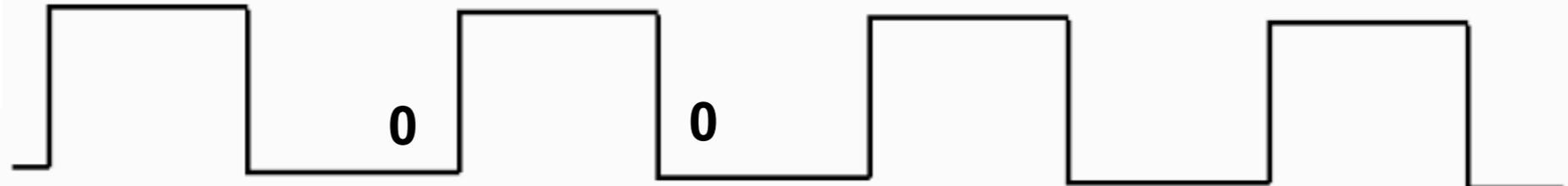
Quadrature Encoder States & Decoding



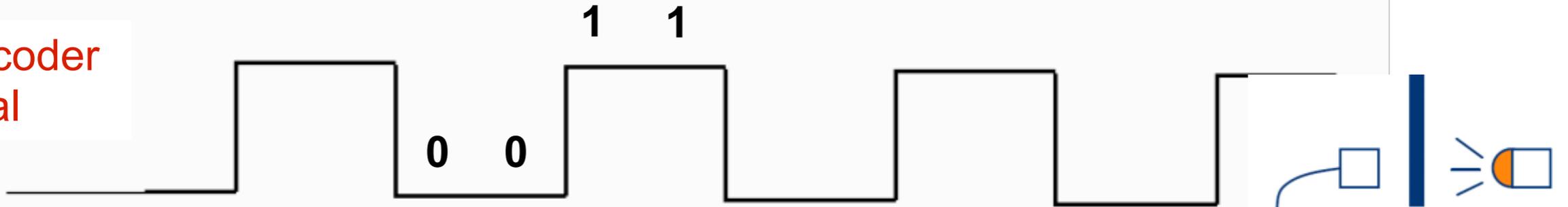
Disk rotation CCW



Ch. 1 Encoder Signal



Ch. 2 Encoder Signal



Detector Emitter

Encoder States

Disk rotation CCW



A B C D

Ch. 1

0	1	1	0
---	---	---	---

Ch. 2

0	0	1	1
---	---	---	---

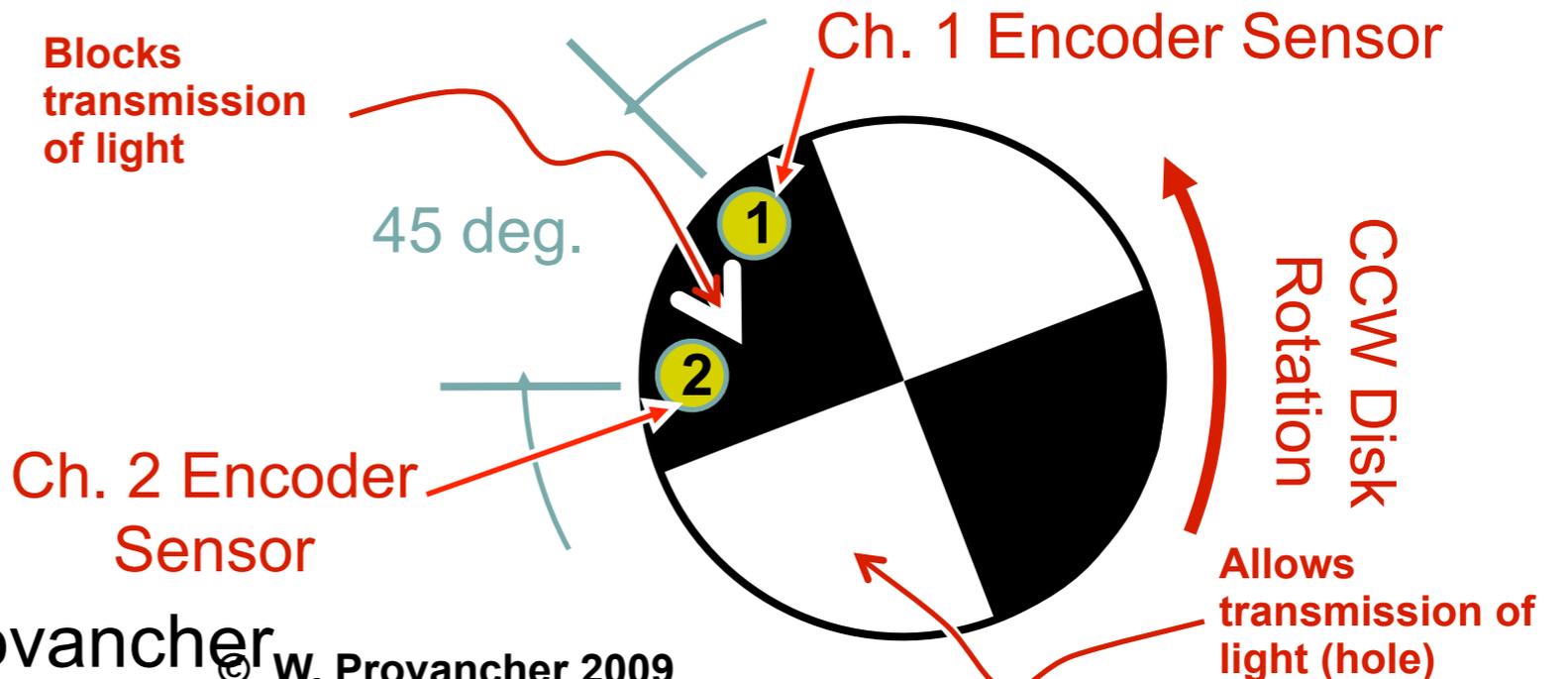
A B C D

Disk rotation CW



Simplified Encoder Disk

(4 CPR, 16 PPR) (shown in state A)



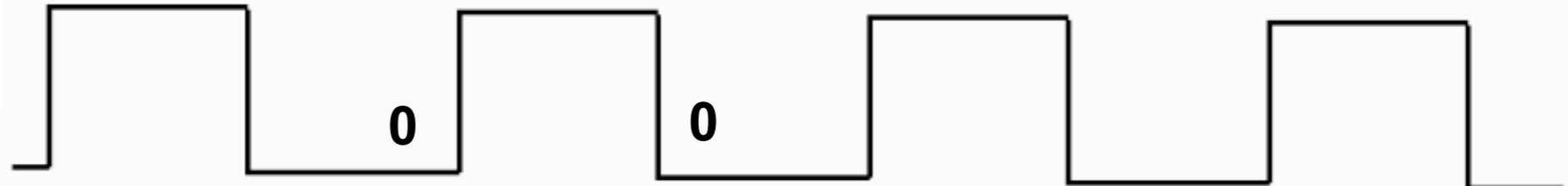
Quadrature Encoder States & Decoding



Disk rotation CCW



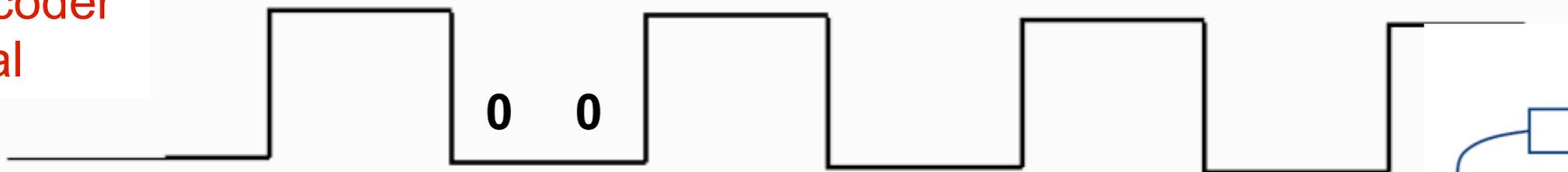
Ch. 1 Encoder Signal



1 1

0 0

Ch. 2 Encoder Signal



1 1

0 0

A B C D

Detector

Emitter

Encoder States

Simplified Encoder Disk

(4 CPR, 16 PPR) (shown in state A)

Disk rotation CCW



A B C D

Ch. 1

	A	B	C	D
Ch. 1	0	1	1	0
Ch. 2	0	0	1	1

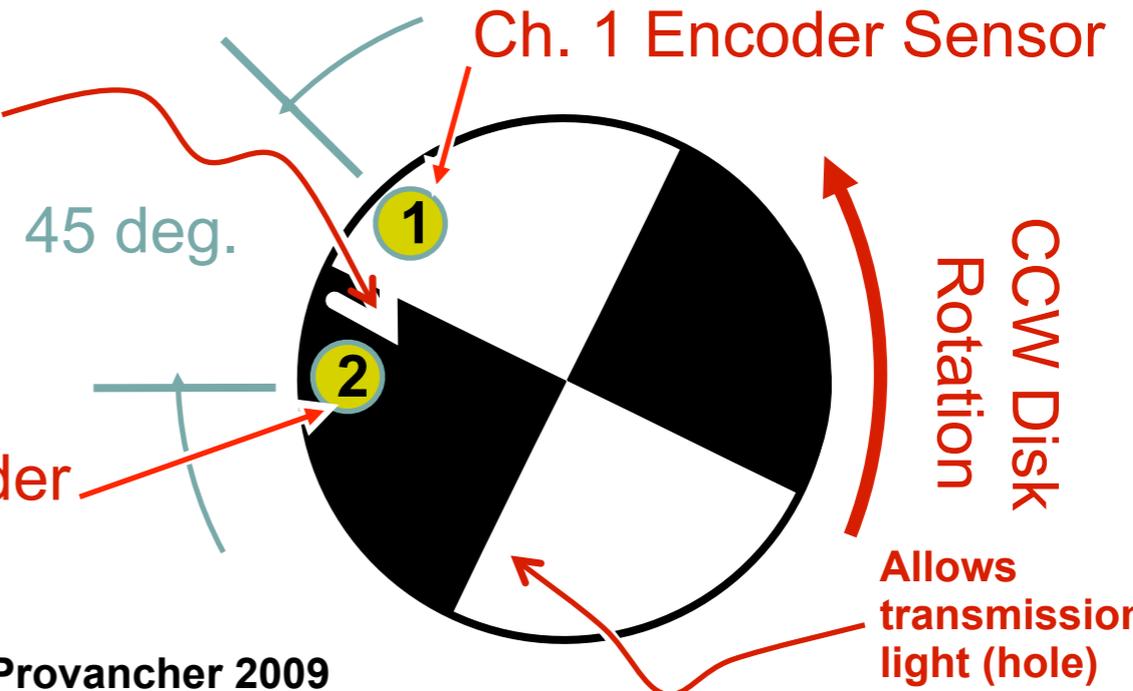
Ch. 2

A B C D

Disk rotation CW



Blocks transmission of light



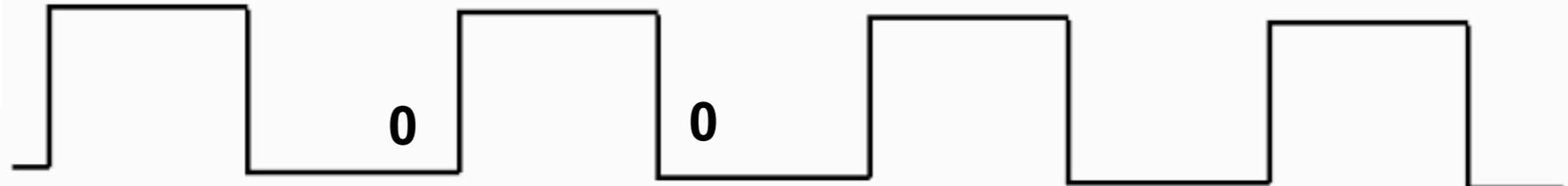
Quadrature Encoder States & Decoding



Disk rotation CCW



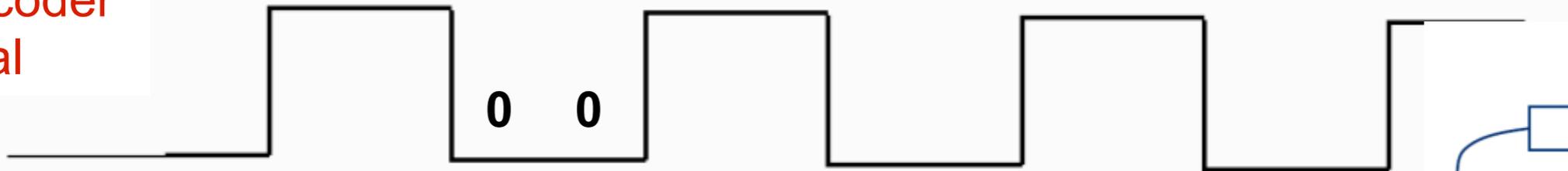
Ch. 1 Encoder Signal



1 1

0 0

Ch. 2 Encoder Signal



1 1

0 0

A B C D

Detector

Emitter

Encoder States

Simplified Encoder Disk

(4 CPR, 16 PPR) (shown in state A)

Disk rotation CCW



A B C D

Ch. 1

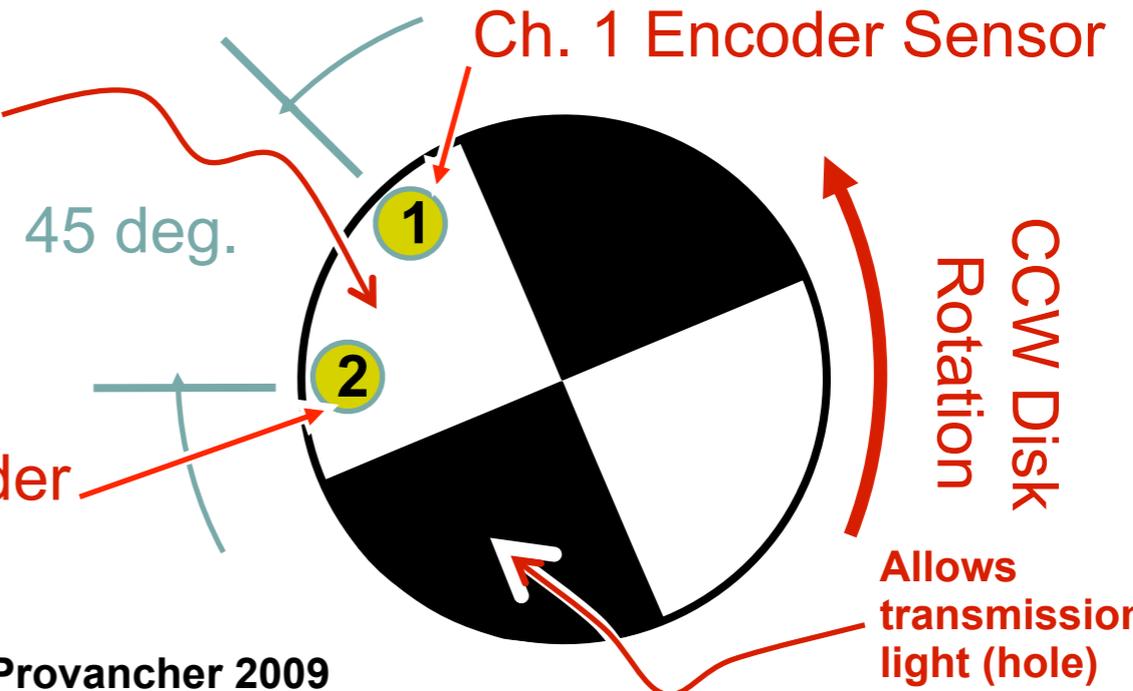
	A	B	C	D
Ch. 1	0	1	1	0
Ch. 2	0	0	1	1

Ch. 2

A B C D

Disk rotation CW

Blocks transmission of light



Quadrature Encoder States & Decoding



Disk rotation CCW



Ch. 1 Encoder Signal



1 1

0 0

Ch. 2 Encoder Signal



1 1

0 0

A B C D

Detector

Emitter

Encoder States

Simplified Encoder Disk

(4 CPR, 16 PPR) (shown in state A)

Disk rotation CCW



A B C D

Ch. 1

	A	B	C	D
Ch. 1	0	1	1	0
Ch. 2	0	0	1	1

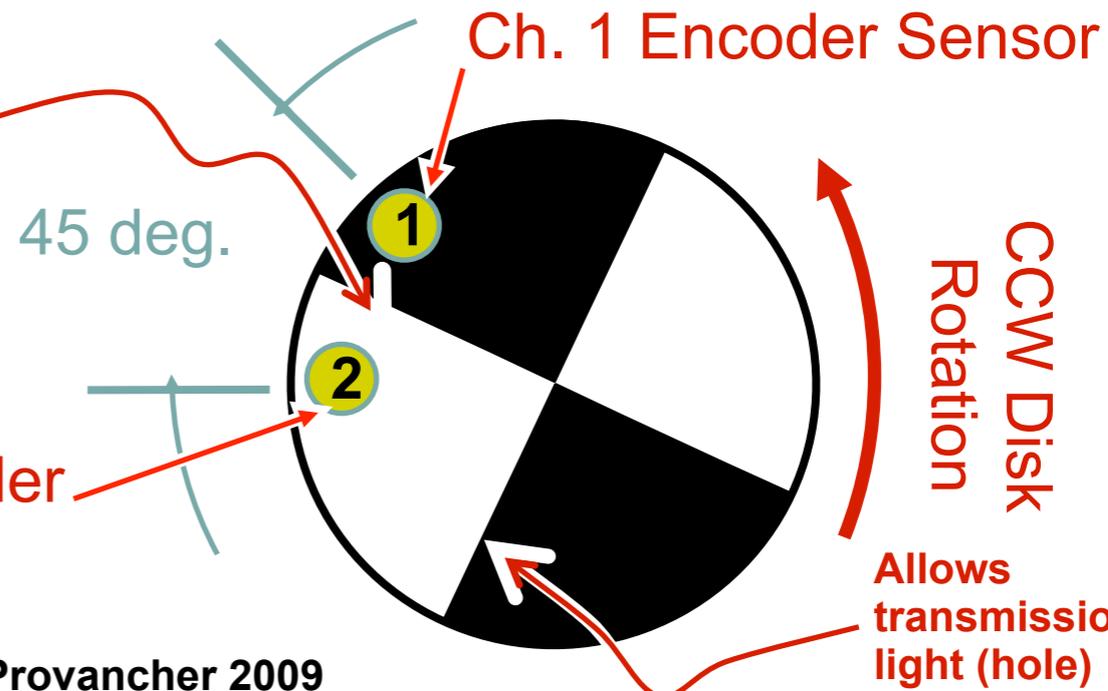
Ch. 2

A B C D

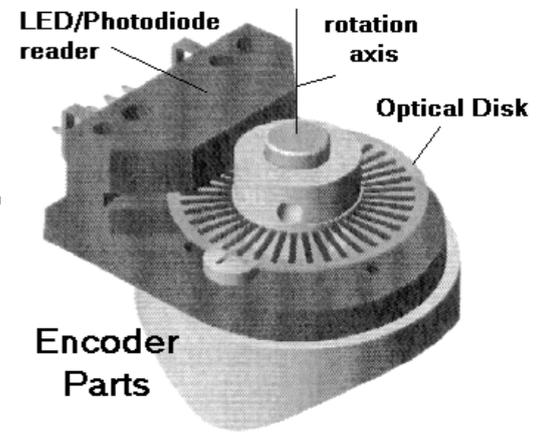
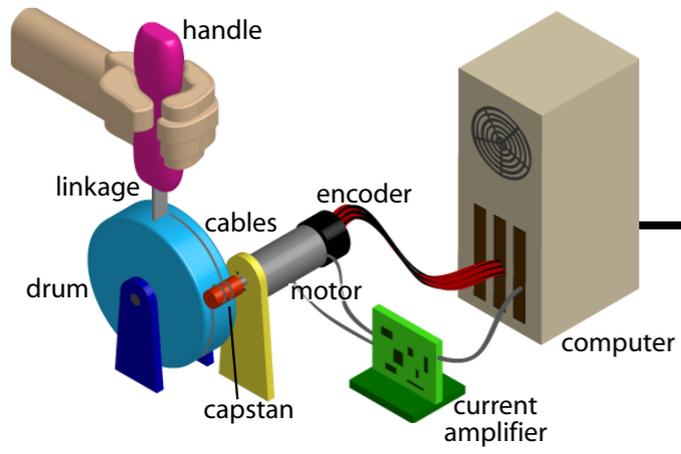
Disk rotation CW



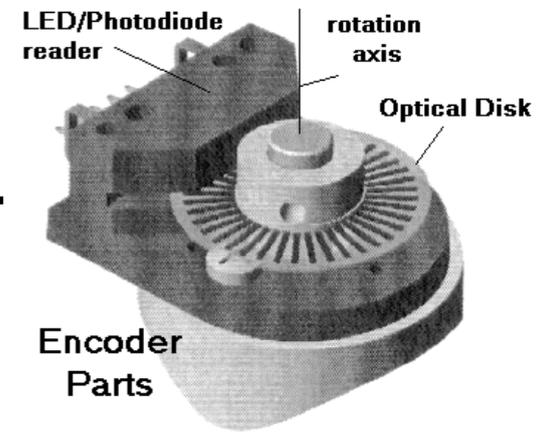
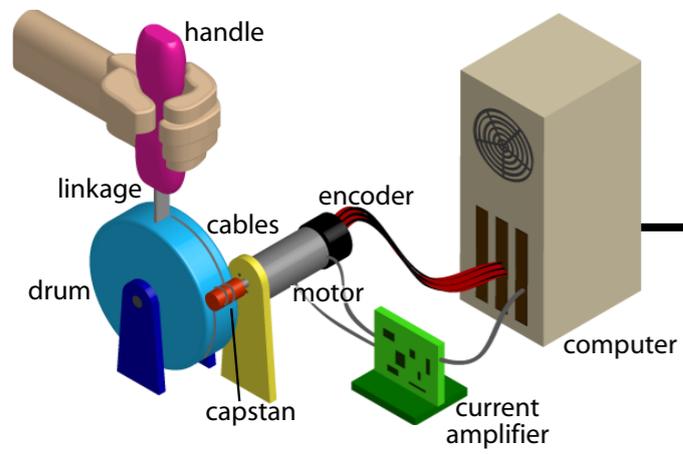
Blocks transmission of light



Encoder

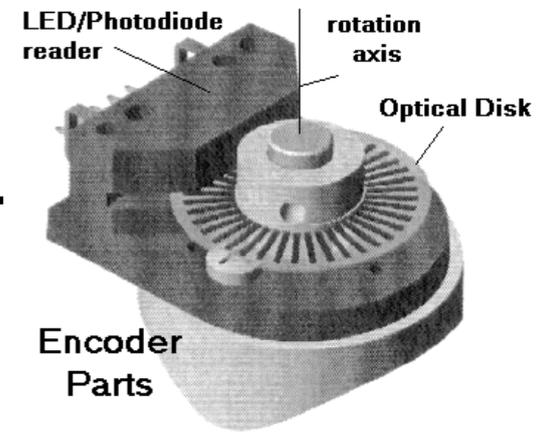
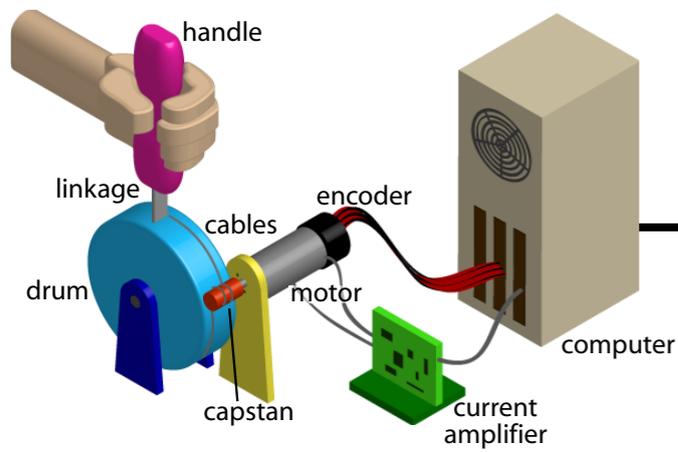


Encoder



Ramifications of using incremental of optical encoders:

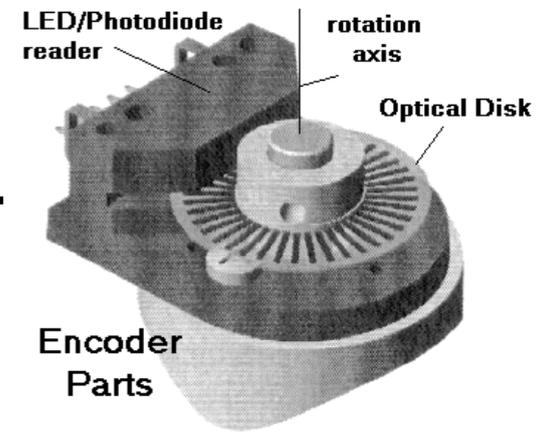
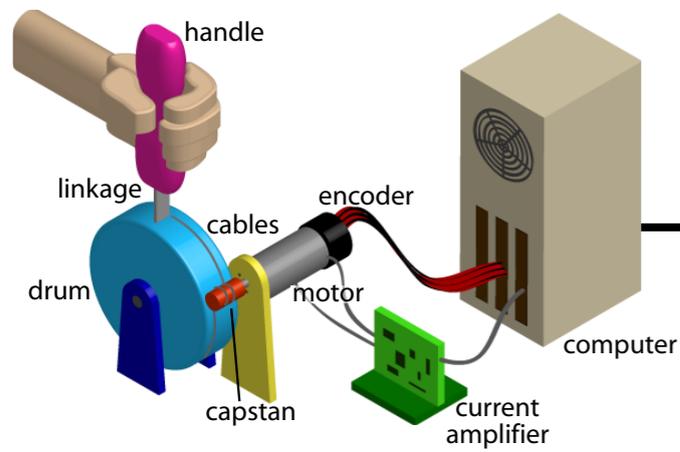
Encoder



Ramifications of using incremental of optical encoders:

- The system has no knowledge of absolute position, because it's always just counting pulses.

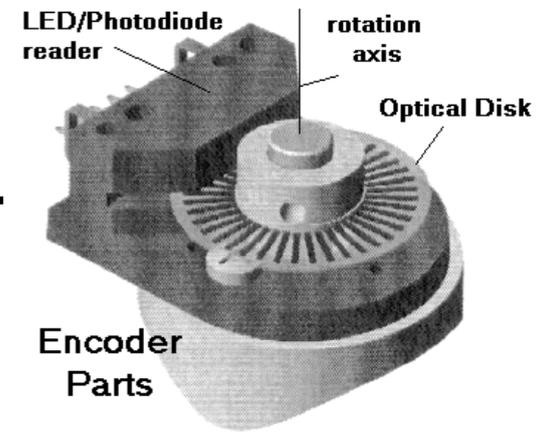
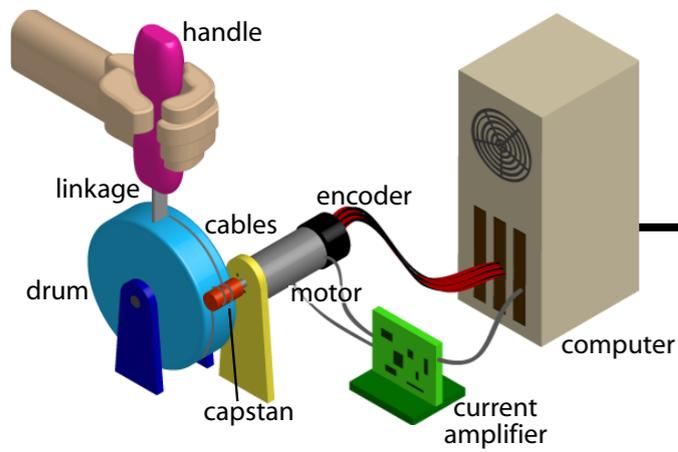
Encoder



Ramifications of using incremental of optical encoders:

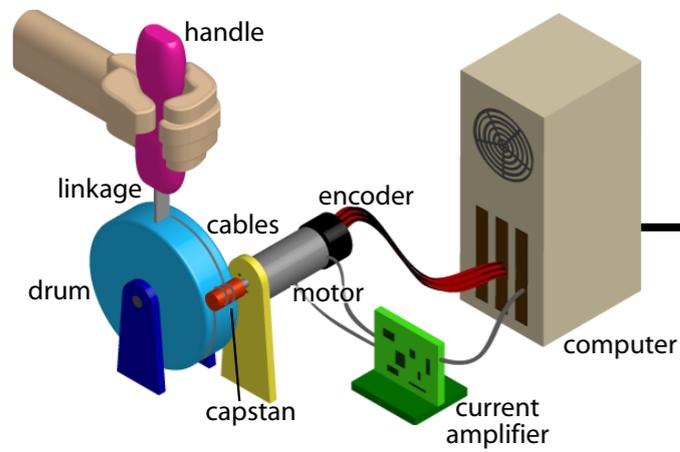
- The system has no knowledge of absolute position, because it's always just counting pulses.
- How can you solve this?

Encoder

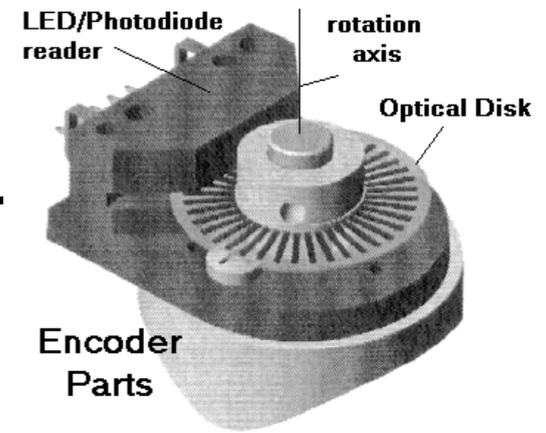


Ramifications of using incremental of optical encoders:

- The system has no knowledge of absolute position, because it's always just counting pulses.
- How can you solve this?
 - Calibration pose (SensAble)

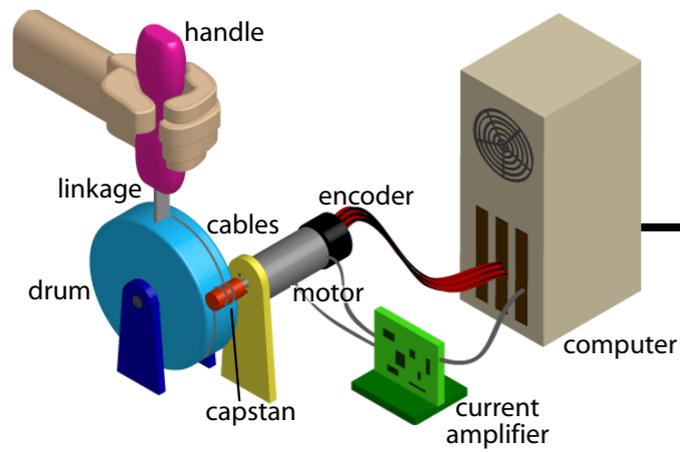


Encoder

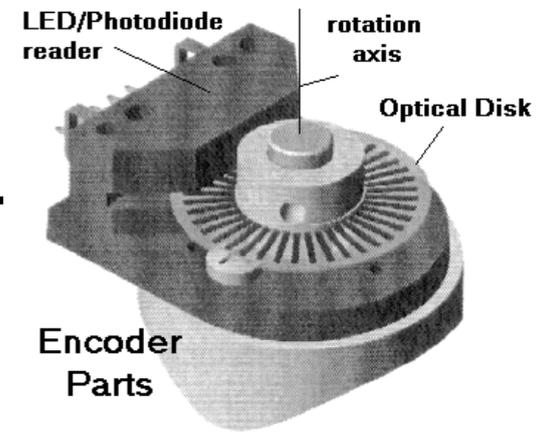


Ramifications of using incremental of optical encoders:

- The system has no knowledge of absolute position, because it's always just counting pulses.
- How can you solve this?
 - Calibration pose (SensAble)
 - Secondary sensors with absolute readings (da Vinci)

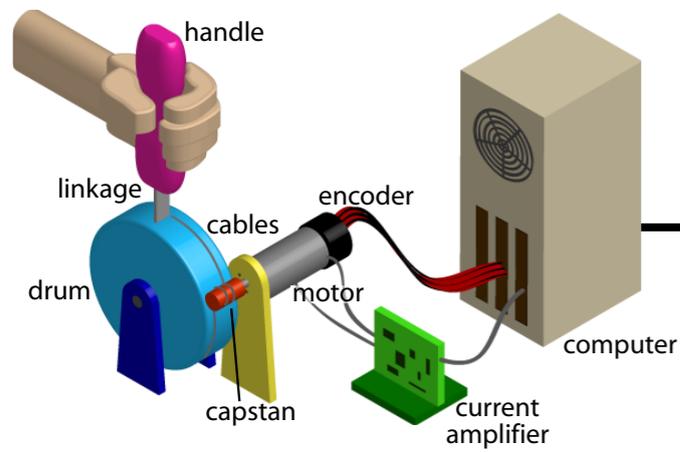


Encoder

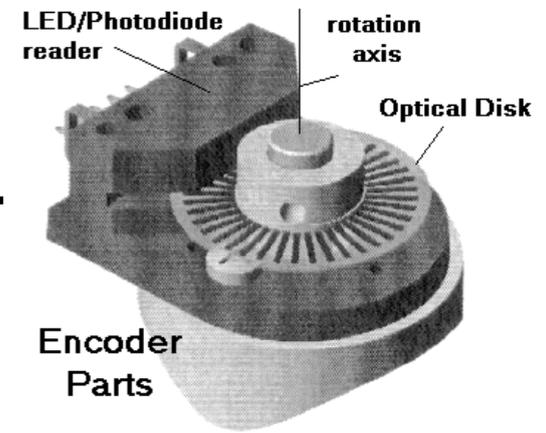


Ramifications of using incremental of optical encoders:

- The system has no knowledge of absolute position, because it's always just counting pulses.
- How can you solve this?
 - Calibration pose (SensAble)
 - Secondary sensors with absolute readings (da Vinci)
- Sometimes problems occur at high velocities.

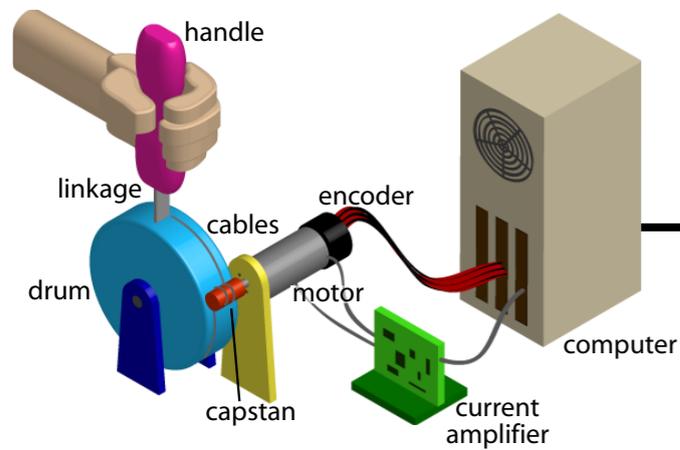


Encoder

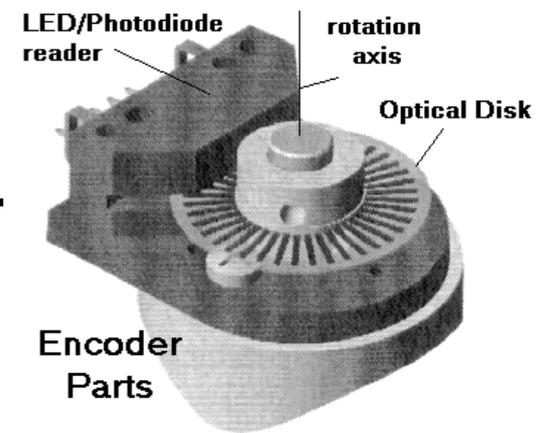


Ramifications of using incremental of optical encoders:

- The system has no knowledge of absolute position, because it's always just counting pulses.
- How can you solve this?
 - Calibration pose (SensAble)
 - Secondary sensors with absolute readings (da Vinci)
- Sometimes problems occur at high velocities.
- No noise on position, but uncertainty due to resolution, and significant noise on velocity.



Encoder

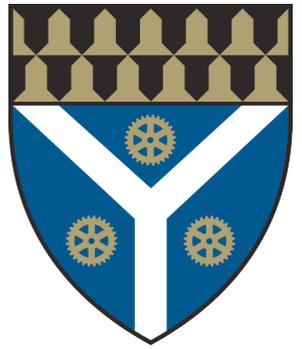


Ramifications of using incremental of optical encoders:

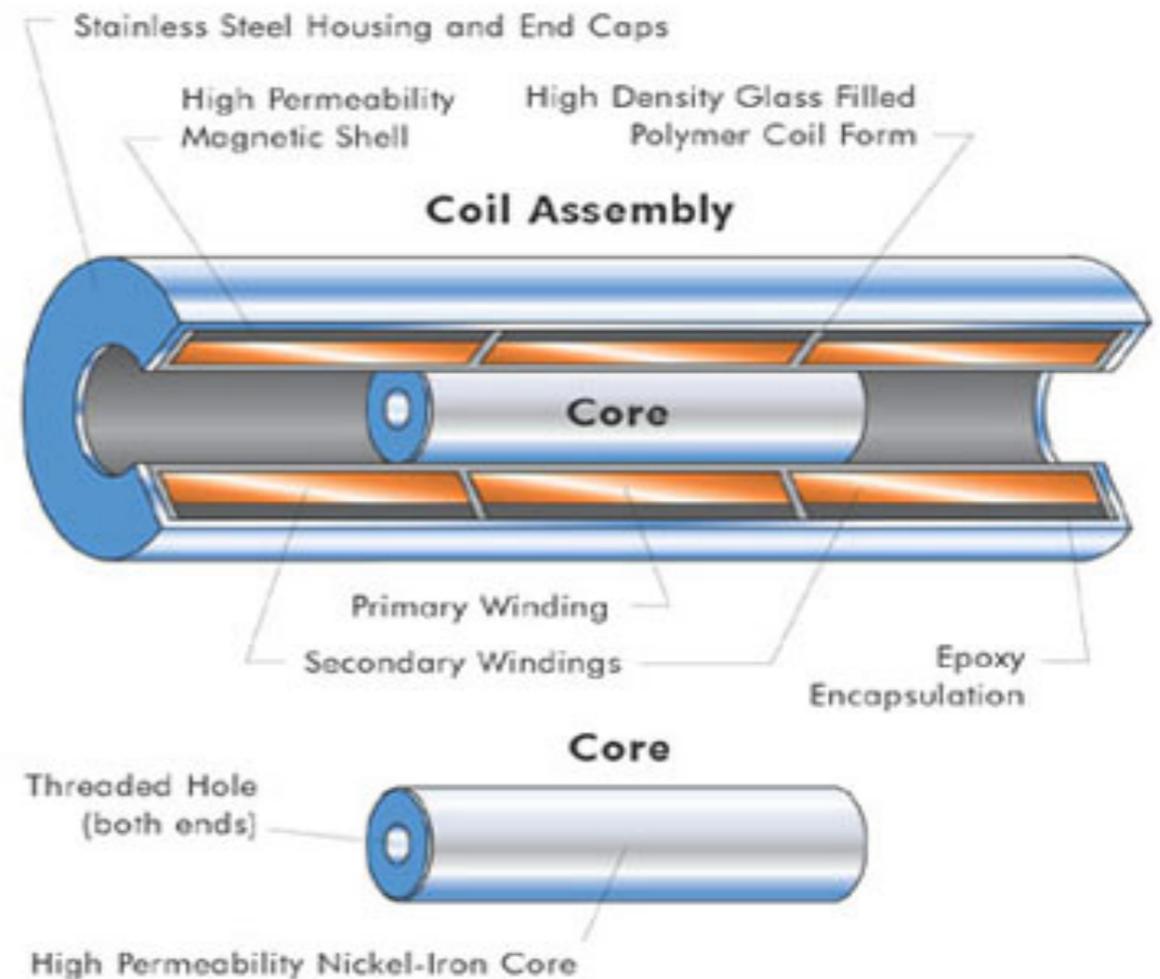
- The system has no knowledge of absolute position, because it's always just counting pulses.
- How can you solve this?
 - Calibration pose (SensAble) $\theta_m = \Delta(Q - Q_{zero})$
 - Secondary sensors with absolute readings (da Vinci)
- Sometimes problems occur at high velocities.
- No noise on position, but uncertainty due to resolution, and significant noise on velocity.



LVDT

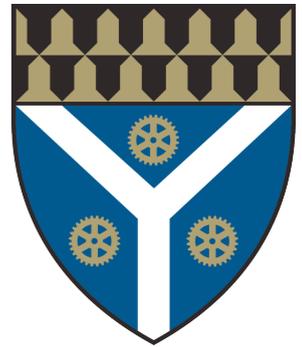


- Linear variable displacement transducer
- Very accurate
- More complex to support than potentiometers or encoders – need multiple AC voltage sources
- Inherently analog

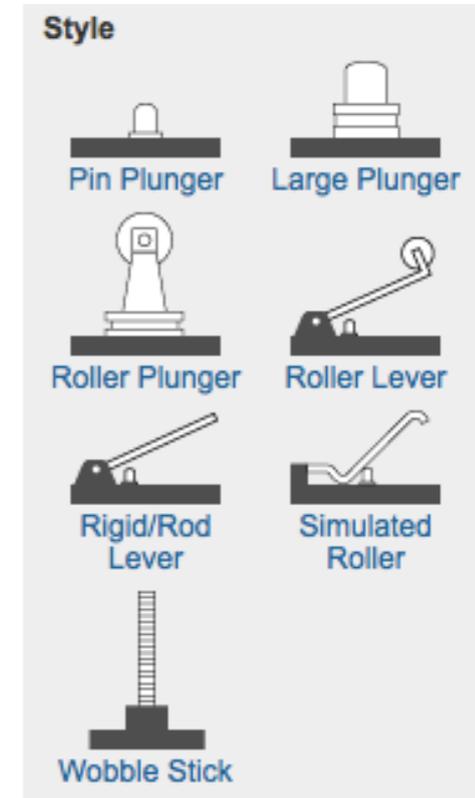
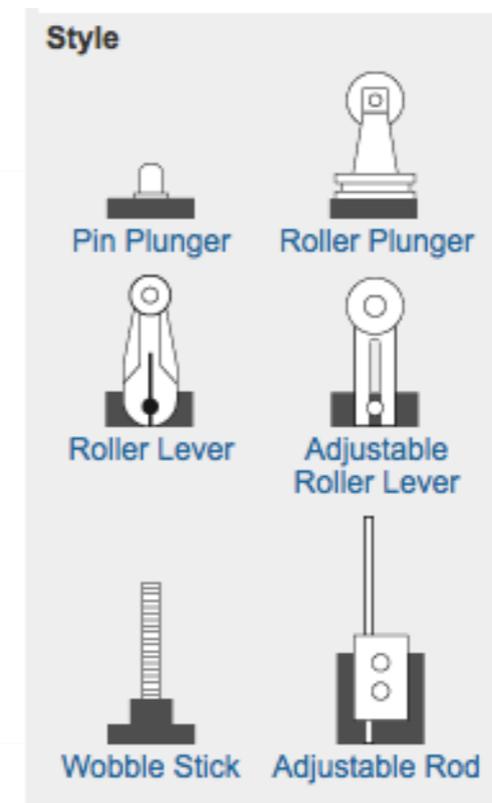
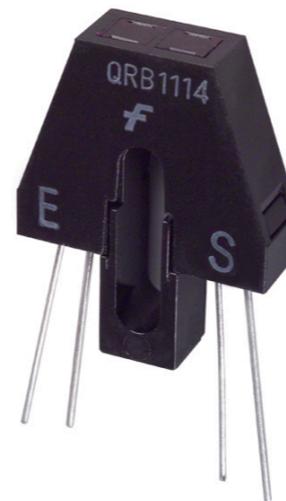




Proximity Sensors

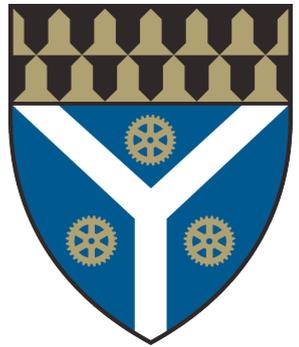


- Implies that one only wants data when something is close – don't care when it is “far away”
 - Eddy current proximity sensor – lower accuracy
 - Inductive proximity sensor – senses metallic objects
 - Limit switch – rugged sealed on/off designed for repeated contact with moving parts
 - Infrared emitter-detector pair – reflected IR from source gives indication of distance
 - Ultrasonic range sensor – reflected ultrasonic signal from source gives indication of distance

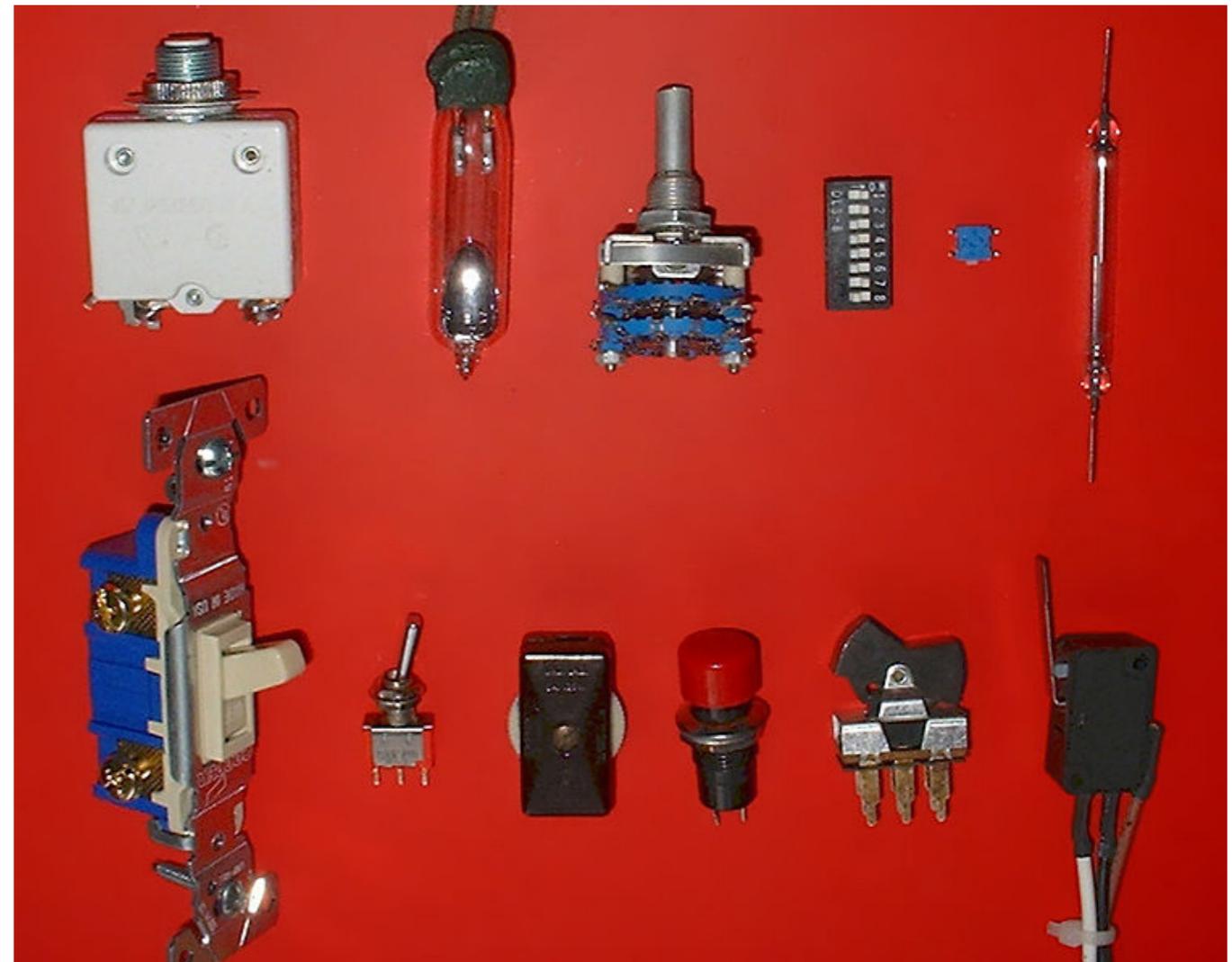




Switches



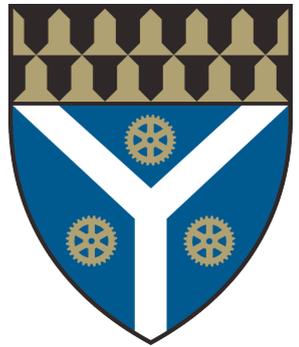
- Rotary, pushbutton, slide, toggle, tilt ...
- Momentary vs. Persistent ON/OFF
- Many, many types
- Bounce



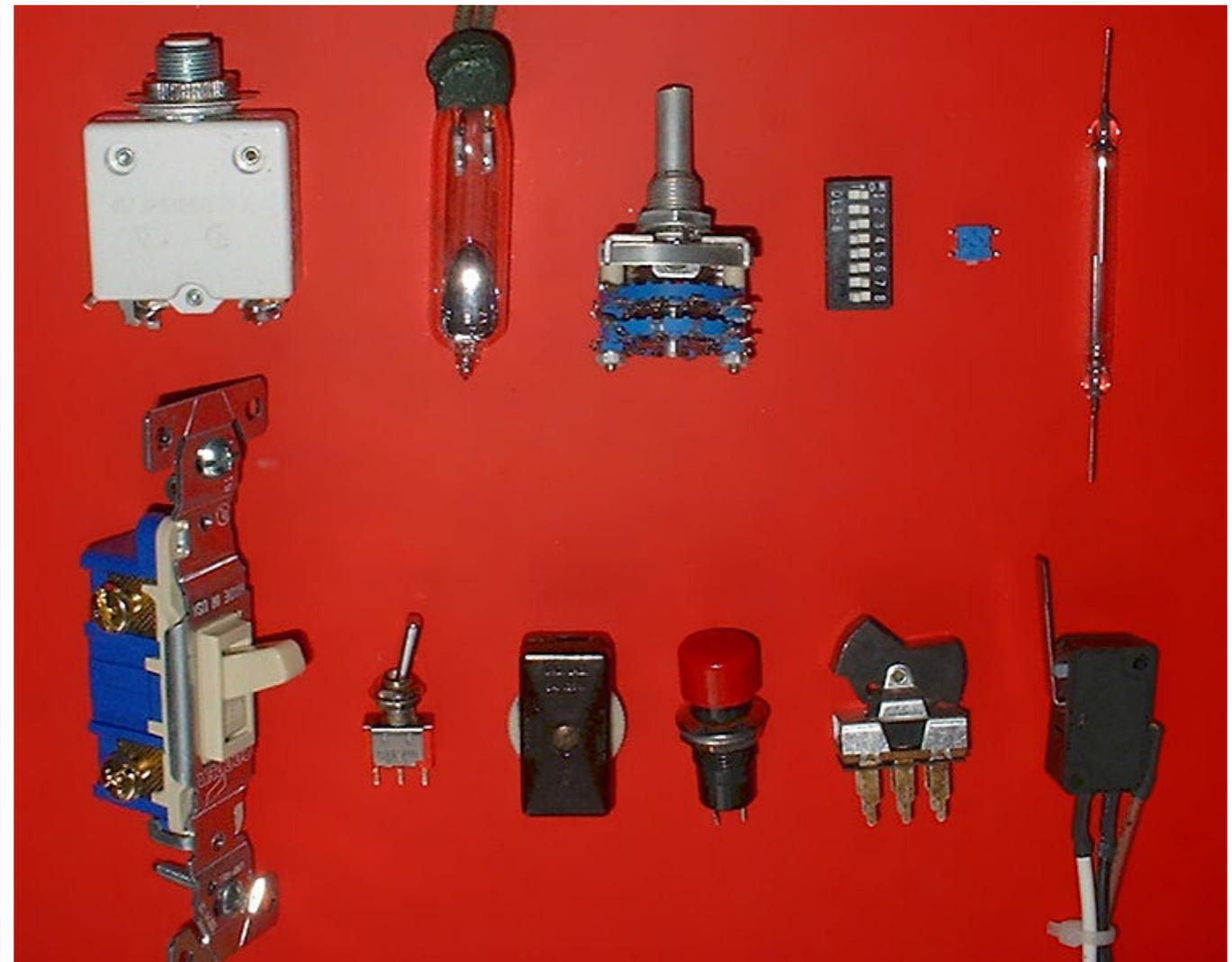
Videos from http://video_demos.colostate.edu/mechatronics/



Switches



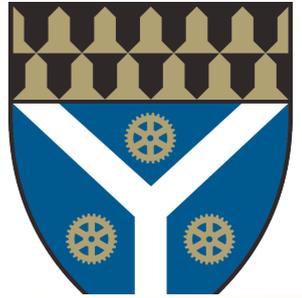
- Rotary, pushbutton, slide, toggle, tilt ...
- Momentary vs. Persistent ON/OFF
- Many, many types
- Bounce



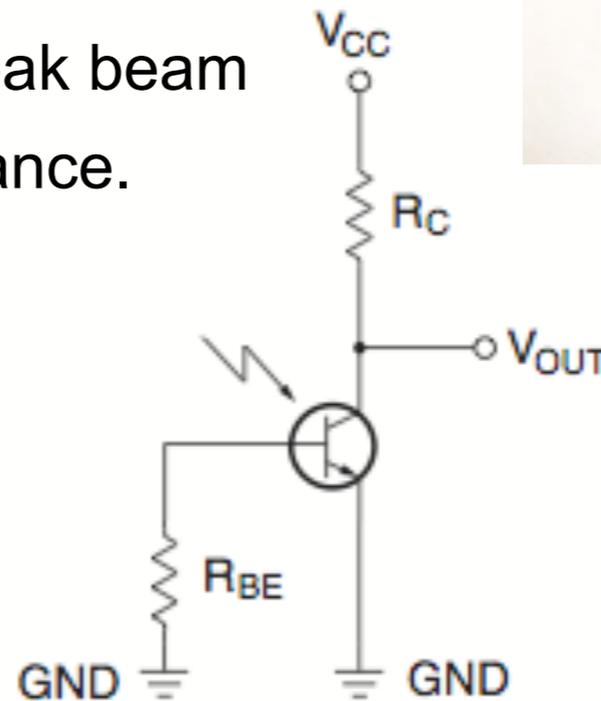
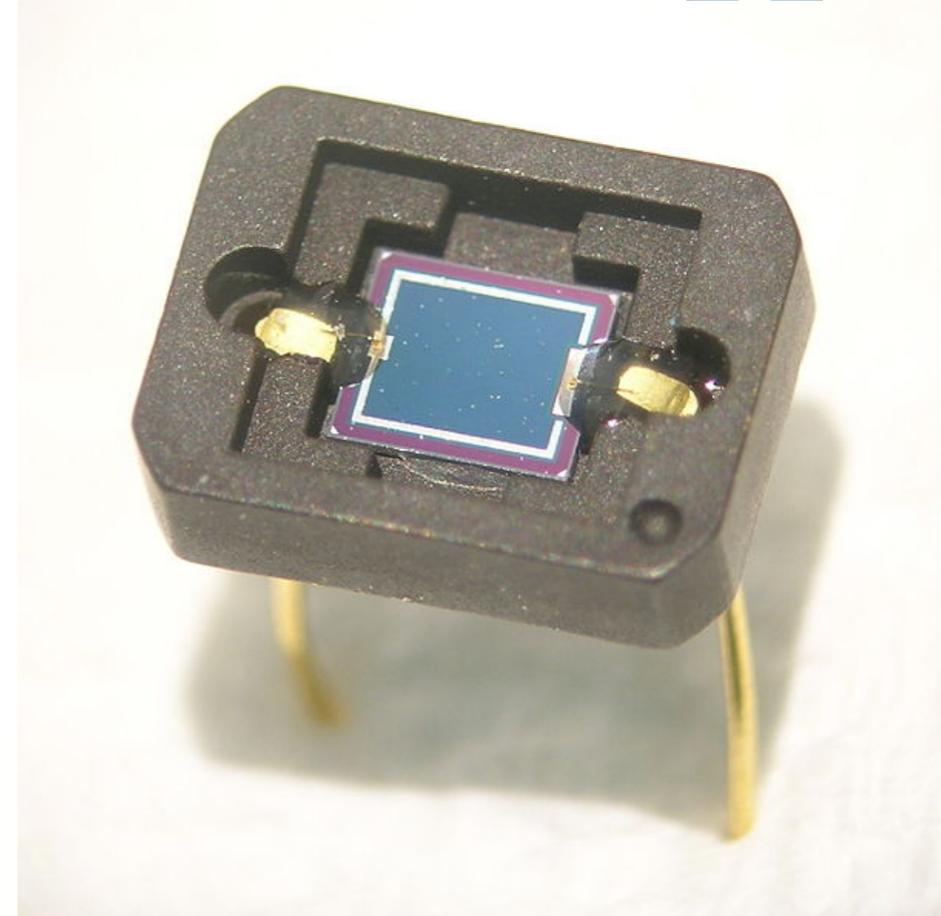
Videos from http://video_demos.colostate.edu/mechatronics/



Light

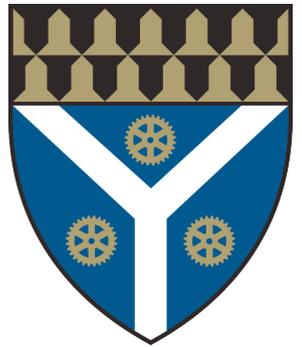


- Photodiodes, phototransistors, photoresistors
 - Small, easy to fit into electronic systems.
 - Require electrical engineering knowledge to implement properly.
 - Can set up in a variety of ways, including distance reflectance, gray-scale reflectance, distance intensity, break beam
 - Ambient light can impact performance.



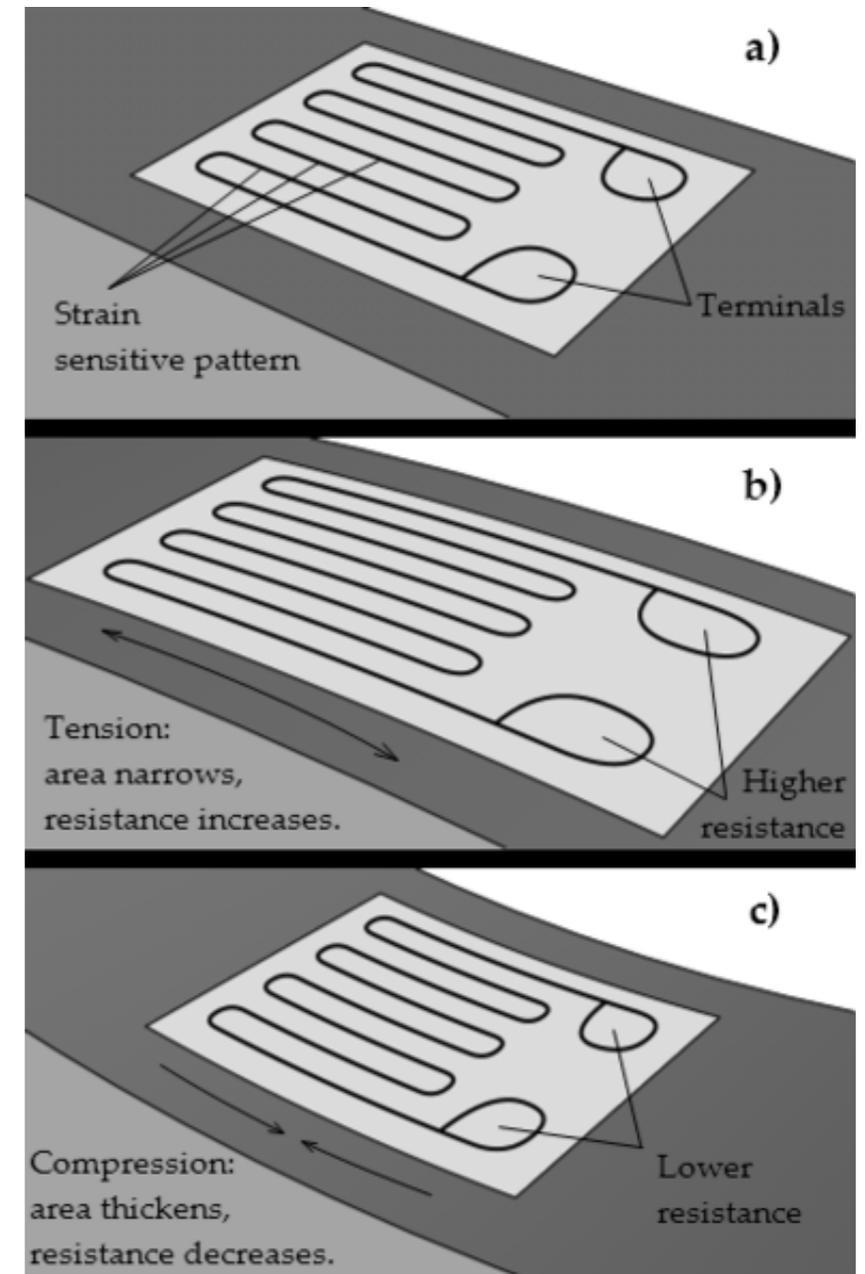
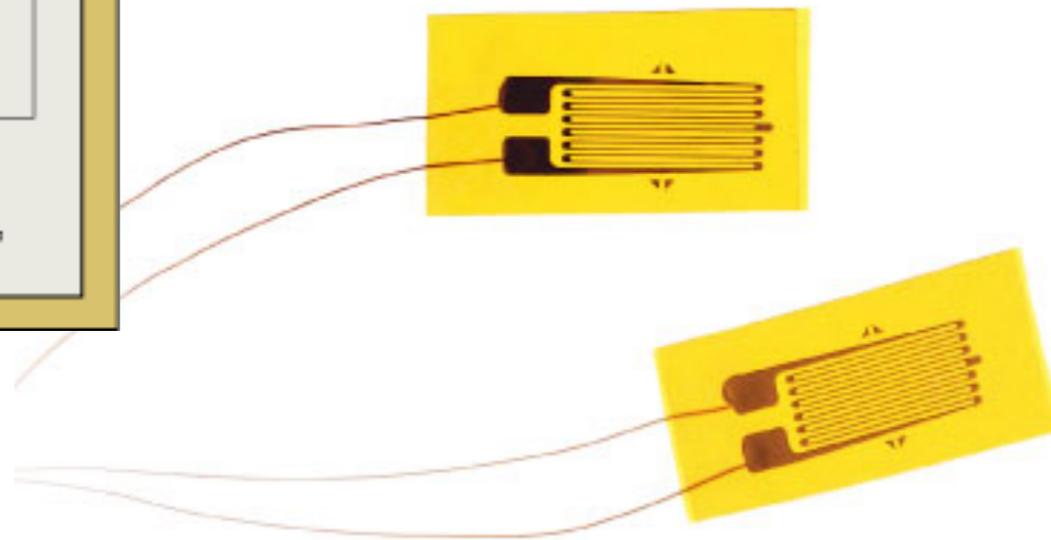
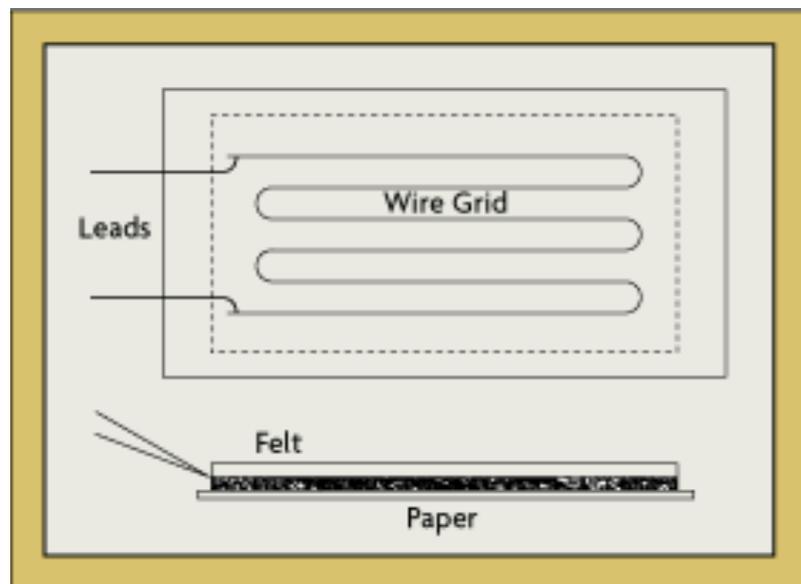


Strain Gauges



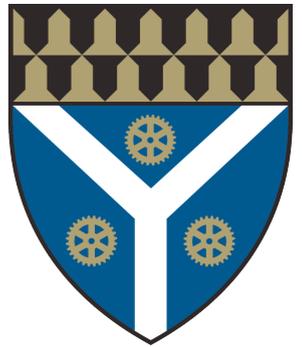
- Change in length changes resistance
- Temperature also changes resistance

$$\frac{\Delta R}{R} = G\varepsilon$$

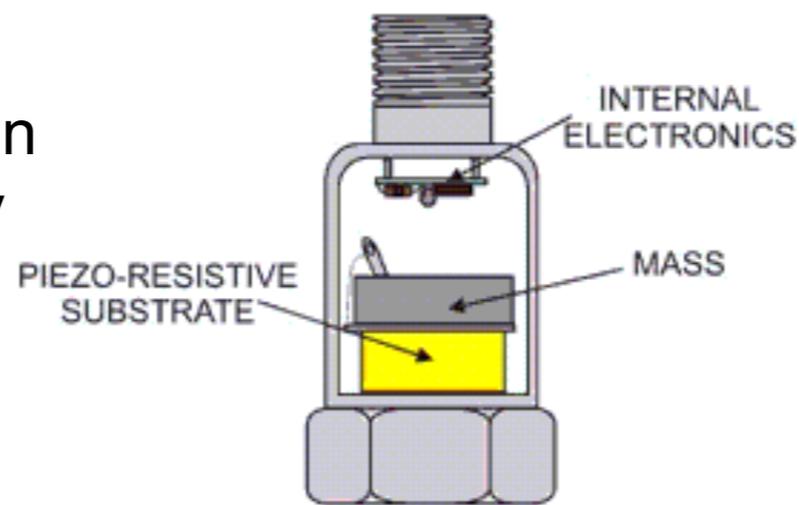




Force Sensing

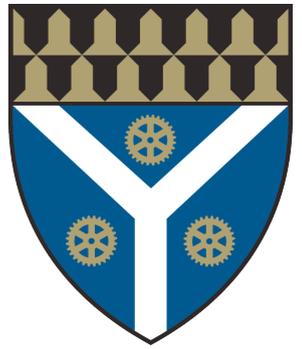


- Measure the position change on an elastic element
- Strain gauge load cell – clever layout of gauges & material shape to create accurate system
- Fluid pressure on a diaphragm – measure change in length/size of a diaphragm with strain gauges
- Piezo electric crystals – generate electrical signals when a strain is generated – typically used for high frequency force changes (accelerations)



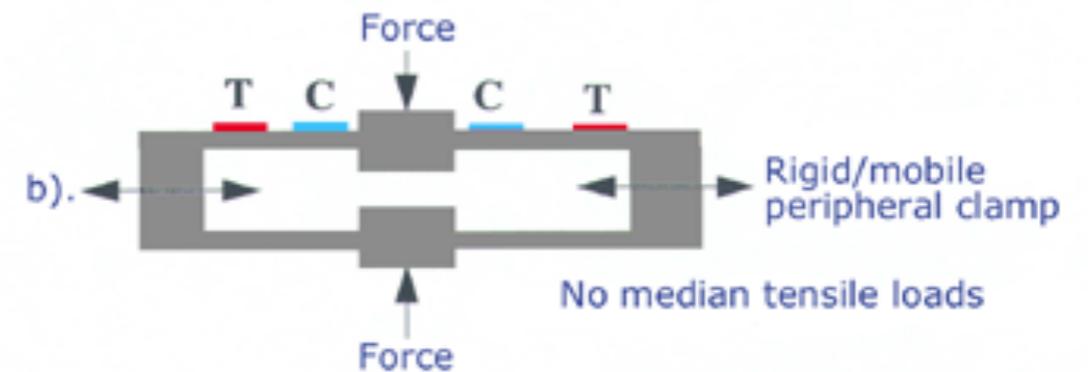
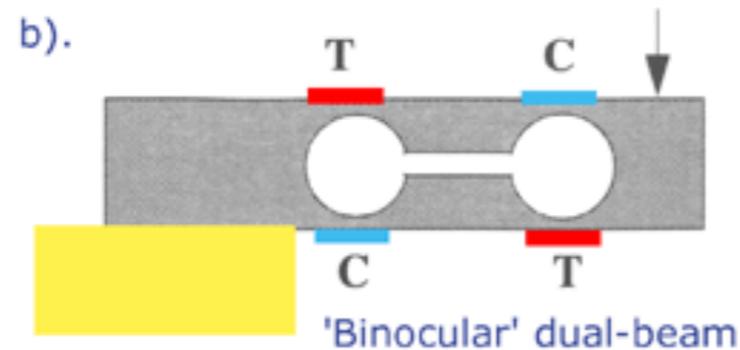
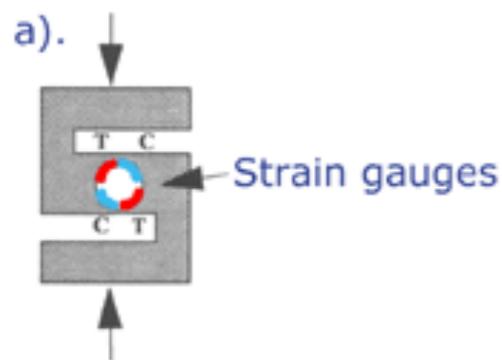
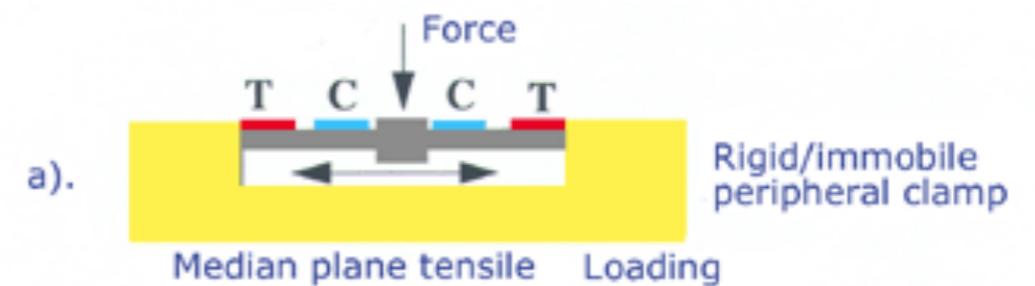
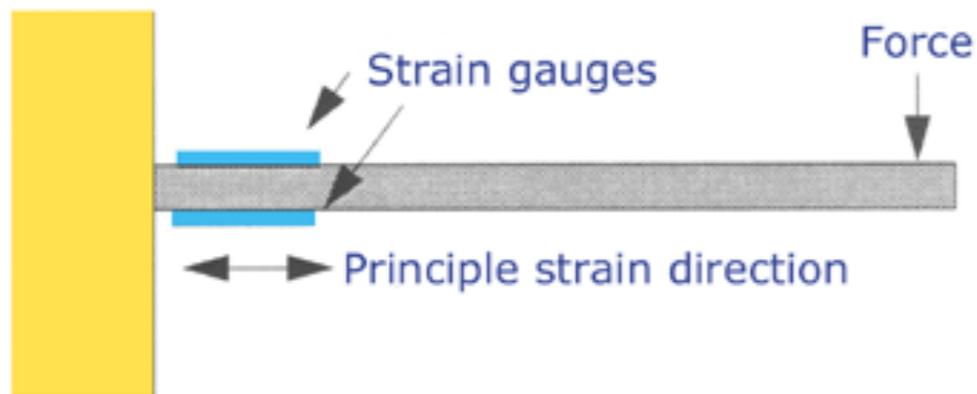
A single ended compression accelerometer





A load cell

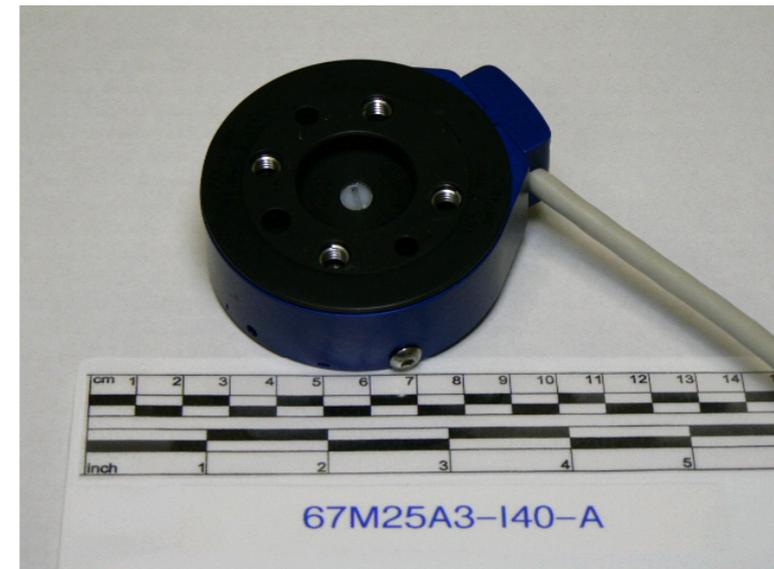
- A piece of metal that is designed to deform in a predictable way to create a measurement of load (torque and/or force)



Force Sensors

- How do they work?
 - Typically a flexure + a strain gage (sometimes also piezoelectric sensors, but these tend to drift)
- A good quality 6-axis force-torque sensor is ~\$6000
 - Mechanically delicate - do not drop or hit
 - Sensitive to temperature fluctuations

6-Axis JR3 Force
Torque Load Cell



JR3.com

ATI Nano17 Transducer



www.ati-ia.com

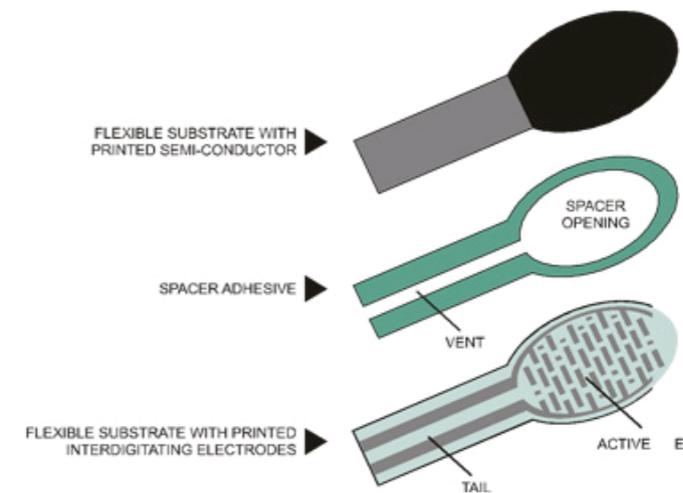


Force Sensing Resistors



- Known as FSRs
 - Piezoresistive ink
 - Tons of sensor drift and hysteresis, sensitivity to contact location
 - Very thin!
 - Cheap ~\$10
 - Use drive circuit recommended by manufacturer to get voltage output that is approximately linear with force

Interlink FSR



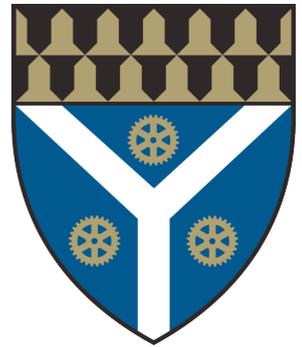
www.interlinkelectronics.com

Tekscan Flexiforce FSR





Temperature

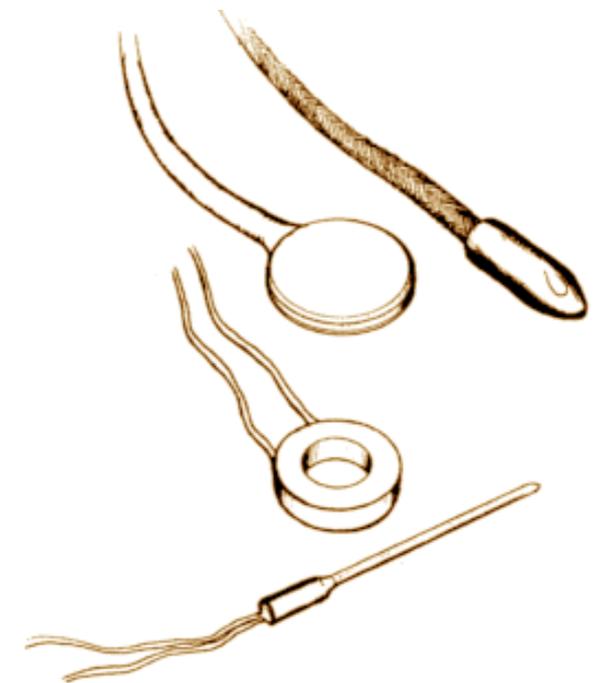
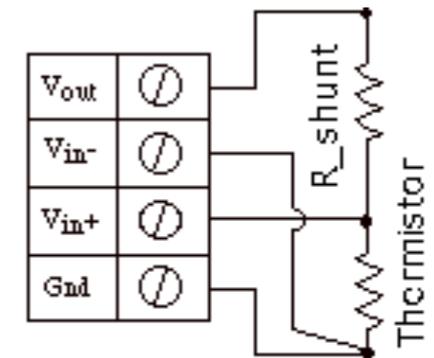
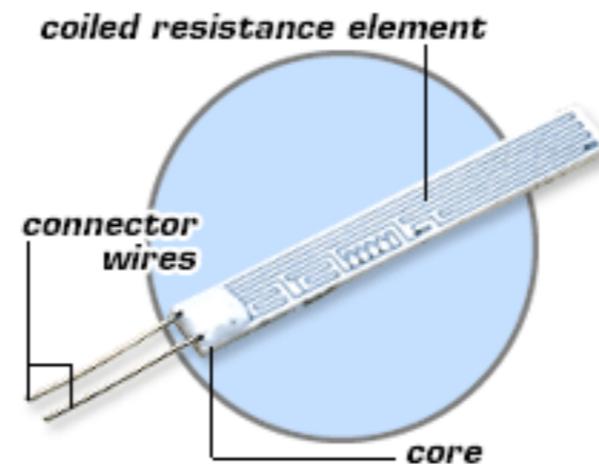


- Thermistor
- RTD
- Thermocouples

- Equations vary but they are all nonlinear and require some “figuring” to get the right answer



Typical RTD Design



Inertial Sensing

Inertial Sensing

MEMS Inertial Sensors | MEMS and Sensors | Analog Devices

http://www.analog.com/en/mems-sensors/mems-inertial-sensors/products/index.html

WORLD LEADER IN HIGH PERFORMANCE SIGNAL PROCESSING

Select a Language: English

ANALOG DEVICES

Enter keywords or part # Search

Parametric Product Search

Cross-Reference and Obsolete Search

Welcome User Log In View Cart

PRODUCTS APPLICATIONS RESOURCES & TOOLS SAMPLE & PURCHASE SUPPORT myAnalog

ADI Home > MEMS and Sensors > MEMS Inertial Sensors

Print | Save to myAnalog

MEMS INERTIAL SENSORS

Learn about MEMS inertial sensor technology that detects and measures acceleration, tilt, shock, vibration, rotation, and multiple degrees-of-freedom (DoF). Determine the MEMS technology that will best support your motion sensing application. Download [inertial sensor FAQs](#), white papers, and the latest technical article, [Gyro Mechanical Performance: The Most Important Parameter, MS-2158](#). Read inertial sensor [customer success stories](#). View [solutions bulletins](#) that highlight MEMS inertial sensor technologies.

Analog Devices offers discrete and integrated inertial sensor solutions – iMEMS® accelerometers and gyroscopes, as well as highly integrated, fully calibrated and factory tested iSensor® intelligent sensors and inertial measurement units (IMUs).

SELECTION TABLES AND DATA SHEETS

- MEMS Accelerometers
- iSensor MEMS Accelerometer Subsystems
- iSensor MEMS Inertial Measurement Units
- MEMS Gyroscopes
- iSensor MEMS Gyroscope Subsystems

NEWS

NEW PRODUCTS

- ADIS16136** - ±450°/Sec Precision Angular Rate Sensor
- ADIS16488** - Low Profile, Low Noise Ten Degrees of Freedom Inertial Sensor
- ADXL337** - Small, Low Power, 3-Axis ±3 g Accelerometer

Subscribe to New Products Feed

Circuits from the Lab™ Reference Circuits

Circuits from the Lab™ reference circuits are engineered and tested for quick and easy system integration.

[View Circuit Notes for MEMS Inertial Sensors](#)



Using MEMS Sensors for Industrial Platform Stabilization Systems

[View Webcast Now](#)

LEARN MORE ABOUT THE TYPES OF INERTIAL SENSING:

- Sense Acceleration
- Sense Tilt
- Sense Rotation
- Sense Shock

Inertial Sensing

MEMS Inertial Sensors | MEMS and Sensors | Analog Devices

http://www.analog.com/en/mems-sensors/mems-inertial-sensors/products/index.html

Google

SELECTION TABLES AND DATA SHEETS

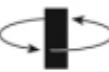
- MEMS Accelerometers
- iSensor MEMS Accelerometer Subsystems
- iSensor MEMS Inertial Measurement Units
- MEMS Gyroscopes
- iSensor MEMS Gyroscope Subsystems

From the **CAD** Reference Circuits integration.
[» View Circuit Notes for MEMS Inertial Sensors](#)

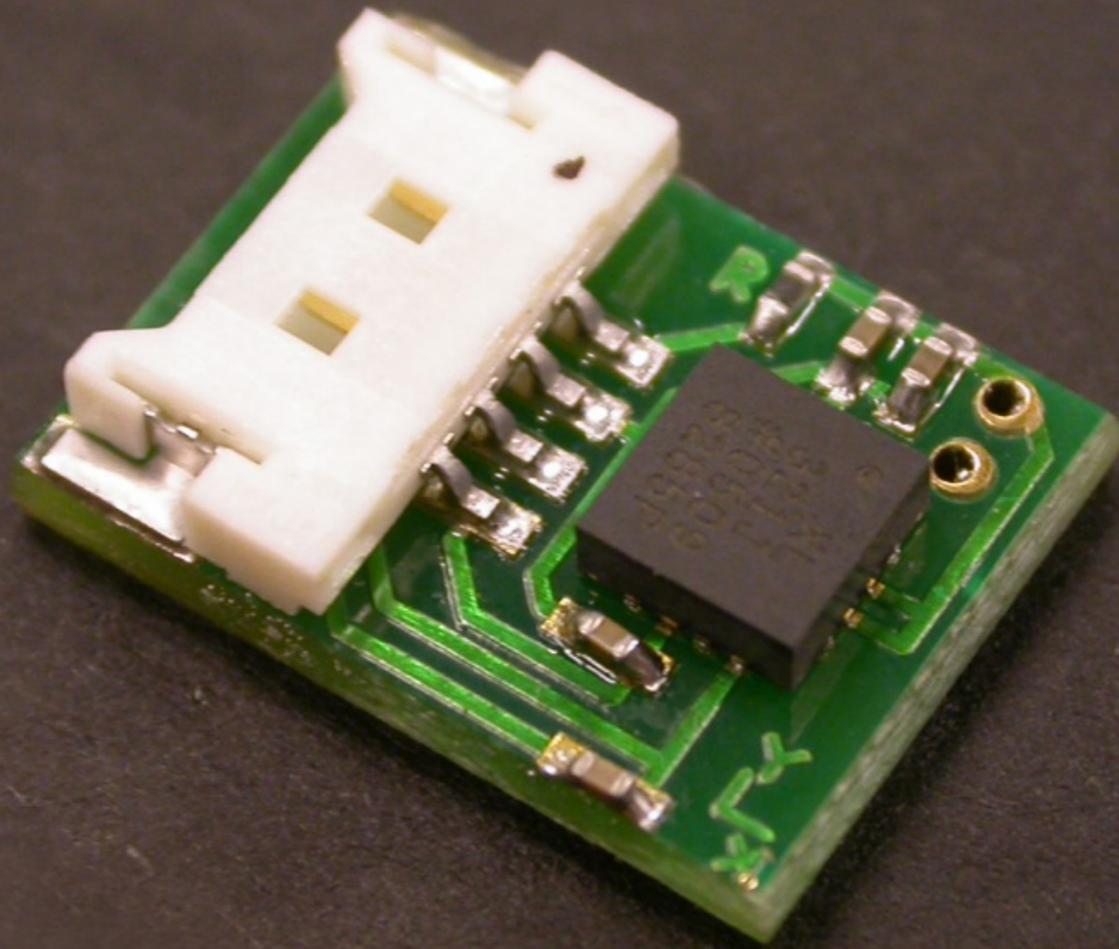


Using MEMS Sensors for Industrial Platform Stabilization Systems
[View Webcast Now](#)

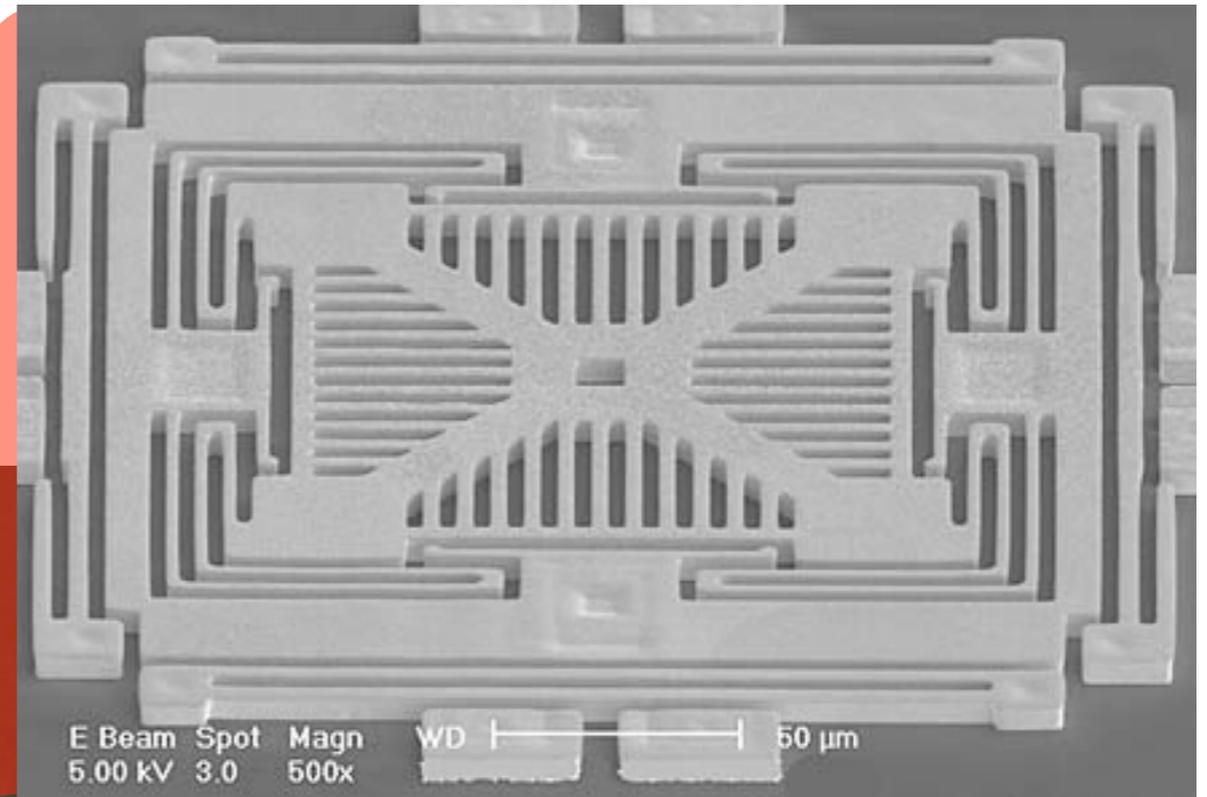
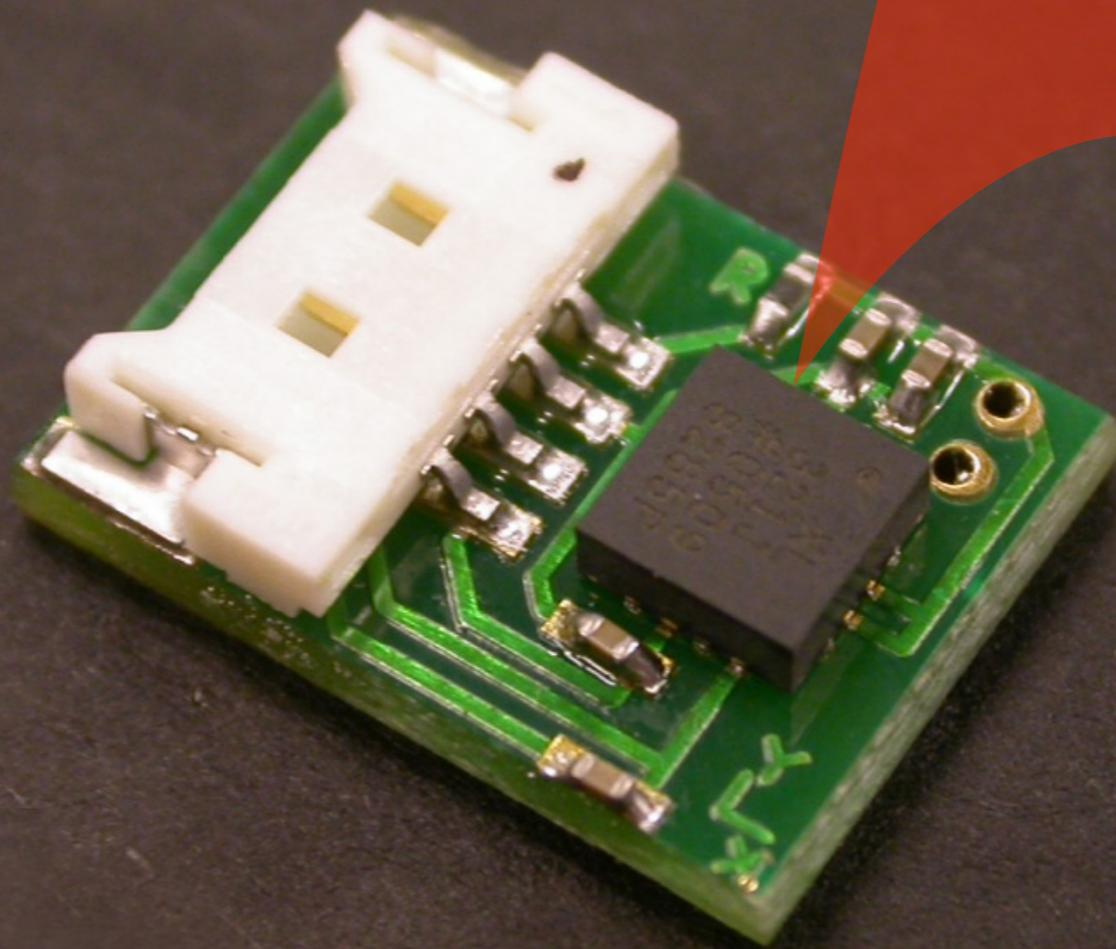
LEARN MORE ABOUT THE TYPES OF INERTIAL SENSING:

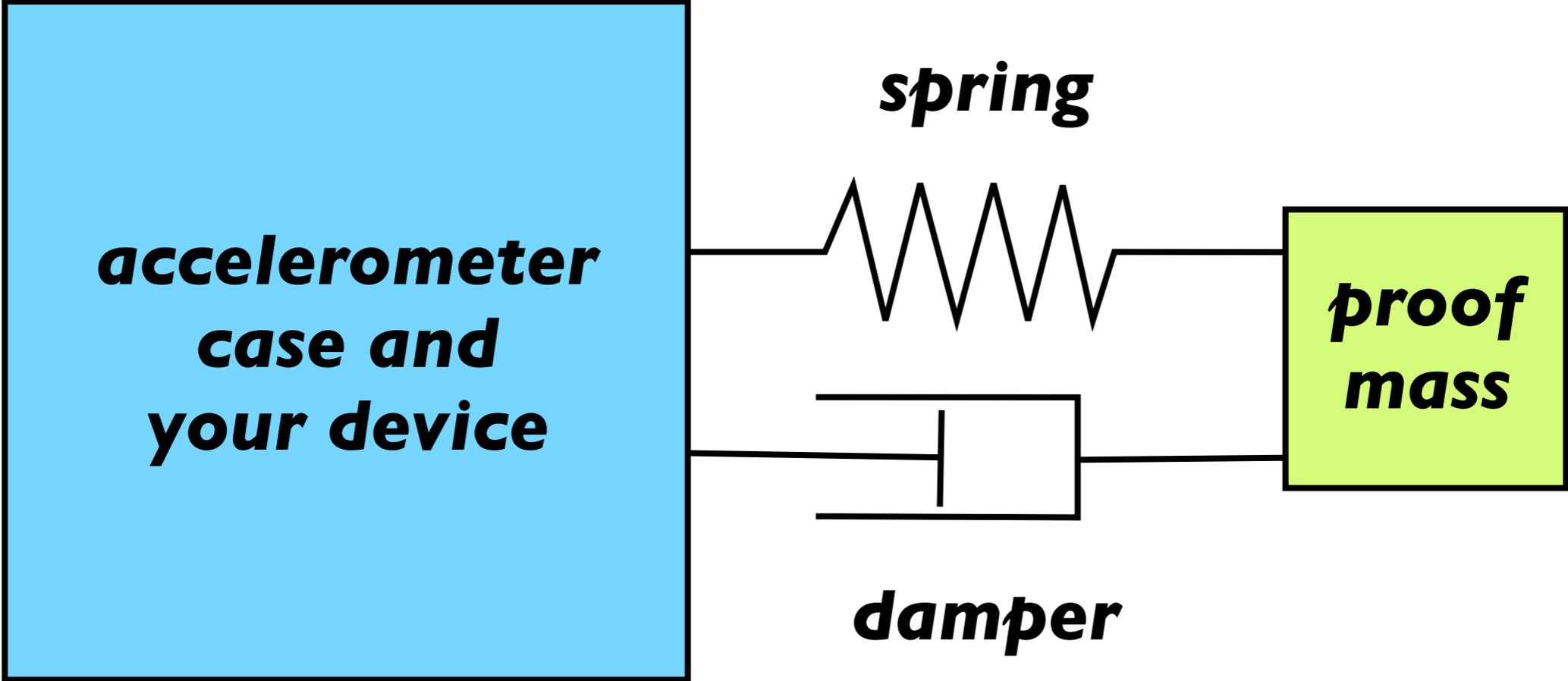
<h3>Sense Acceleration</h3>  <p>What is Acceleration Sensing?</p> <p>Acceleration sensing refers to the movement of an object from one point to another along a straight line or axis. It includes translational movement such as position and orientation. More...</p>	<h3>Sense Tilt</h3>  <p>What is Tilt Sensing?</p> <p>Tilt sensing measures the inclination or angle of change with respect to gravity. More...</p>	<h3>Sense Rotation</h3>  <p>What is Rotation Sensing?</p> <p>Rotation sensing measures the angular rate—how quickly an object turns. The rotation is typically measured in degrees per second of change and in reference to one of three axes: yaw, pitch, or roll. More...</p>	<h3>Sense Shock</h3>  <p>What is Shock Sensing?</p> <p>Shock sensing detects sudden impact at a predetermined level. More...</p>
<h3>Sense Vibration</h3>  <p>What is Vibration Sensing?</p> <p>Vibration sensing detects acceleration and deceleration occurring in a periodic manner. More...</p>	<h3>Sense Multiple Degrees-of-Freedom (DoF)</h3>  <p>What is Multiple Degrees-of-Freedom Sensing?</p> <p>Multiple DoF sensing relies on the combined input of multiple sensing types, such as acceleration and rotation, along multiple axis. More...</p>	<h3>Technical Documentation</h3> <p>Get the Basics</p> <ul style="list-style-type: none">FAQGlossary of TermsQuick Definition of Accelerometer SpecsWhite Paper: The 5 Motion Senses: Using MEMS Inertial Sensing to Transform ApplicationsAnalog Dialogue: Accelerometers—Fantasy & Reality	

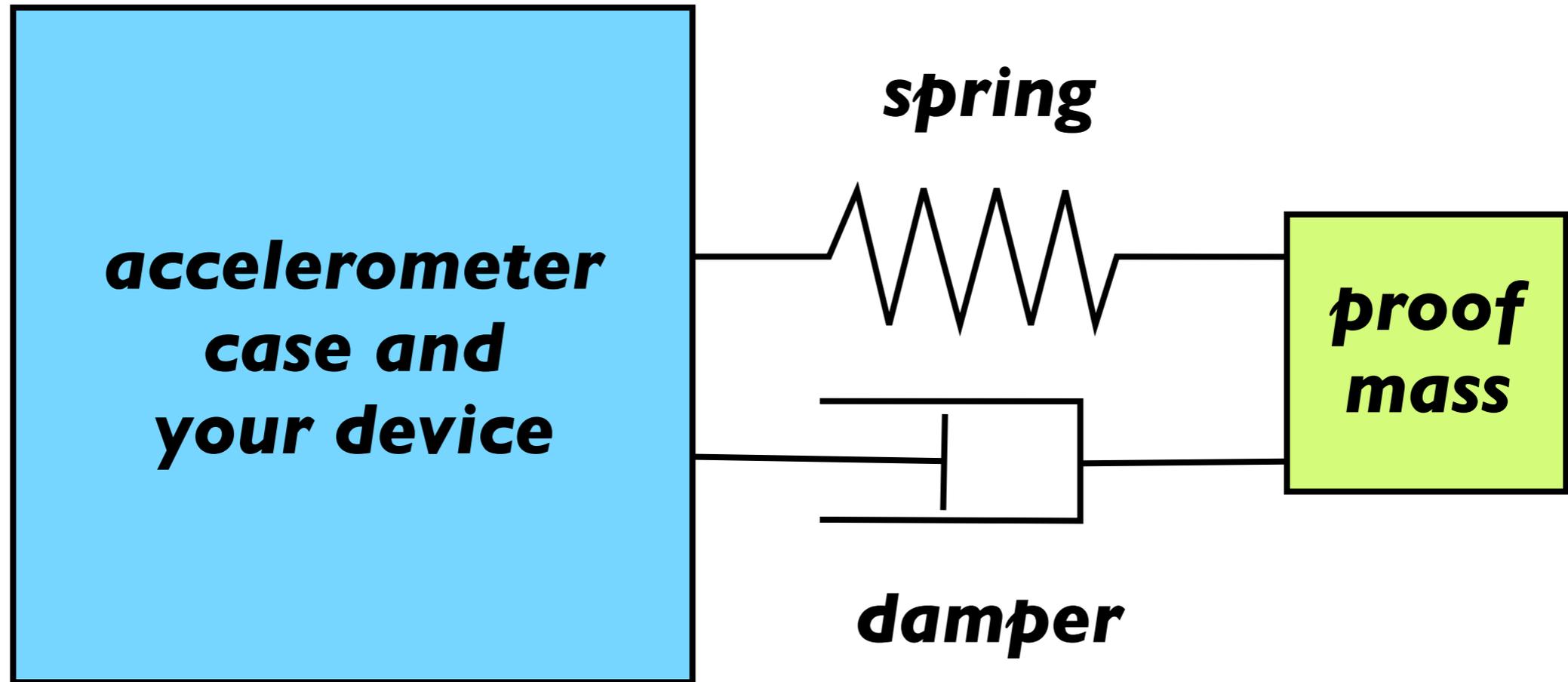
MEMS-based Accelerometers



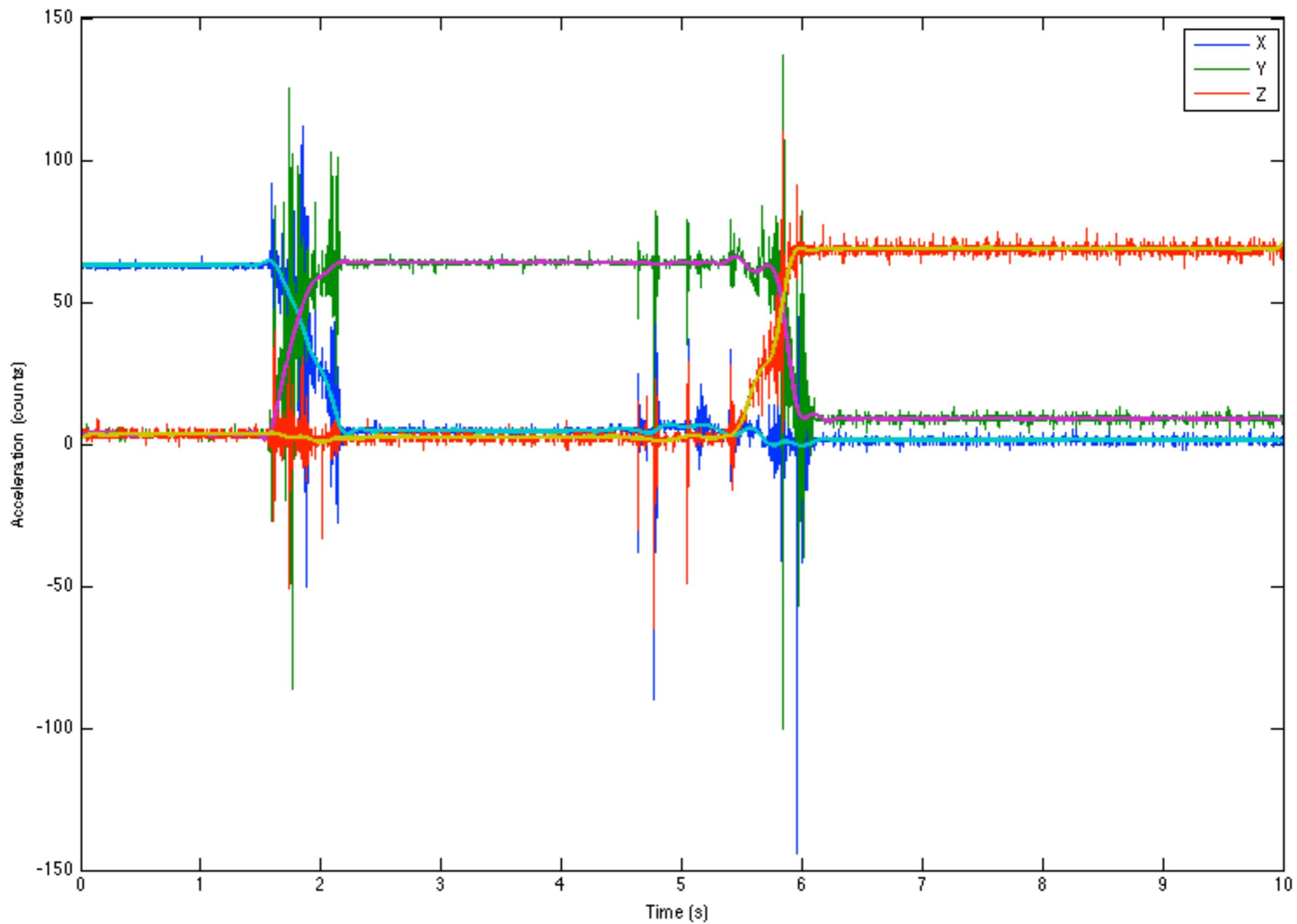
MEMS-based Accelerometers



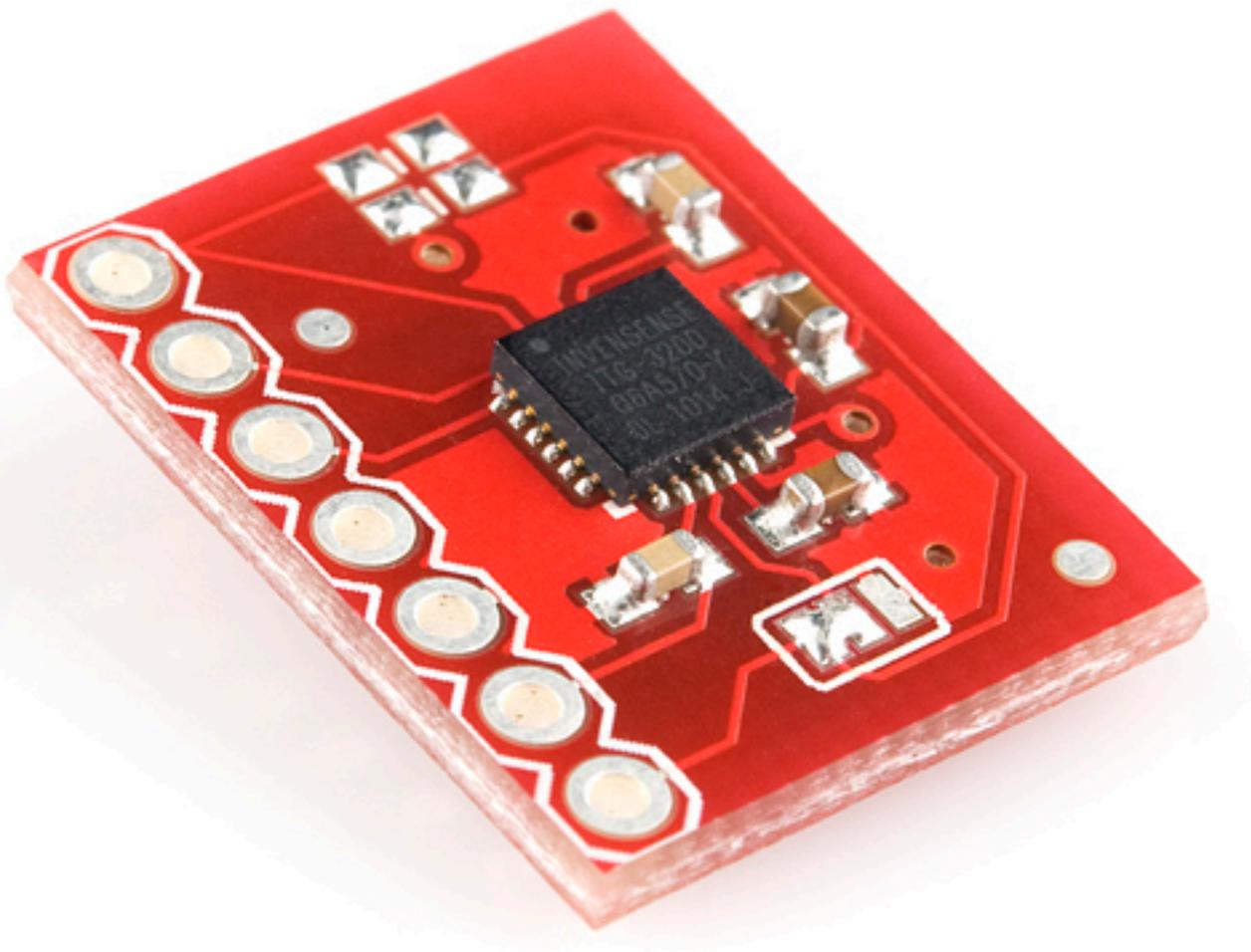




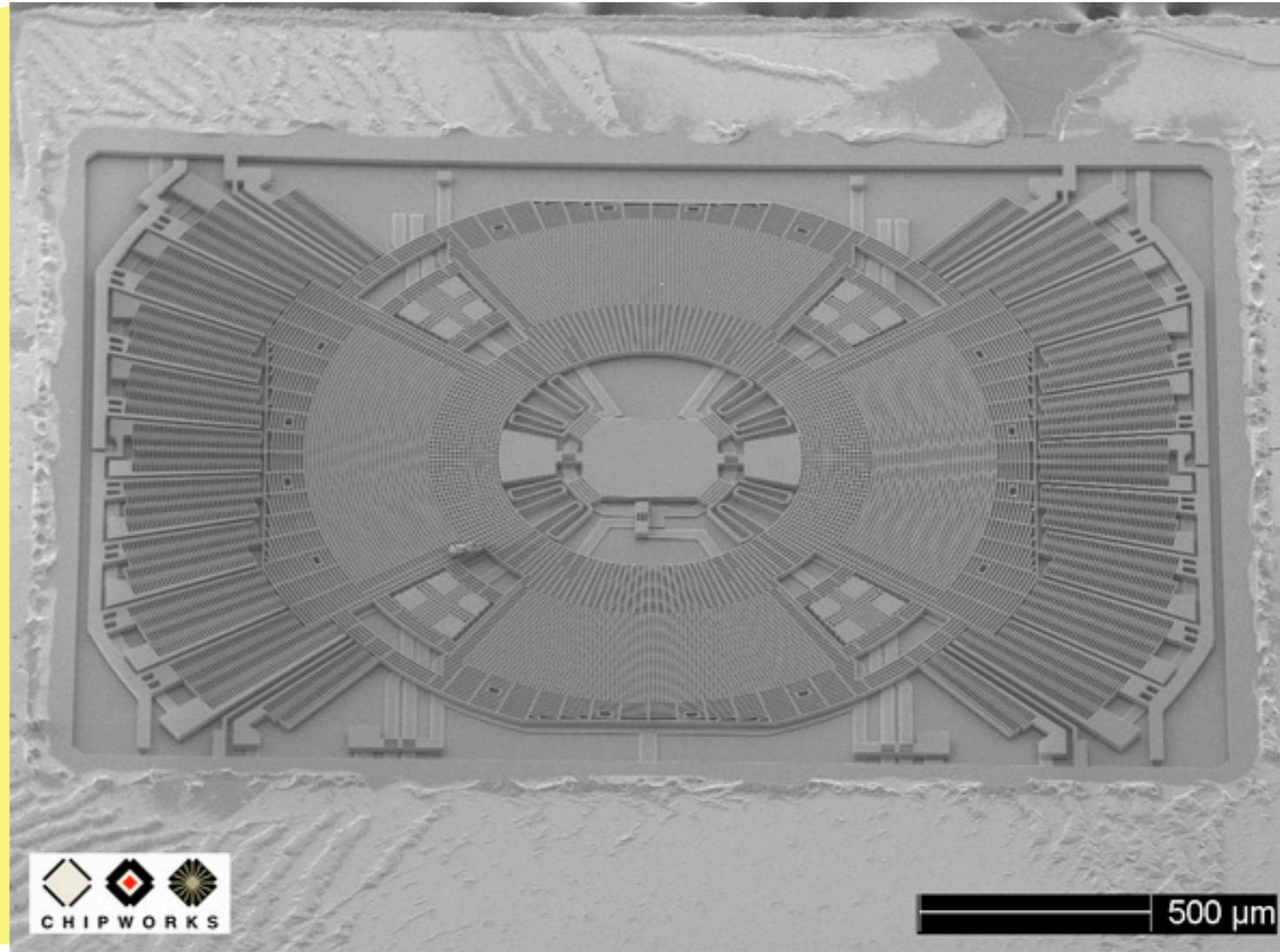
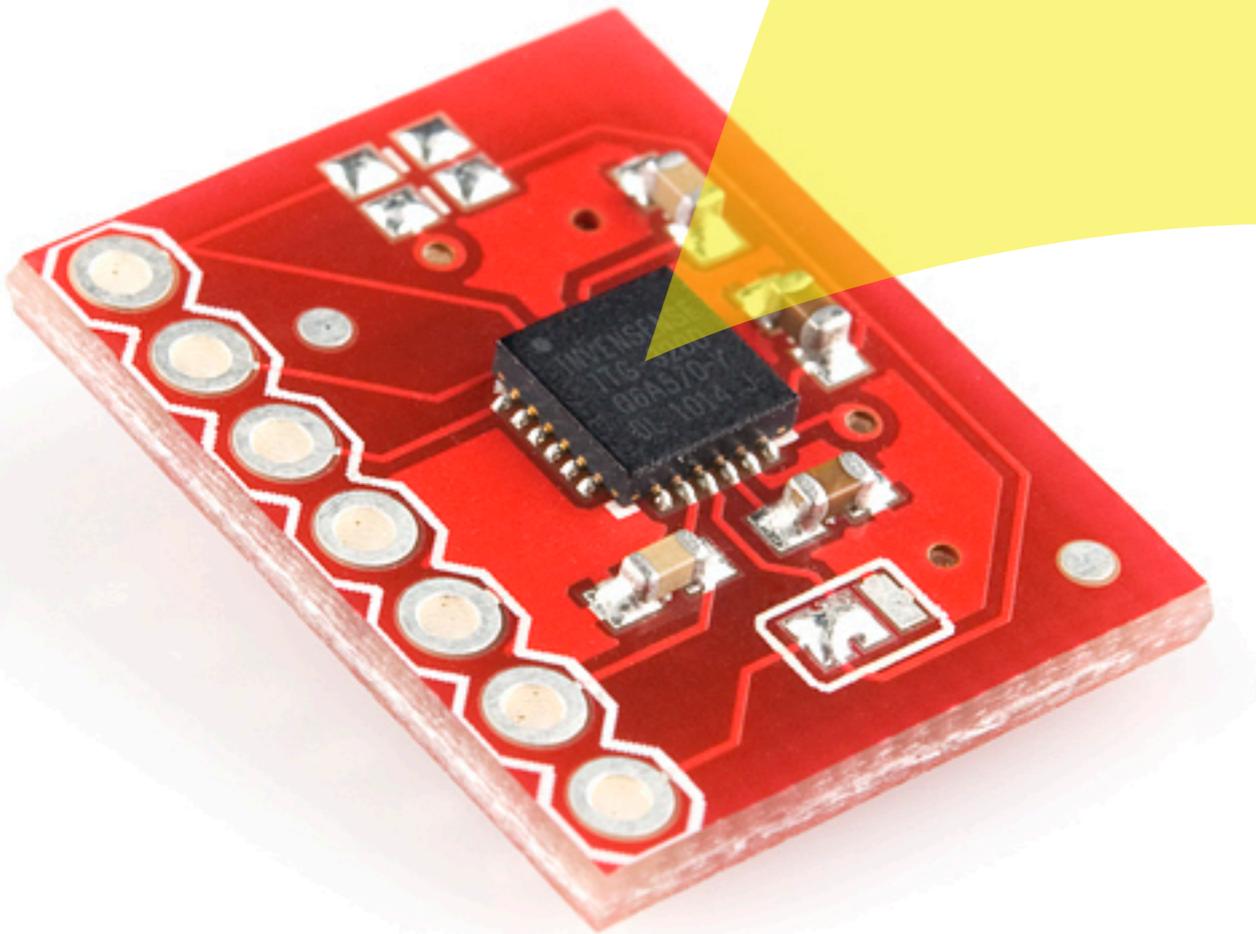
Measures acceleration and gravity



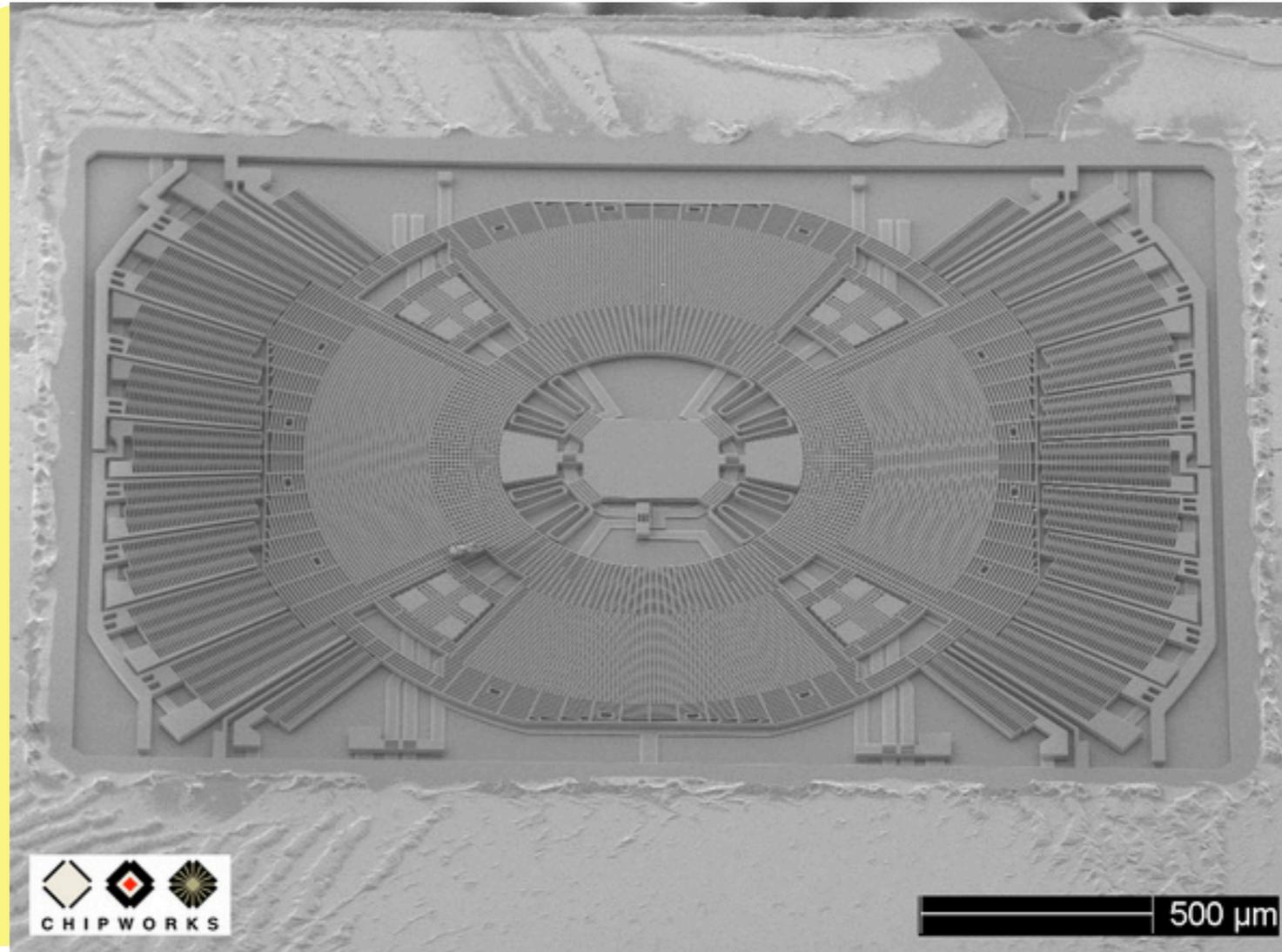
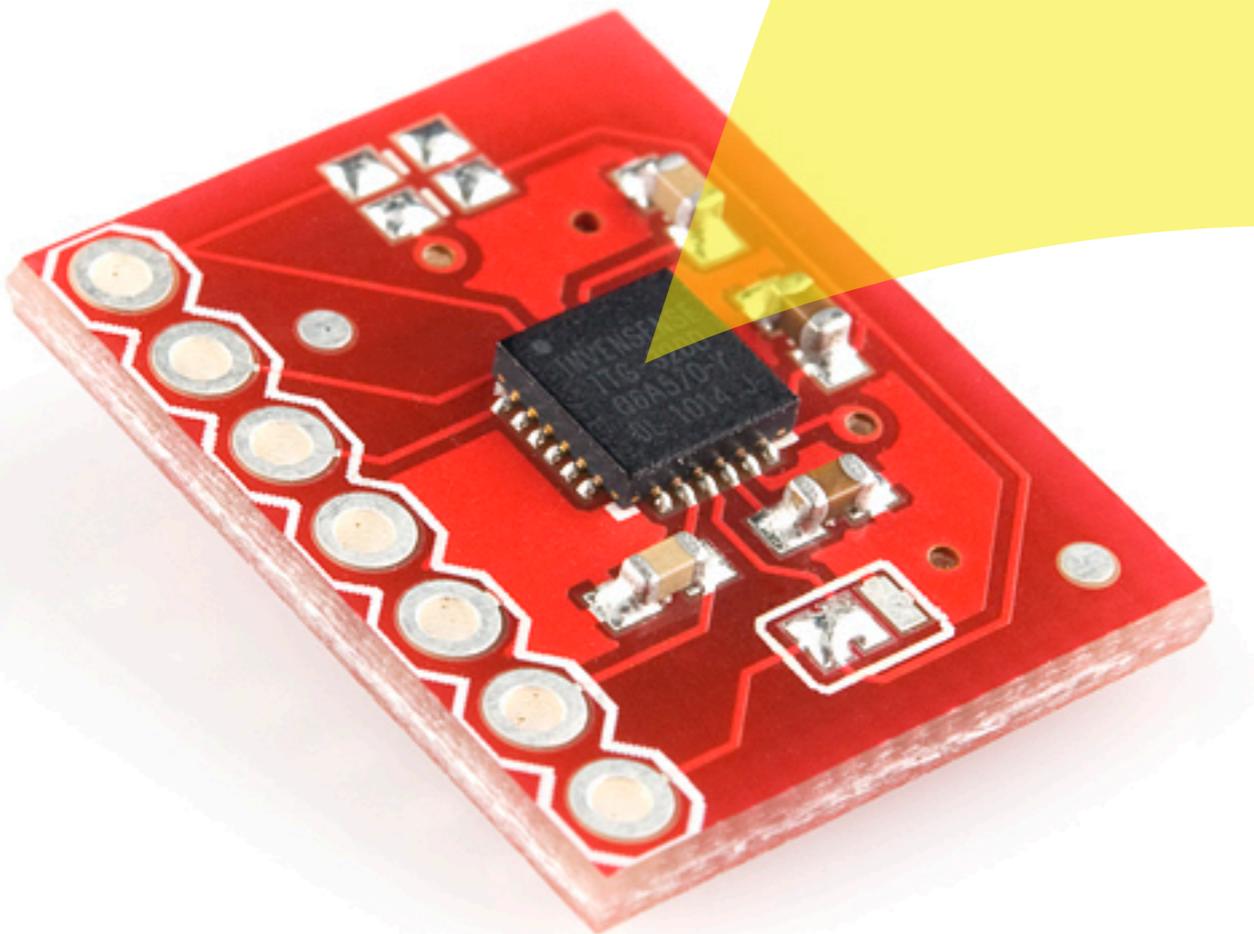
MEMS-based Rate Gyroscopes



MEMS-based Rate Gyroscopes



MEMS-based Rate Gyroscopes



Measures angular velocity

Inertial Measurement Units (IMUs)

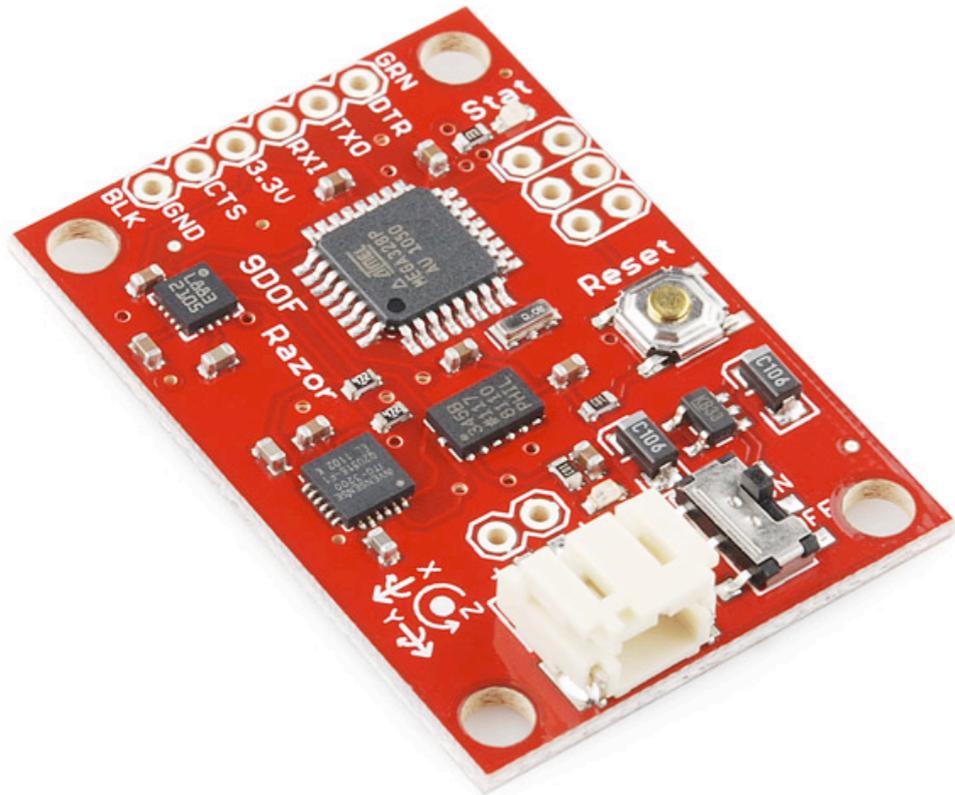
9 Degrees of Freedom on a single, flat board for \$125:

ITG-3200 - triple-axis digital-output gyroscope

ADXL345 - 13-bit resolution, $\pm 16g$, triple-axis accelerometer

HMC5883L - triple-axis, digital magnetometer

Outputs of all sensors processed by on-board ATmega328 and sent out via a serial stream



Inertial Measurement Units (IMUs)



Same sensors in a clean package with all processing and software done for you, estimates absolute heading, around \$2000?

Magnetic Tracking



Field generator creates magnetic field; small wired sensors used to estimate position and orientation of tracked item; bad interference from metal and electromagnetic actuators; price ranges from ~\$300 (Razer Hydra) to ~\$16,000 (precise, medical use).



Optical Tracking



Custom camera system with blob detection in 2D; limited by camera frame rate, processing time

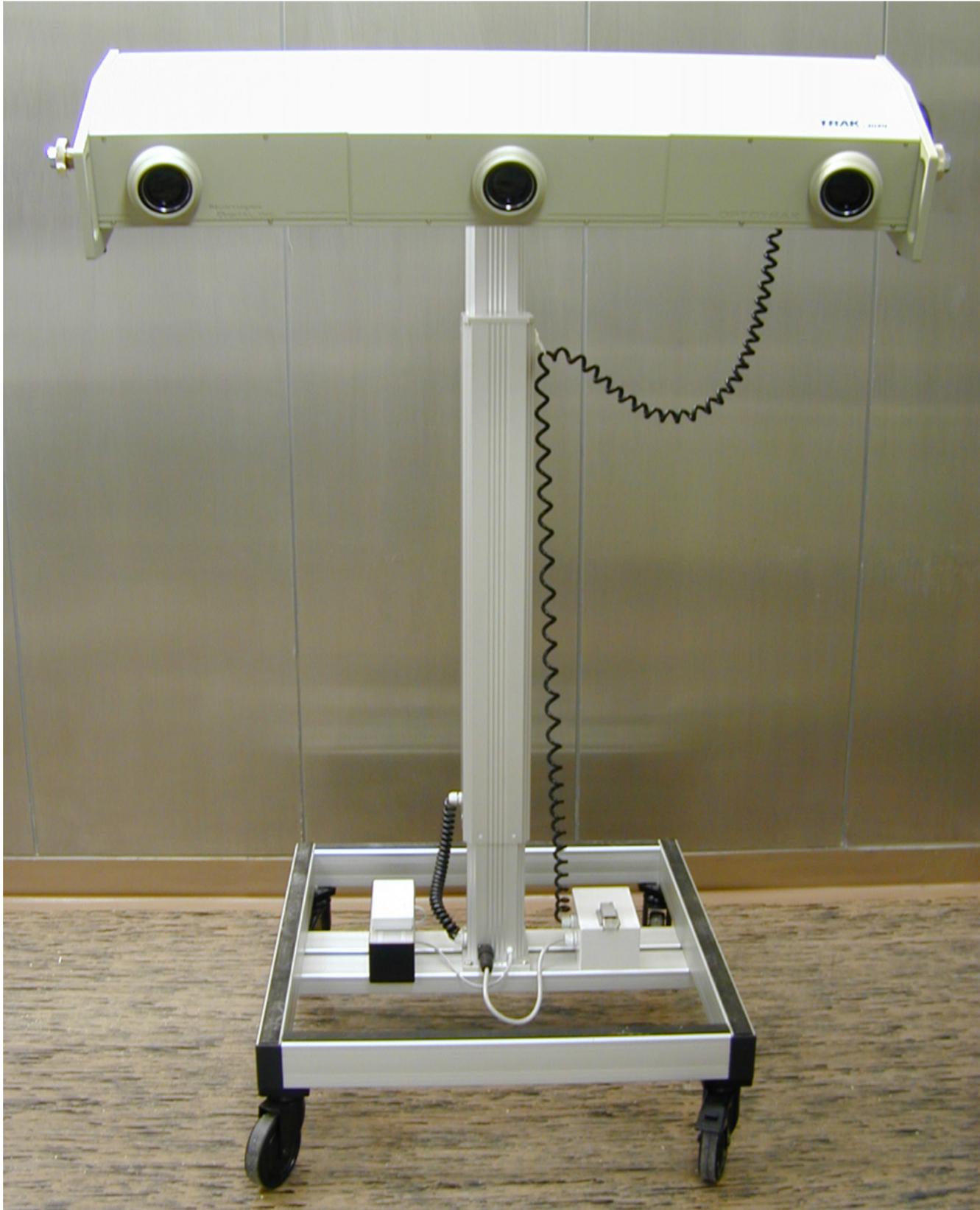


Optical Tracking



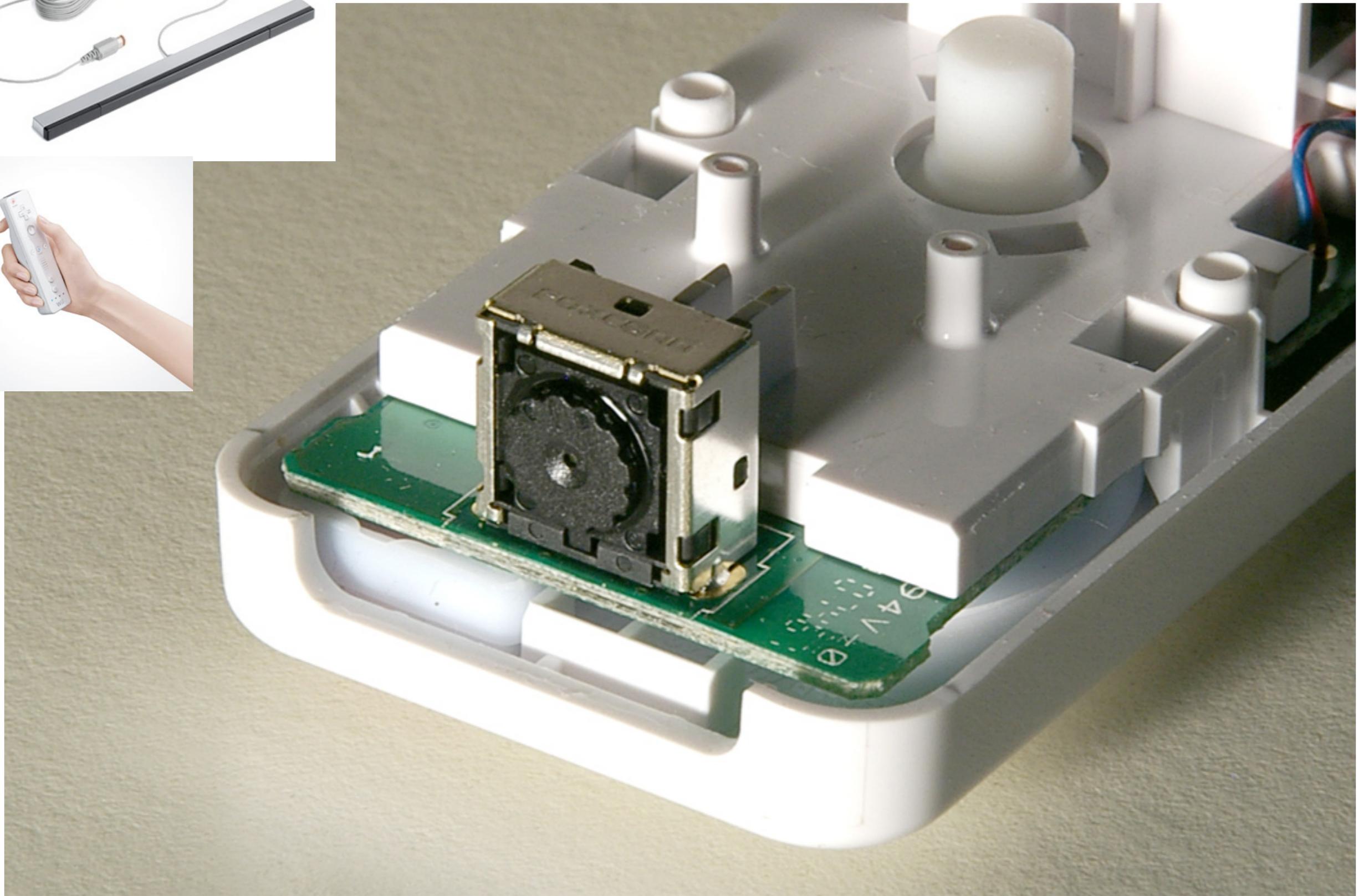
VICON system, many cameras, passive markers, >\$100k

Optical Tracking



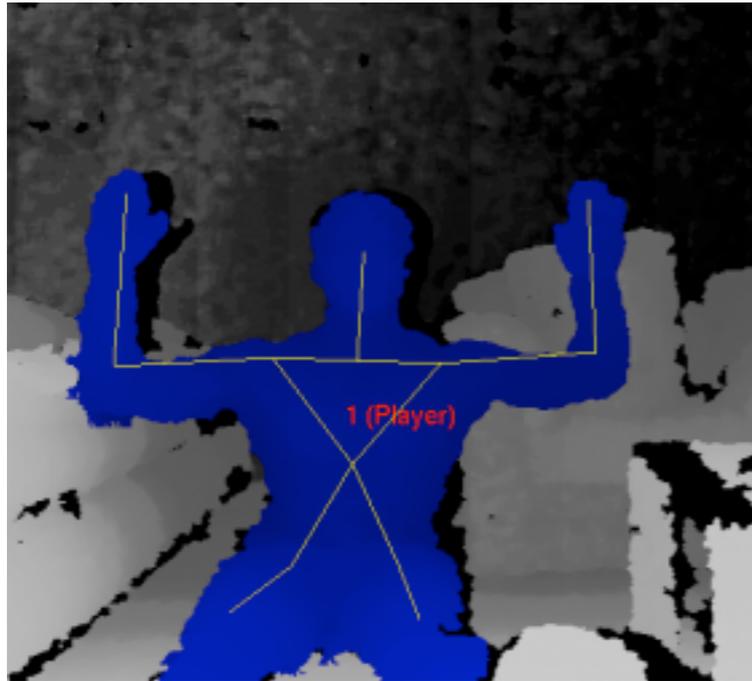
OptoTrak system: 3 cameras, active markers, ~\$50k?

Optical Tracking

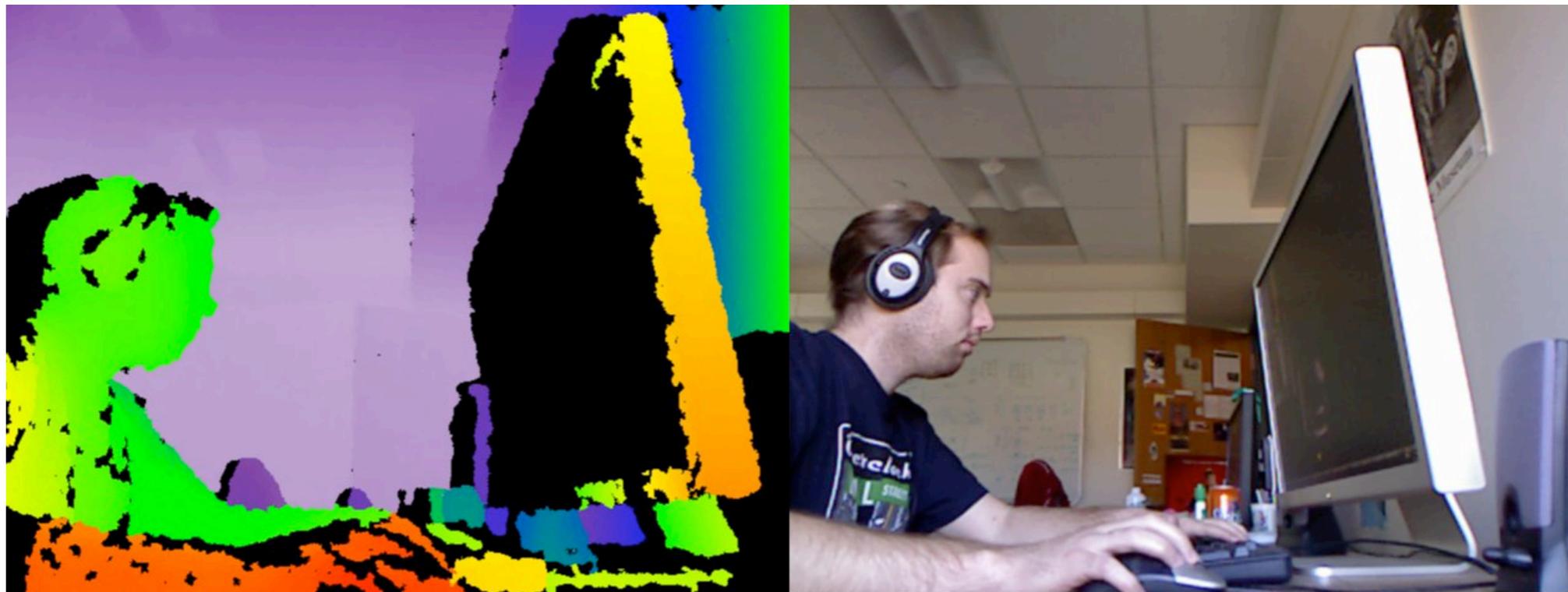


WiiMote camera: finds 4 brightest IR spots, ~\$40

Optical Tracking

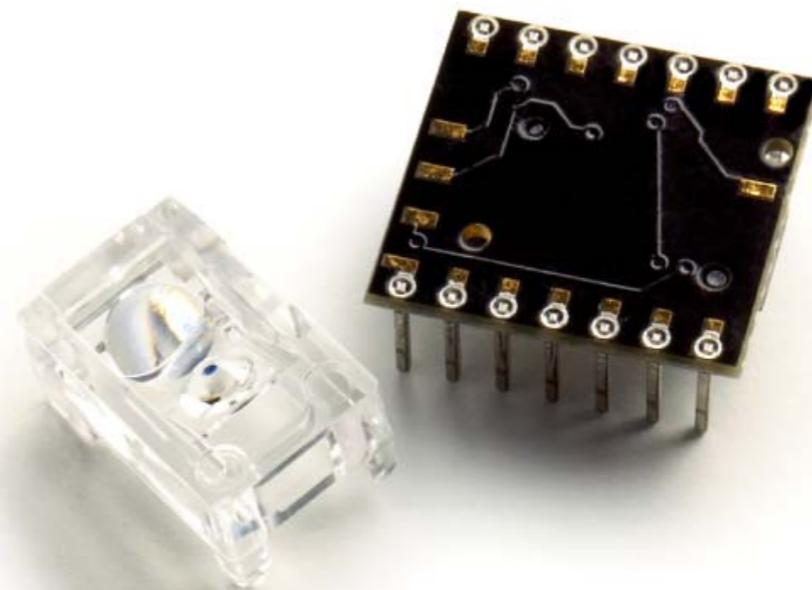
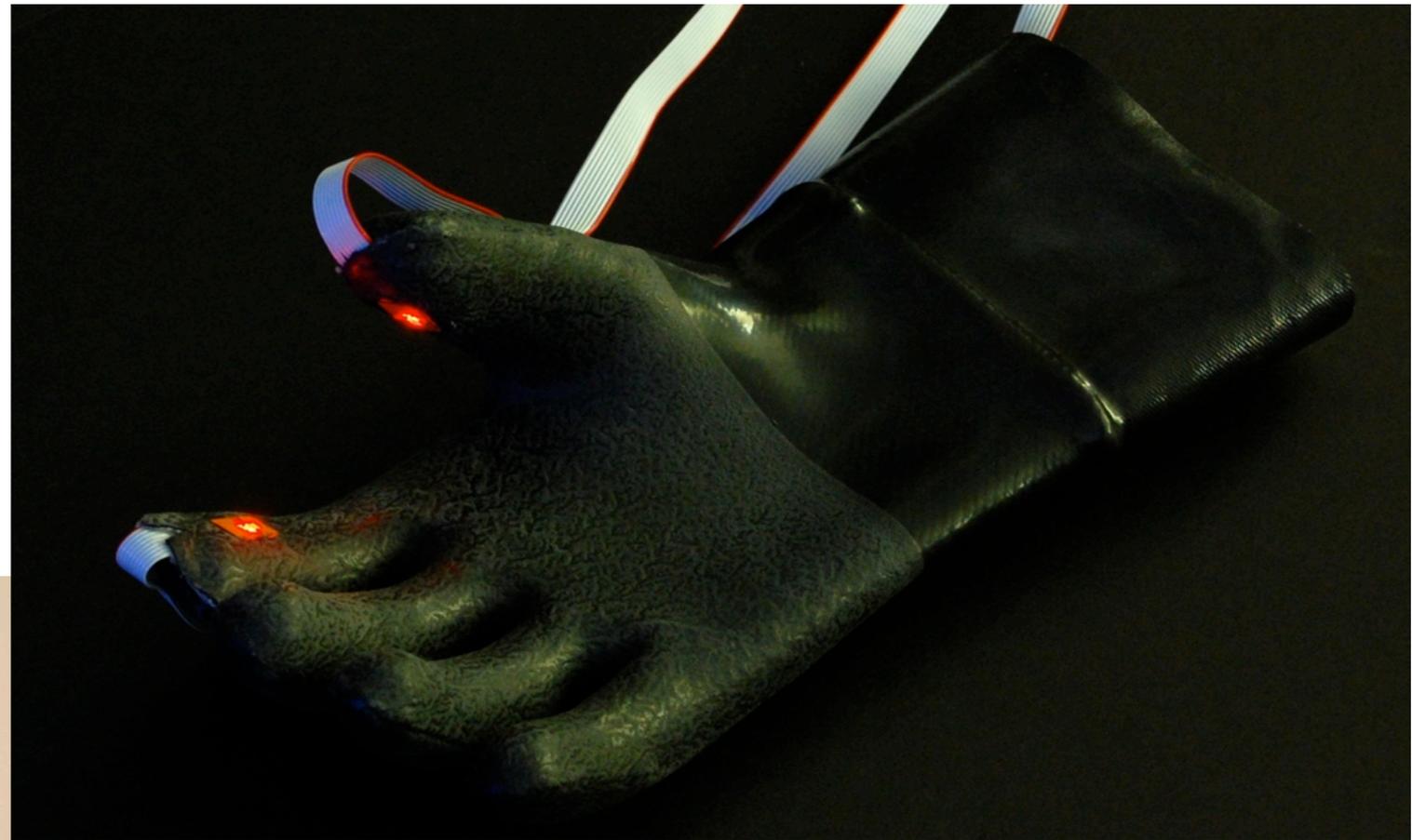
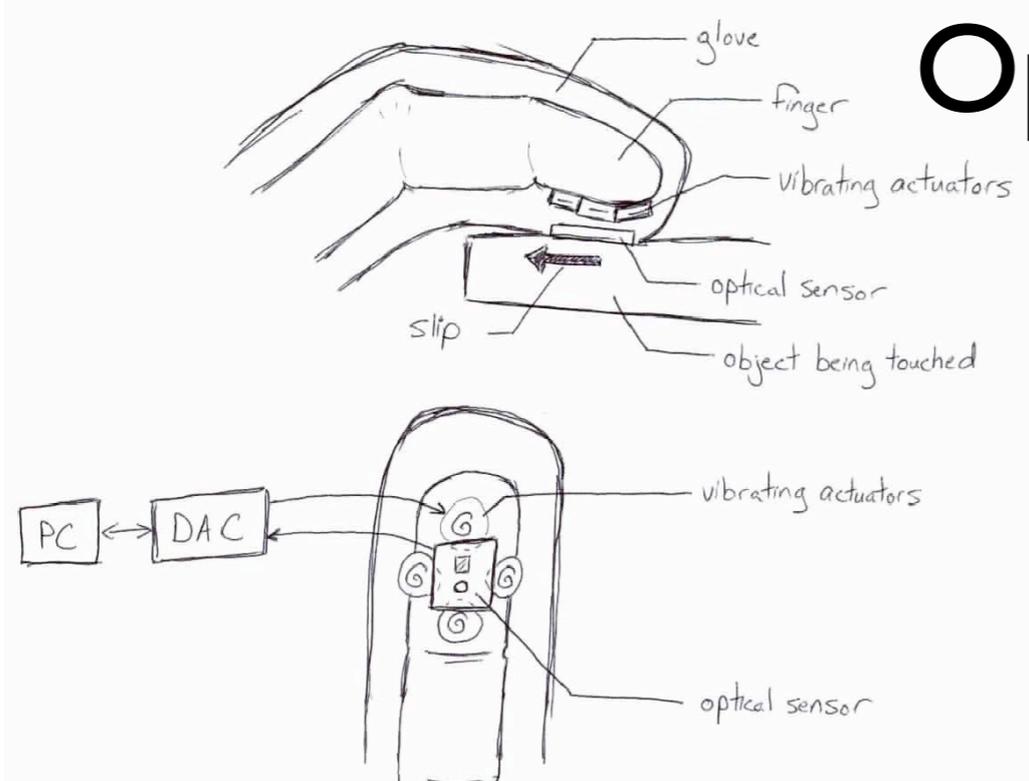


KINECT™
for  XBOX 360.



Kinect: color camera with depth, tracks humans, ~\$200

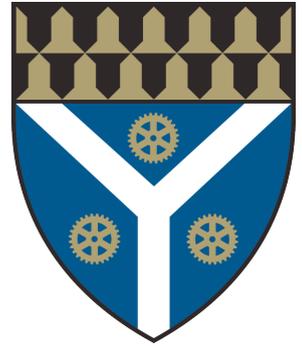
Optical Tracking



Mouse Sensor: senses optical flow in 2D, digital comm.



Sensor Videos



Video Demonstrations of Mechatronics Principles

http://video_demos.colostate.edu/mechatronics/

Video Demonstrations of Mechatronic Devices and Principles

NOTE: The video clips below are Windows Media files.
They are **best viewed using Internet Explorer** and the Windows Media Player.
Click on the icon below if you wish to download the latest free player.



- [actuators](#)
- [circuit examples](#)
- [data acquisition](#)
- [electrical components and measurements](#)
- [mechatronic system examples](#)
- [PIC microcontroller examples](#)
- [PIC microcontroller student design projects](#)
- [power transmission](#)
- [sensors](#)

See also:

- [control system demonstrations](#)
- [vibration and sound demonstrations](#) (various examples of spectra, frequency response, and sampling)
- [robotics demonstrations](#)

For more information about mechatronics and measurement systems, see:

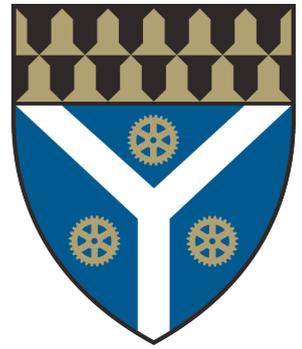
- [Introduction to Mechatronics and Measurement Systems](#)

- **actuators**
 - [ac induction motor \(single phase\)](#) (2.3 MB)
 - [ac induction motor variable frequency drive for a building air handler unit](#) (6.8 MB)
 - [ac induction motor with a soft start for a water pump](#) (1.2 MB)
 - [ac generator, motor, and load experiment](#) (6.9 MB)
 - [brushless dc motor from a computer fan](#) (1.7 MB)
 - [brushless dc motor gear pump](#) (2.5 MB)

Videos from http://video_demos.colostate.edu/mechatronics/



Sensor Videos



Video Demonstrations of Mechatronics Principles

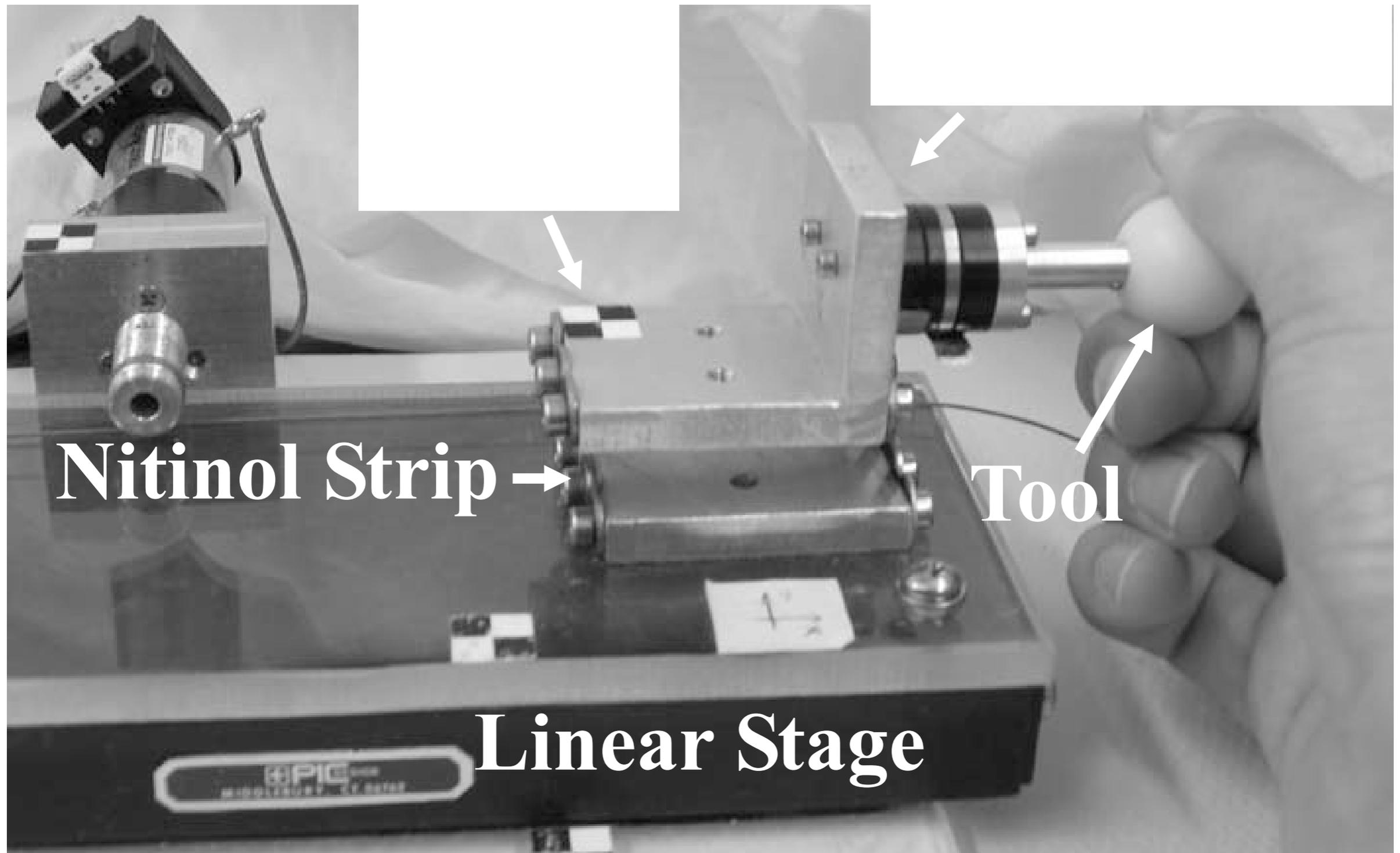
http://video_demos.colostate.edu/mechatronics/

- 158. [automobile automatic wiper and defroster](#) (2.6 MB)
- 159. [card dealer](#) (4.5 MB)
- 160. [alarm clock](#) (2.5 MB)
- 161. [automated ice-fishing pole](#) (2.7 MB)
- 162. [submersible temperature and pressure sensor apparatus](#) (3.9 MB)
- 163. [motor indexer](#) (1.4 MB)

- **power transmission**
 - [high voltage power transmission line cables and connectors](#) (2.2 MB)
 - [high voltage disconnect switch](#) (0.6 MB)
 - power station transformer fire (photos [during](#), [close-up](#), and [after](#))
 - [zapped squirrel](#) (and [stupid man](#))
- **sensors**
 - [accelerometer bearing signature analysis experiment](#) (3.3 MB)
 - [bouncing ball accelerometer](#) (0.7 MB)
 - [computer mouse relative encoder](#) (1.0 MB)
 - [EMG sensor used to control a robot](#) (6.0 MB)
 - [encoder components](#) (1.8 MB)
 - [infrared proximity sensor used in an automated laboratory rat exercise machine](#) (8.0 MB)
 - [inkjet printer components with custom digital encoders](#) (6.8 MB)
 - [LVDT principles of operation](#)
 - [magnetic pickup tachometer used in a PID speed controller test-stand](#) (4.0 MB)
 - [magnetostrictive position sensor](#) (0.8 MB)
 - [robot digital encoder components](#) (4.3 MB)
 - see also: [Adept One robot internal design and construction](#) (4.6 MB)
 - [strain gage rosette experiment](#) (2.4 MB)
 - [strain gage rosette experiment analysis discussion](#) (10.3 MB)
 - [PDF file containing analysis summary](#)
 - [switches](#) (1.6 MB)
 - [switch bounce](#) (0.8 MB)
 - [thermocouple with a digital thermometer](#) (4.5 MB)
 - [thermostat with bimetallic strips and mercury switch](#) (2.3 MB)
 - [voice coil](#) (1.1 MB)

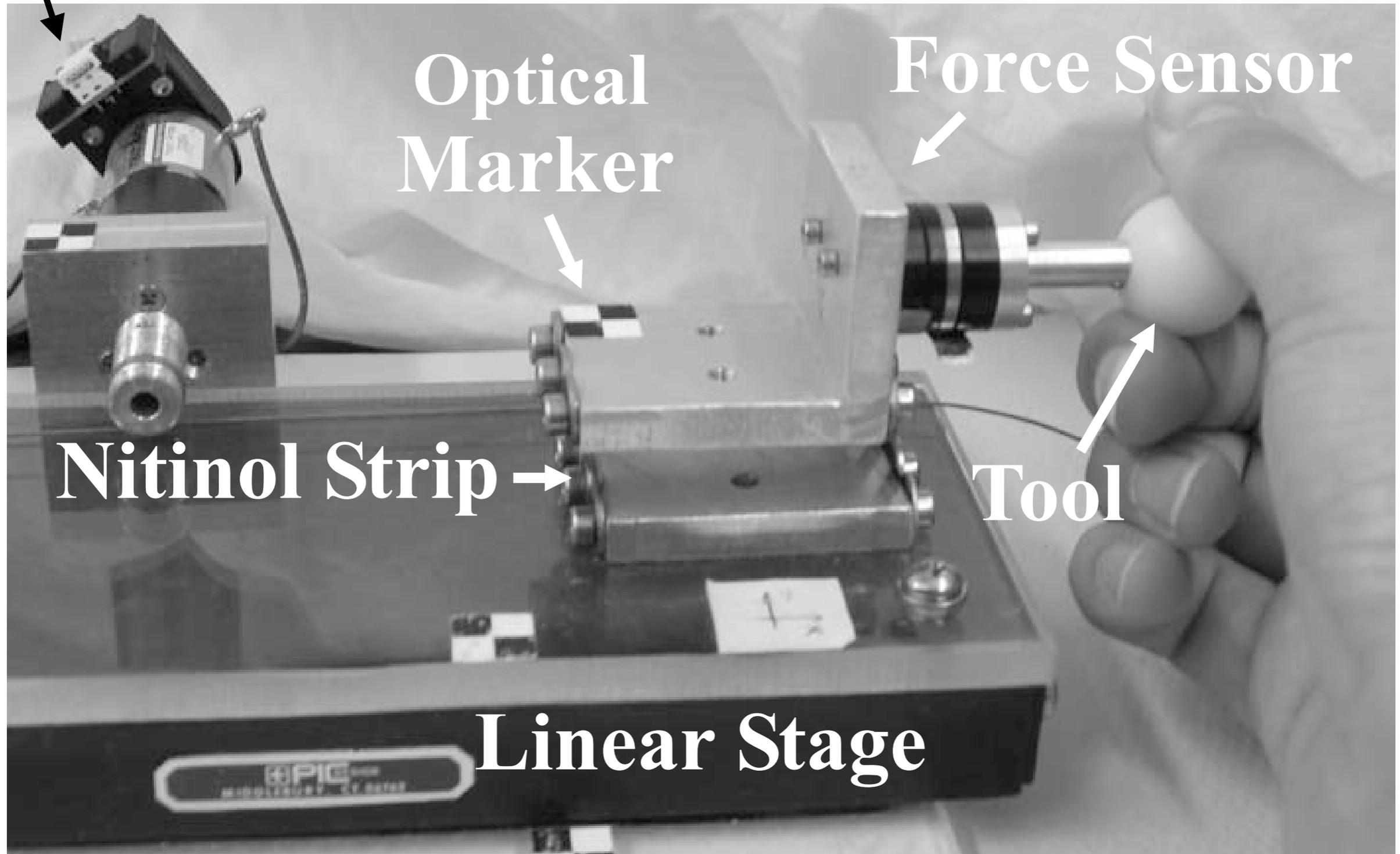
Videos from http://video_demos.colostate.edu/mechatronics/

Quick Quiz What sensors do you see?



Quick Quiz What sensors do you see?

Encoder



Any other types of sensors you are wondering about?

Sensor Processing

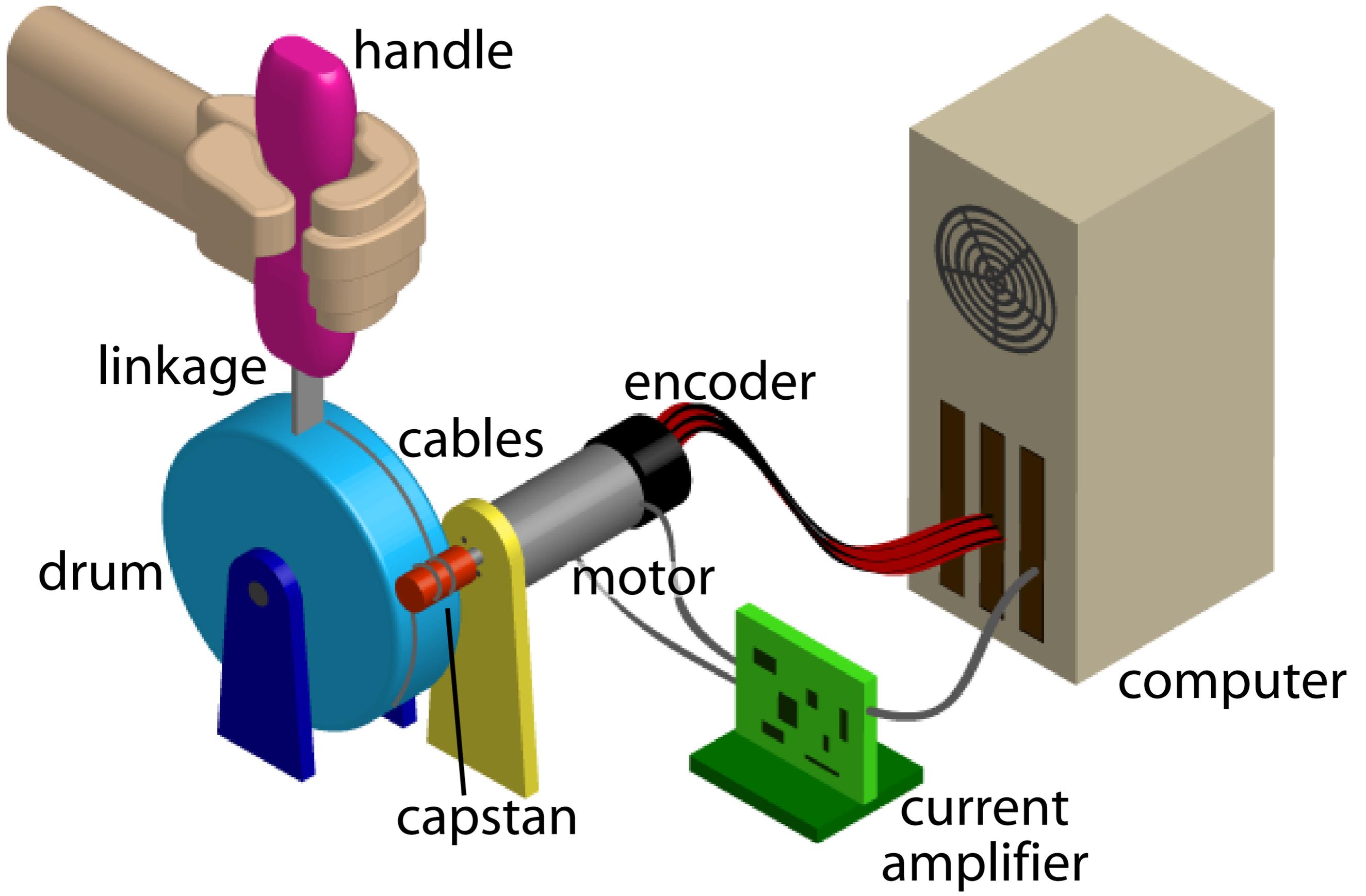


Illustration from K. J. Kuchenbecker and G. Niemeyer, "Induced Master Motion in Force-Reflecting Teleoperation." ASME Journal of Dynamic Systems, Measurement, and Control. Volume 128(4):800-810, December 2006.

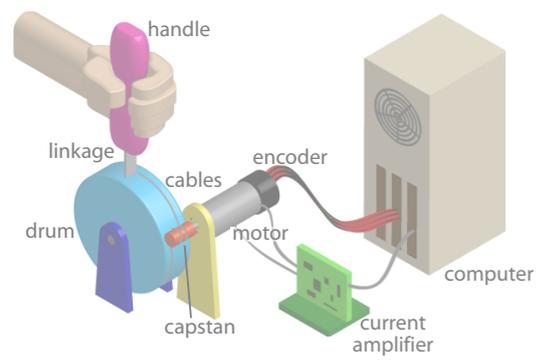
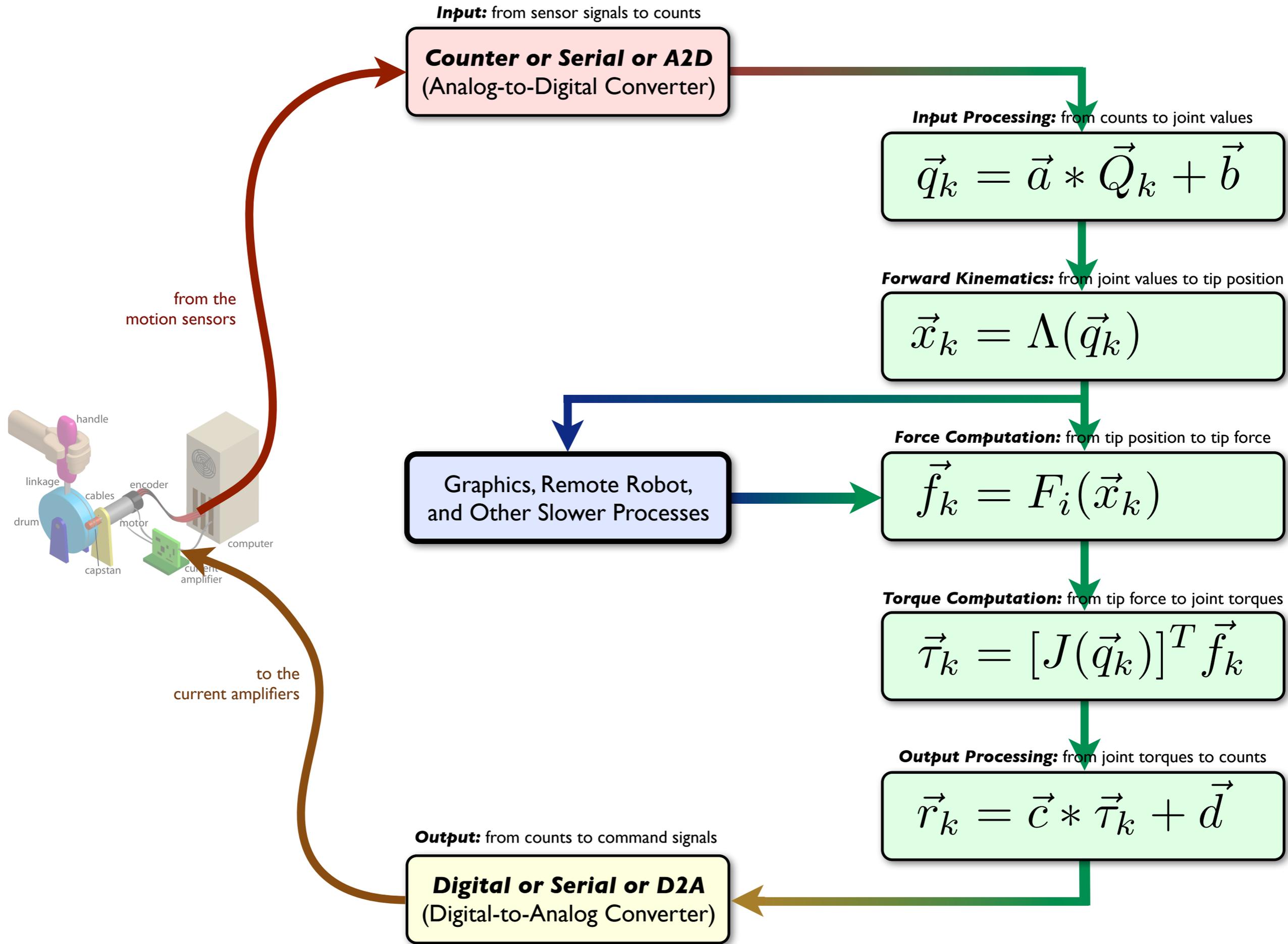


Illustration from K. J. Kuchenbecker and G. Niemeyer, "Induced Master Motion in Force-Reflecting Teleoperation." ASME Journal of Dynamic Systems, Measurement, and Control. Volume 128(4):800-810, December 2006.

Typical Software Configuration





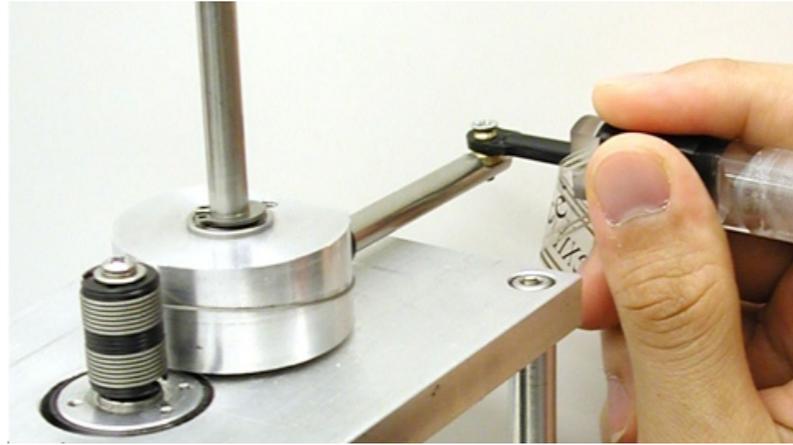
D/A and A/D

- Converts between voltages and counts
- Computer stores information digitally, and communicates with the outside world using signed voltage signals
 - e.g., for 8-bit 0-5V ADC
 $2.5V = 10000000$

MSB LSB

Decimal	Binary	Hexadecimal
0	0000	0
1	0001	1
2	0010	2
3	0011	3
4	0100	4
5	0101	5
6	0110	6
7	0111	7
8	1000	8
9	1001	9
10	1010	A
11	1011	B
12	1100	C
13	1101	D
14	1110	E
15	1111	F

Input Processing Steps

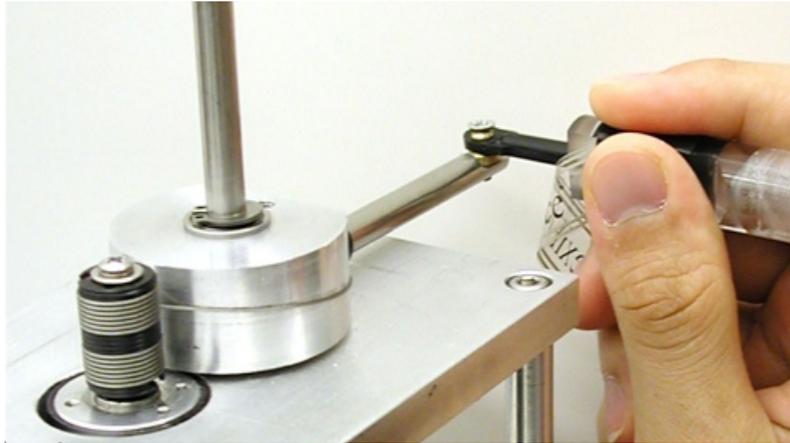


Input Processing Steps



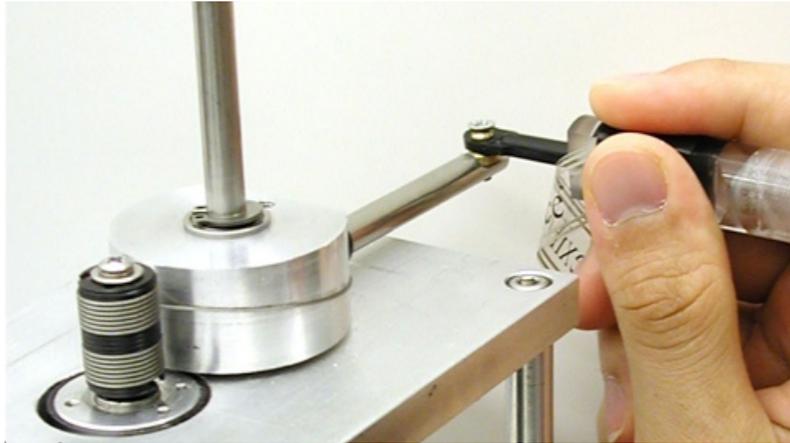
- Get counts Q_j from encoder counters, serial communications, or analog-to-digital conversions.

Input Processing Steps



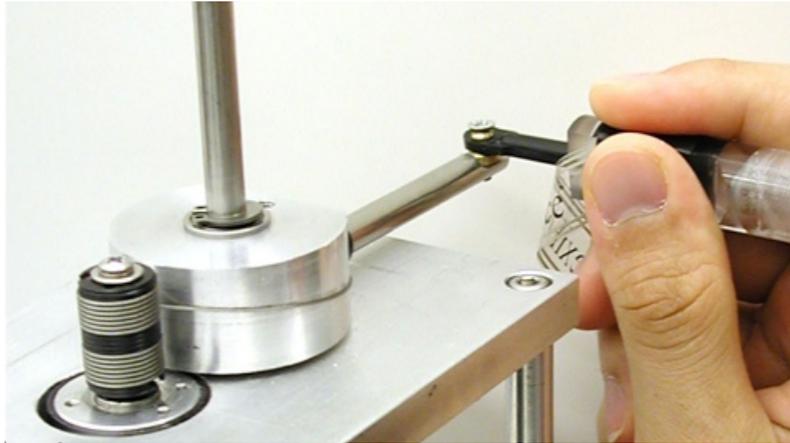
- Get counts Q_j from encoder counters, serial communications, or analog-to-digital conversions.
- Convert counts to sensor shaft angles θ_{sj} or sensor displacements d_{sj} using knowledge of the sensor's characteristics.

Input Processing Steps



- Get counts Q_j from encoder counters, serial communications, or analog-to-digital conversions.
- Convert counts to sensor shaft angles θ_{sj} or sensor displacements d_{sj} using knowledge of the sensor's characteristics.
- Convert sensor angles to joint coordinates q_j (joint angles θ_j or joint displacements d_j) using the gear ratio. In this process, use a negative sign to flip the joint angle direction if desired.

Input Processing Steps



Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

- Get counts Q_j from encoder counters, serial communications, or analog-to-digital conversions.
- Convert counts to sensor shaft angles θ_{sj} or sensor displacements d_{sj} using knowledge of the sensor's characteristics.
- Convert sensor angles to joint coordinates q_j (joint angles θ_j or joint displacements d_j) using the gear ratio. In this process, use a negative sign to flip the joint angle direction if desired.

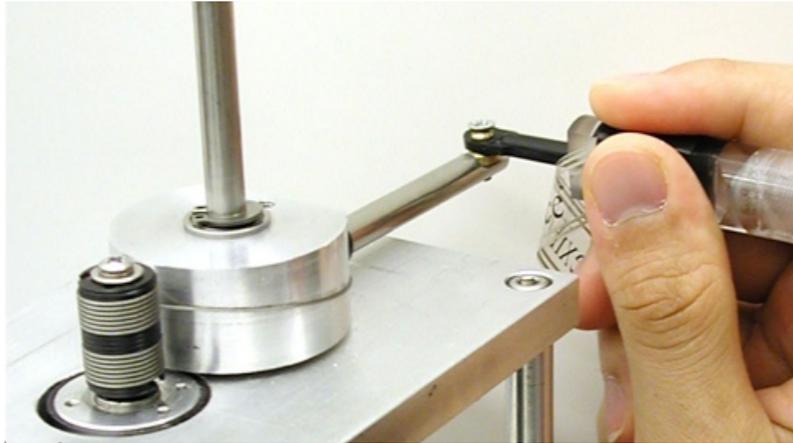
Input Processing Steps



Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

Input Processing Steps

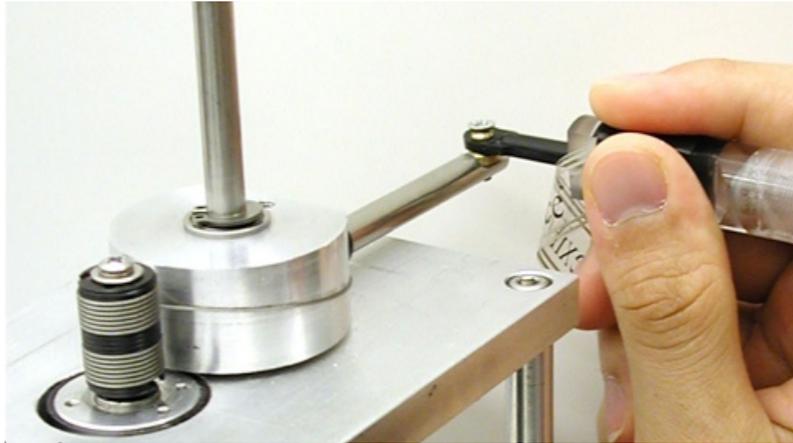


Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

- Check your work along the way.

Input Processing Steps

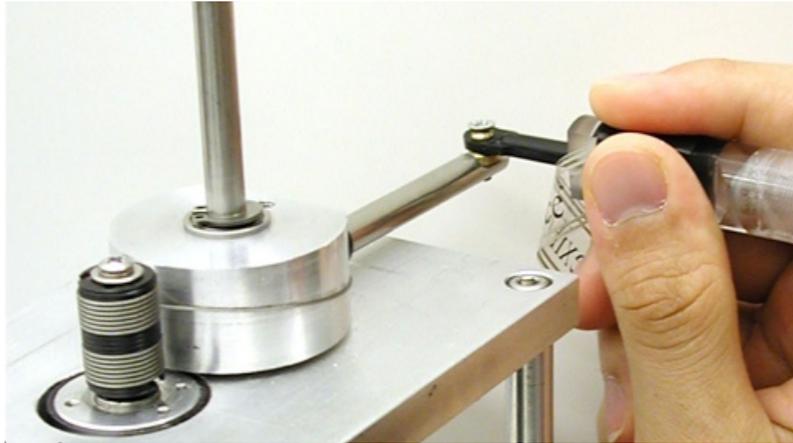


Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

- Check your work along the way.
- How?

Input Processing Steps

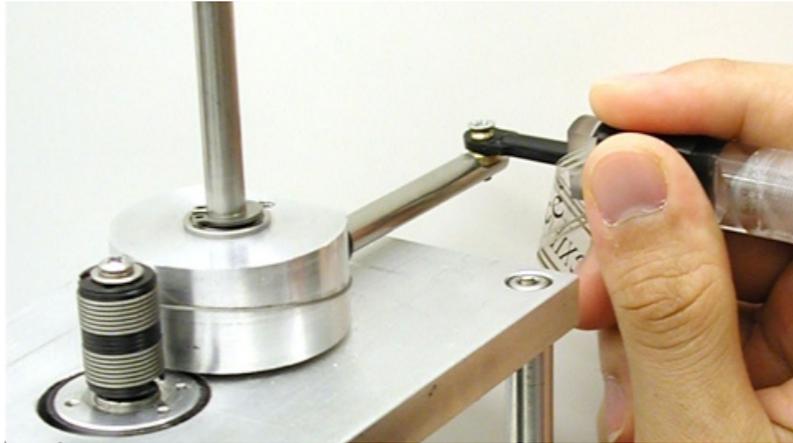


Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

- Check your work along the way.
- How?
 - Units

Input Processing Steps

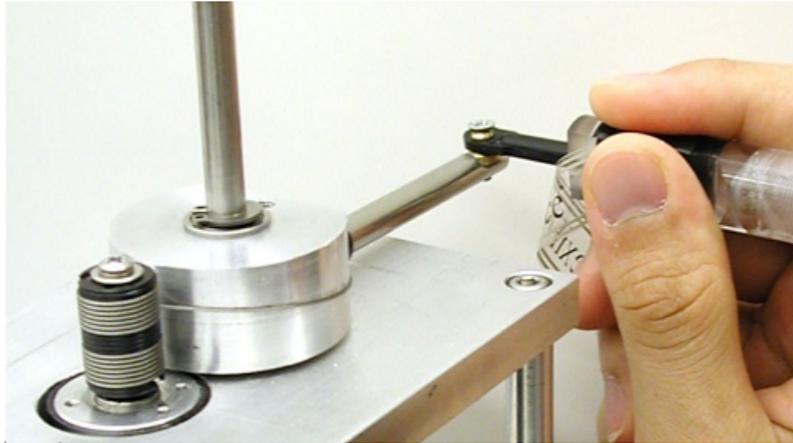


Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

- Check your work along the way.
- How?
 - Units
 - Known configurations

Input Processing Steps

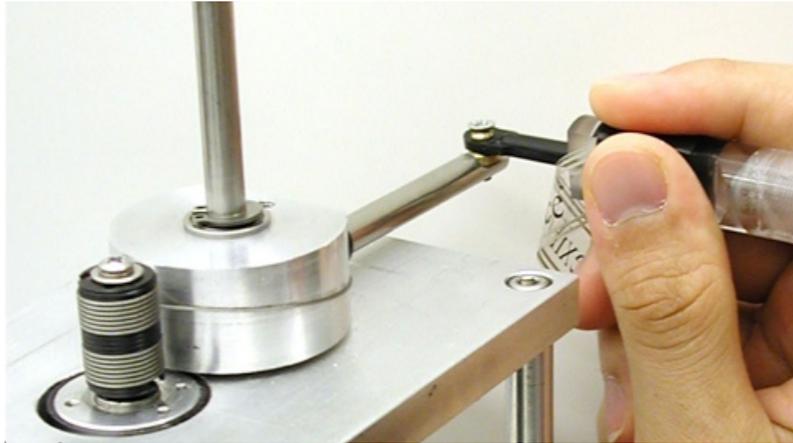


Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

- Check your work along the way.
- How?
 - Units
 - Known configurations
 - Ranges

Input Processing Steps

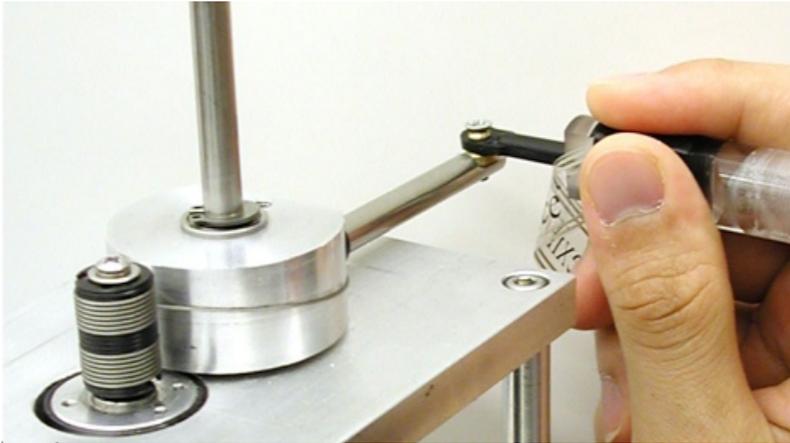


Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

- Check your work along the way.
- How?
 - Units
 - Known configurations
 - Ranges
 - Record and graph

Input Processing Steps



Input Processing: from counts to joint values

$$\vec{q}_k = \vec{a} * \vec{Q}_k + \vec{b}$$

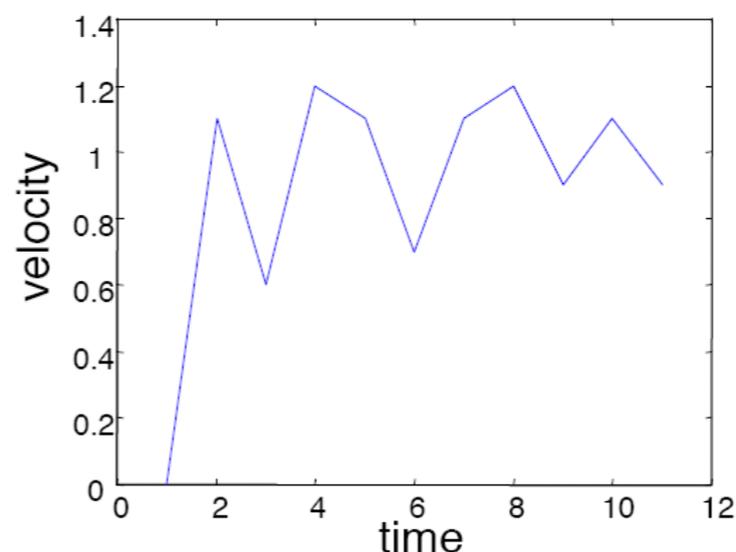
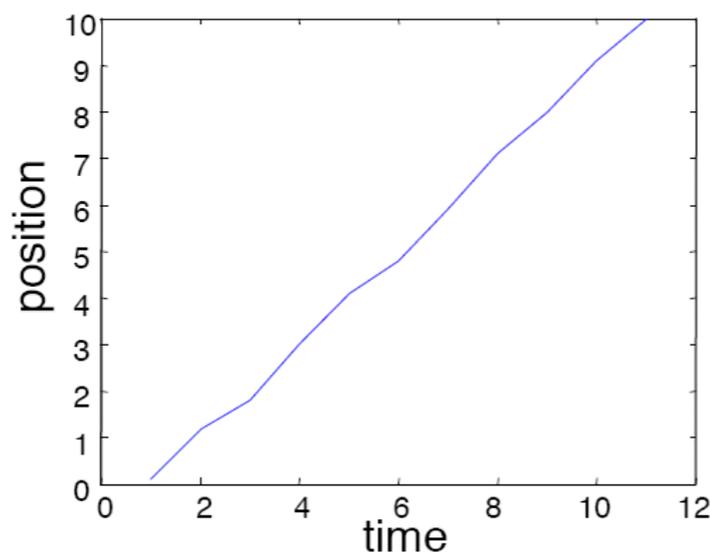
- Check your work along the way.
- How?
 - Units
 - Known configurations
 - Ranges
 - Record and graph
- Check *before* you use the movement information to output forces.



Digital differentiation

- Many different methods
- Simple Example:
 - Position reading at time 1 = P1
 - Position reading at time 2 = P2
 - t is the period of the servo loop (in sec. or counts)
 - The position is typically sampled on a fixed interval
- Differentiation increases noise

$$V = \frac{P2 - P1}{t}$$





Noisy Velocity readings

- Noise on velocity signal can create jitter on your haptic device when your controller has velocity feedback (virtual damping)
- Common solutions
 - Use a Tach/Generator
 - Voltage goes with speed (same source as back-EMF)
 - Resolution is set by your A/D converter
 - Integrate the signal from an accelerometer
 - Measure time per tick rather than ticks per time
 - Use a special chip that measures time between ticks
 - Especially good to do at slow speeds
 - Fares poorly at high velocities
 - Filtering (conventional to smooth or Kalman filtering to combine sensor signals)

Calculating Velocity

Calculating Velocity

```
/**
```

```
hapticCallback()
```

```
Main callback that sets the force that the user will feel. It gets the current position and velocity of the device.
```

```
This is what you want to edit to change the system's haptic feedback.
```

```
*/
```

```
HDCallbackCode HDCALLBACK hapticCallback(void *data)
```

```
{
```

```
    // Local variables.
```

```
    hduVector3Dd position;
```

```
    hduVector3Dd velocity;
```

```
    hduVector3Dd force;
```

```
    hduVector3Dd extraForce;
```

```
    hduVector3Dd proxyPosition;
```

```
    HDint currentButtonState;
```

```
    HDint lastButtonState;
```

```
    double stiffness = 0.25; // Units are newtons per millimeter.
```

Calculating Velocity

```
/******
```

```
hapticCallback()
```

Main callback that sets the force that the user will feel. It gets the current position and velocity of the device.

This is what you want to edit to change the system's haptic feedback.

```
*****/
```

```
HDCallbackCode HDCALLBACK hapticCallback(void *data)
```

```
{
```

```
    // Local variables.
```

```
    hduVector3Dd position;
```

```
    hduVector3Dd velocity;
```

```
    hduVector3Dd force;
```

```
    hduVector3Dd extraForce;
```

```
    hduVector3Dd proxyPosition;
```

```
    HDint currentButtonState;
```

```
    HDint lastButtonState;
```

```
    double stiffness = 0.25; // Units are newtons per millimeter.
```

```
    // Local variables for custom velocity calculation.
```

```
    static bool firstTime = true;
```

```
    static hduVector3Dd lastPosition; // mm
```

```
    hduVector3Dd rawVelocity; // mm/s
```

```
    static hduVector3Dd filteredVelocity(0.0, 0.0, 0.0); // mm/s
```

```
    float filterWeight = 0.03;
```

```
    float dampingCoefficient = 0.01; // N/(mm/s)
```

```
    hduVector3Dd dampingForce; // N
```

Calculating Velocity

```
// Local variables for custom velocity calculation.
static bool firstTime = true;
static hduVector3Dd lastPosition; // mm
hduVector3Dd rawVelocity; // mm/s
static hduVector3Dd filteredVelocity(0.0, 0.0, 0.0); // mm/s
float filterWeight = 0.03;
float dampingCoefficient = 0.01; // N/(mm/s)
hduVector3Dd dampingForce; // N

// Get the handle for the current haptic device.
HHD hHD = hdGetCurrentDevice();

// Begin the haptic frame for this device.
hdBeginFrame(hHD);

// Get its position and velocity and store them in hduVector3Dd variables.
hdGetDoublev(HD_CURRENT_POSITION, position); // Units are millimeters.
hdGetDoublev(HD_CURRENT_VELOCITY, velocity); // Units are millimeters per second.

// Fill lastPosition with current position if this is the first function call.
if (firstTime) {
    lastPosition = position;
    firstTime = false;
}

// Calculate the raw velocity from this position and lastPosition.
rawVelocity = (position - lastPosition) / DELTAT;

// Low-pass filter this raw velocity signal using a first-order IIR filter.
filteredVelocity = filterWeight * rawVelocity + (1 - filterWeight) * filteredVelocity;
```

Calculating Velocity

```
hdGetDoublev(HD_CURRENT_POSITION, position); // Units are millimeters.
hdGetDoublev(HD_CURRENT_VELOCITY, velocity); // Units are millimeters per second.

// Fill lastPosition with current position if this is the first function call.
if (firstTime) {
    lastPosition = position;
    firstTime = false;
}

// Calculate the raw velocity from this position and lastPosition.
rawVelocity = (position - lastPosition) / DELTAT;

// Low-pass filter this raw velocity signal using a first-order IIR filter.
filteredVelocity = filterWeight * rawVelocity + (1 - filterWeight) * filteredVelocity;

// Store current position as lastPosition for next time.
lastPosition = position;

// Use the custom filtered velocity rather than SensAble's velocity?
// Comment out this line if you want to use the standard velocity.
velocity = filteredVelocity;

// Compute an extra damping force to add to the force the user feels,
// just so you can test the velocity.
dampingForce = -dampingCoefficient * velocity;

// Other code....

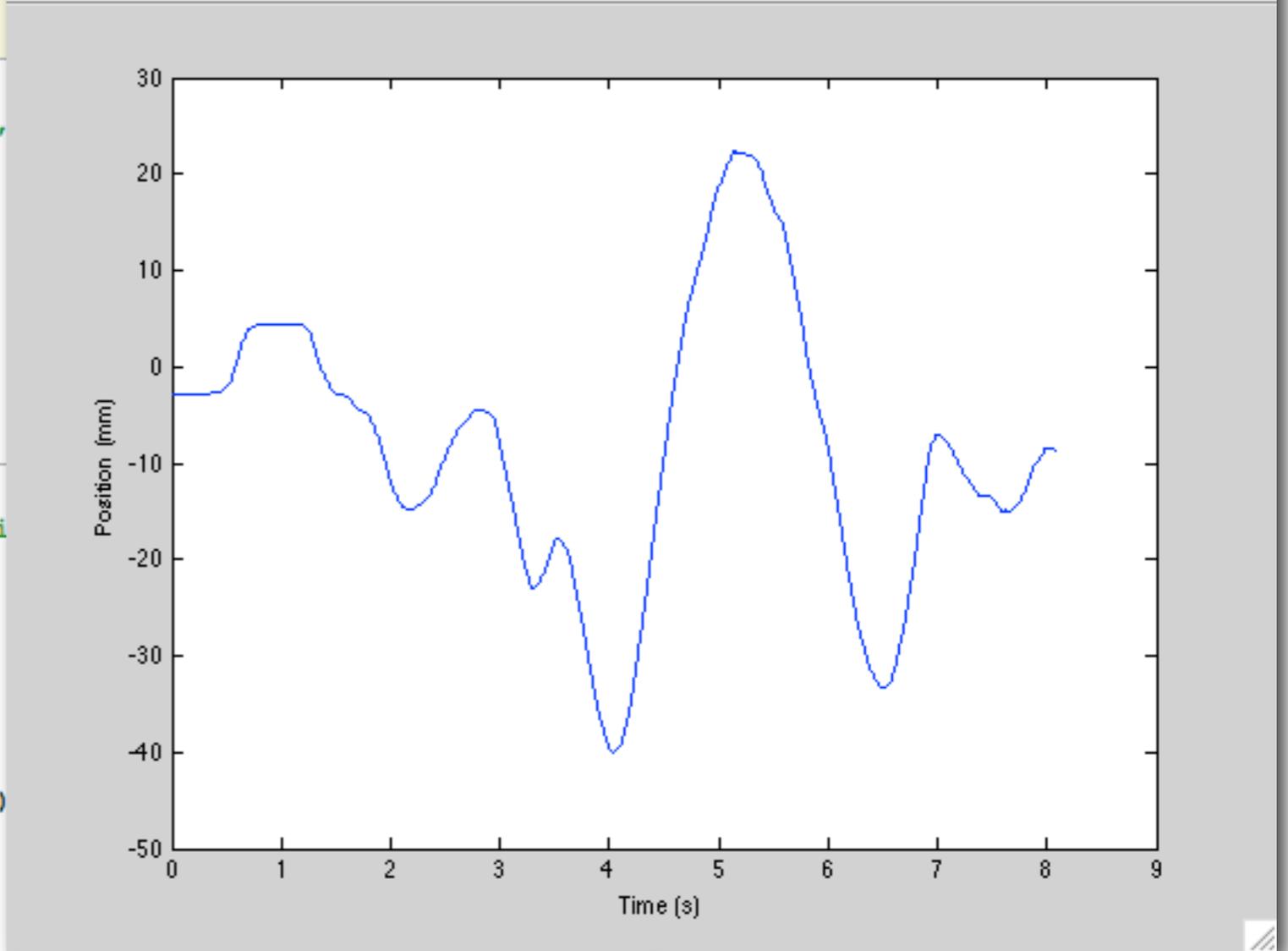
// Compute the force.
force = stiffness * (proxyPosition - position) + dampingForce + extraForce;
```

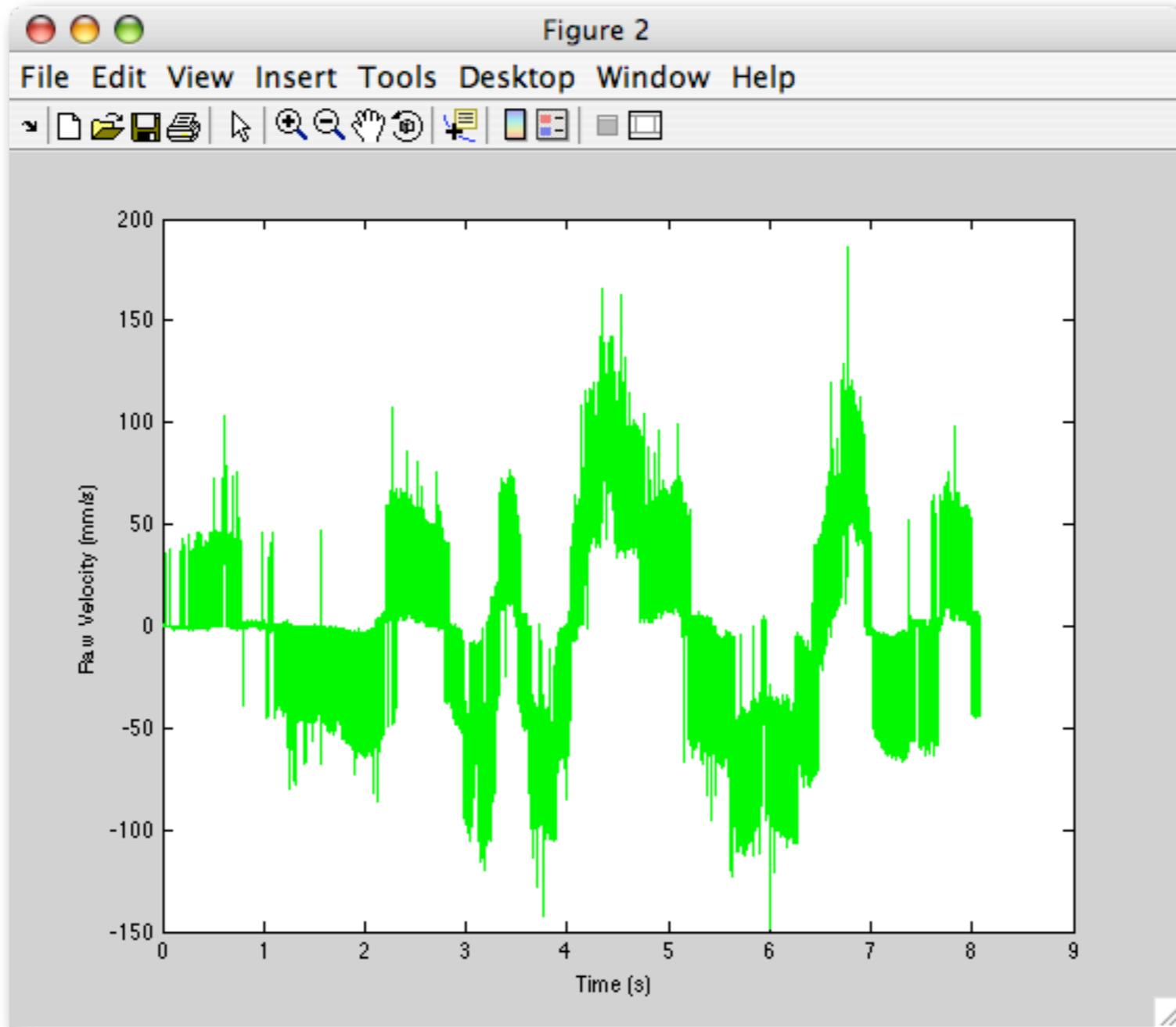
$$v_{smooth}(k) = w \cdot v_{raw}(k) + (1 - w) \cdot v_{smooth}(k - 1)$$

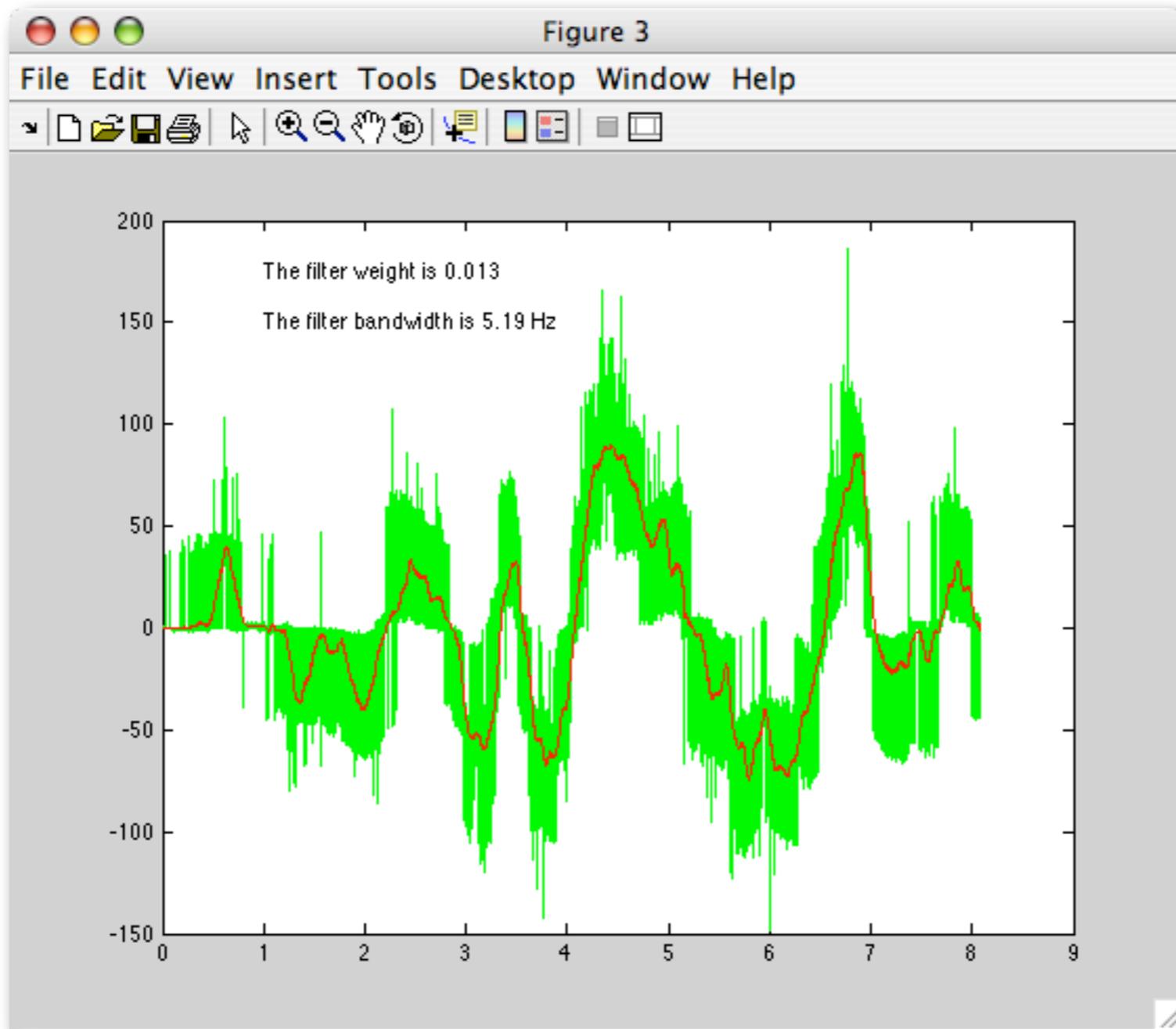


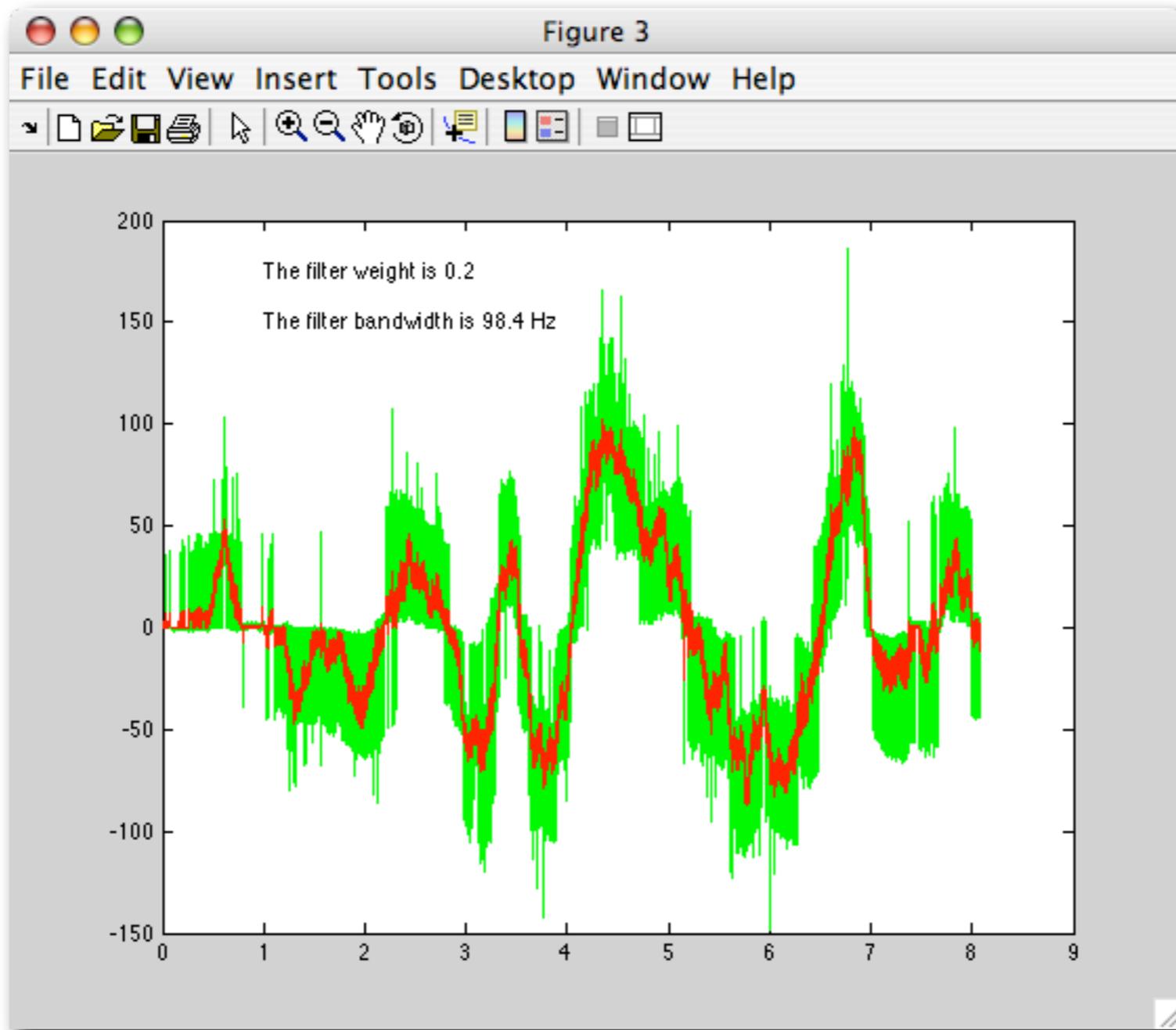
```
1 %% Clear workspace, load data, and plot position over time.
2 clear;
3
4 load data;
5
6 % Plot position over time.
7 figure(1)
8 plot(t,x,'b');
9 xlabel('Time (s)')
10 ylabel('Position (mm)')
11
12 %% Calculate raw velocity.
13
14 % Step through the vector and calculate raw velocity,
15 % being done in real time.
16 vraw = zeros(length(x),1);
17 for i = 2:length(x)
18     vraw(i) = (x(i) - x(i-1)) / (t(i) - t(i-1));
19 end
20
21 % Plot raw velocity over time.
22 figure(2)
23 plot(t(2:end),vraw(2:end),'g')
24 xlabel('Time (s)')
25 ylabel('Raw Velocity (mm/s)')
26
27 %% Compute smoothed velocity.
28
29 % Step through the vector and calculate smooth veloci
30 % being done in real time.
31 w = 0.01;
32 vsmooth = zeros(length(x),1);
33 for i = 2:length(vraw)
34     vsmooth(i) = w*vraw(i) + (1-w) * vsmooth(i-1);
35 end
36
37 % Plot raw and smoothed velocities over time.
38 figure(3)
39 plot(t(2:end),vraw(2:end),'g',t(2:end),vsmooth(2:end))
40
41 % Compute filter bandwidth.
42 T = mean(diff(t));
43 lambda = w / (T - w*T);
44
45 fc = lambda / (2*pi);
46 text(1,175,sprintf('The filter weight is %0.4g',w))
47 text(1,150,sprintf('The filter bandwidth is %0.3g Hz',fc))
```

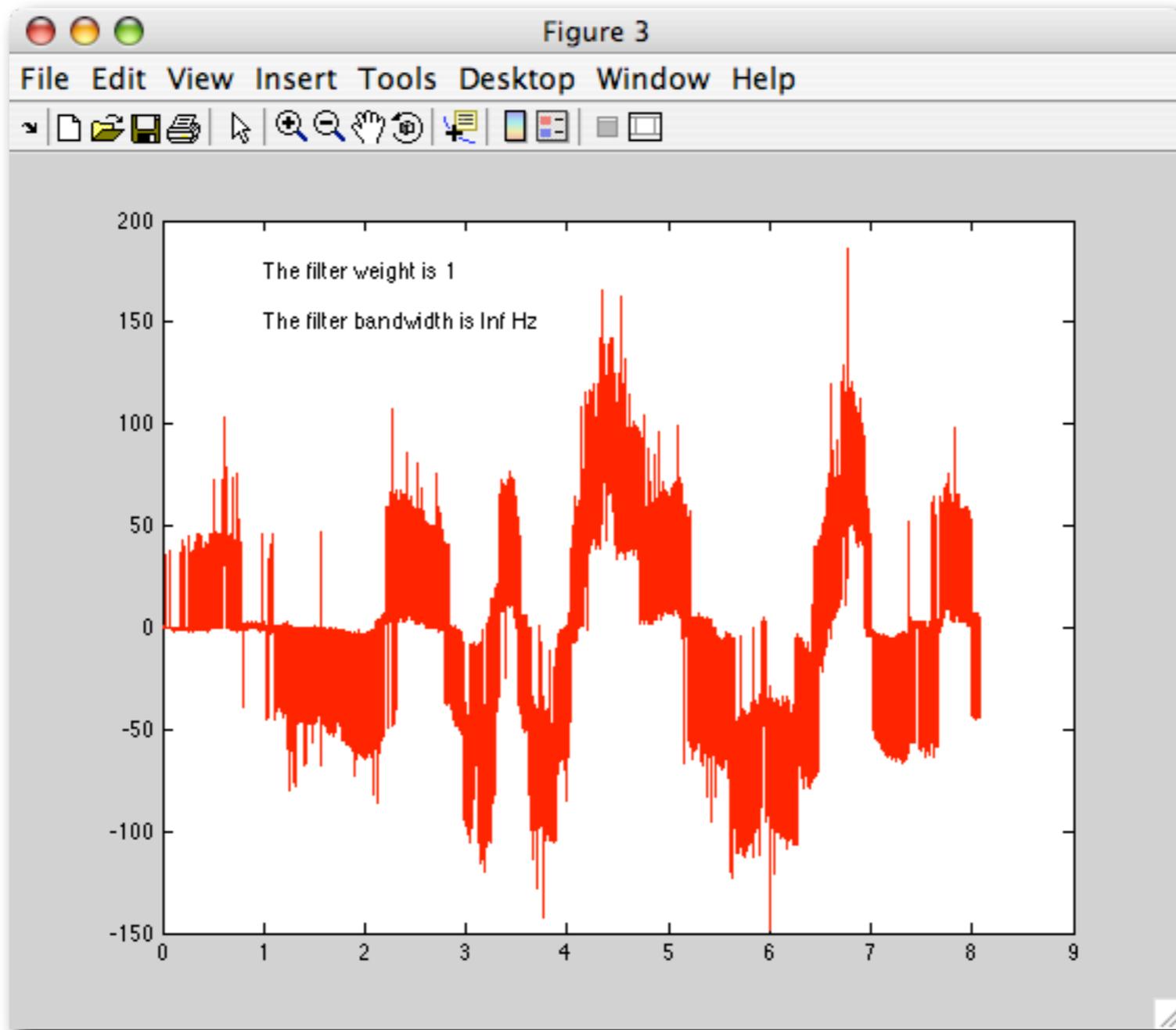
Figure 1

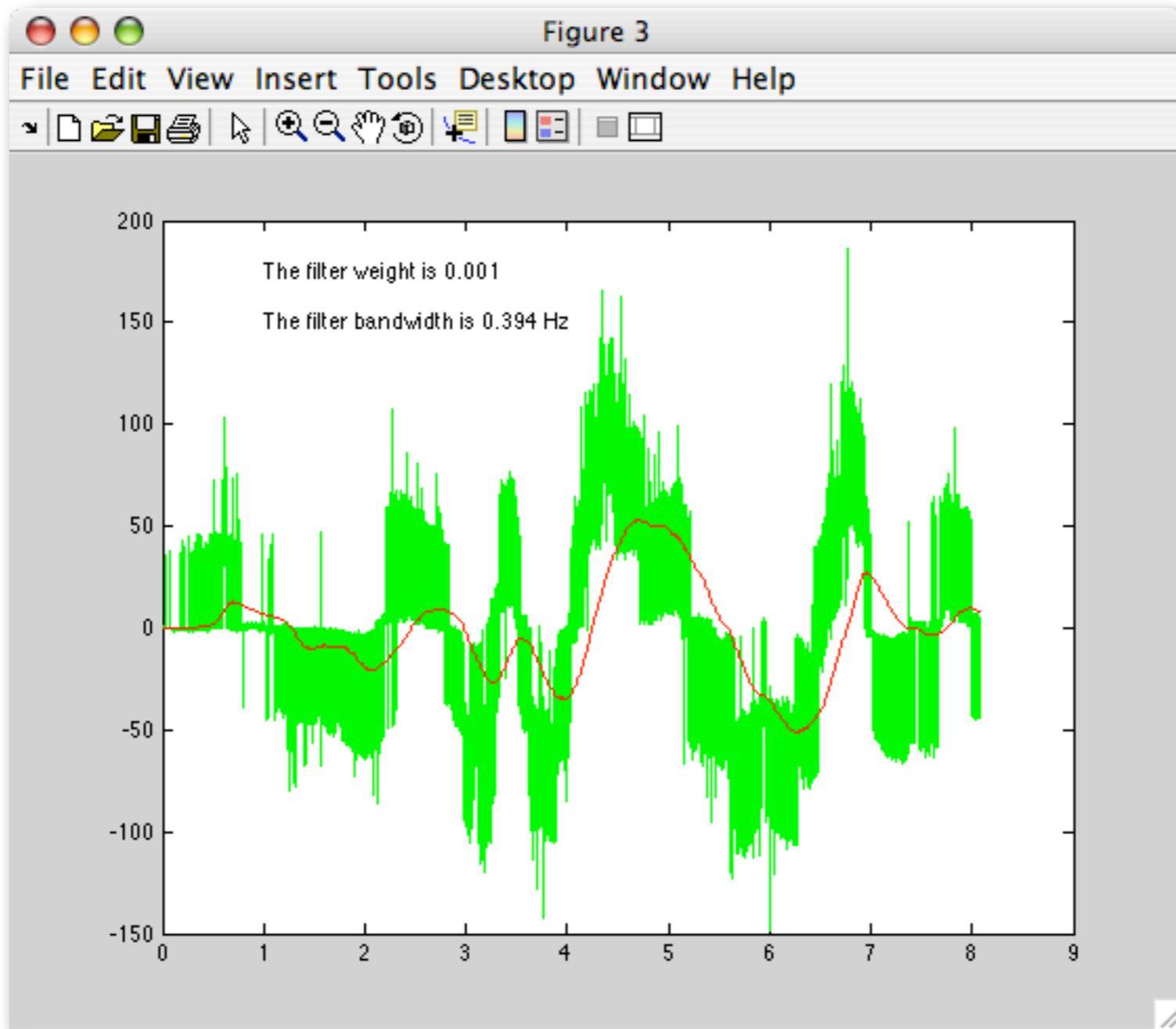












RJZ

24 Jan 2007

Begin with a first-order continuous-time low-pass filter, where $Y(s)$ is the Laplace transform of the filtered output and $X(s)$ is that of our signal.

$$\text{output} \rightarrow \frac{Y(s)}{X(s)} = \frac{\lambda}{s + \lambda} \leftarrow \text{gain} = 1 @ s = 0$$

input \nearrow \nwarrow one pole at $-\lambda$, λ is filter cutoff in rad/s

Convert from continuous time (smooth derivatives) to discrete time (sampled at ~~the~~ intervals of T seconds).

This requires us to choose a method for approximating the derivative. Other options would work too, but the simplest is backward differencing:

\swarrow Z transform acts like a shift operator.

$$s = \frac{(1 - z^{-1})}{T}$$

\uparrow
makes sense: this value minus last value divided by T.

substitute this in for s in the above eqn.

$$\frac{Y(z)}{X(z)} = \frac{\lambda}{\frac{(1 - z^{-1})}{T} + \lambda}$$

$$Y(z) \left[\frac{(1 - z^{-1})}{T} + \lambda \right] = \lambda X(z)$$

$$Y(z) - Y(z) * z^{-1} + \lambda T Y(z) = \lambda T X(z)$$

$$(1 + \lambda T) Y(z) = \lambda T X(z) + z^{-1} * Y(z)$$

$$Y(z) = \frac{\lambda T}{1 + \lambda T} X(z) + \frac{1}{1 + \lambda T} z^{-1} Y(z)$$

do inverse z transform

$$y(k) = \frac{\lambda T}{1 + \lambda T} x(k) + \frac{1}{1 + \lambda T} y(k-1)$$

index \nearrow

$$y(k) = w \cdot x(k) + (1-w) y(k-1)$$

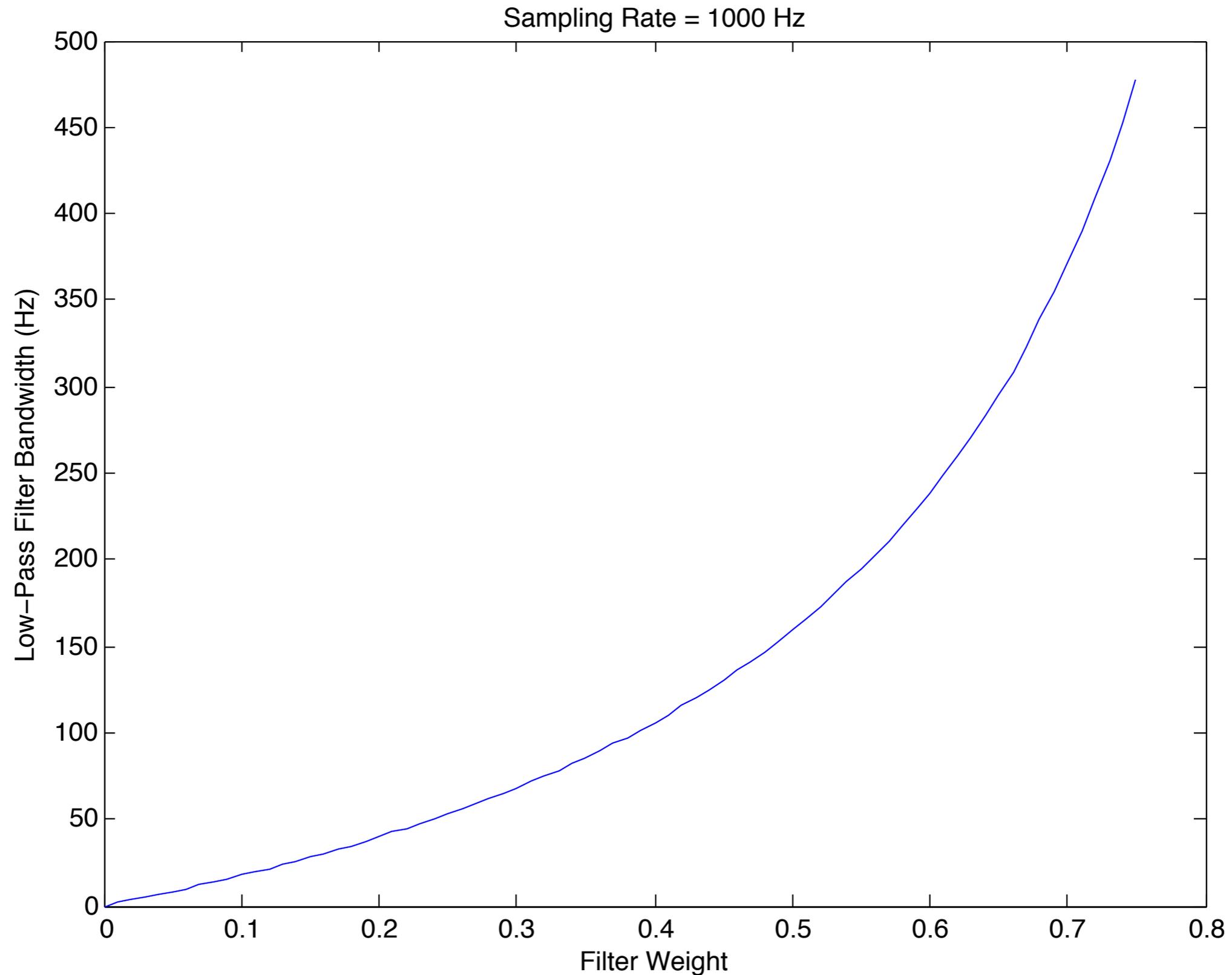
\uparrow
filter-weight = $\frac{\lambda T}{1 + \lambda T}$

$$\lambda = \frac{w}{T(1-w)}$$

$$\lambda = \frac{w}{T(1-w)}$$

$$f = \lambda \cdot \frac{1 \text{ cycle}}{2\pi \text{ rad}} = \frac{w}{T(1-w)} \cdot \frac{1 \text{ cycle}}{2\pi \text{ rad}}$$

$$\lambda = \frac{w}{T(1-w)} \quad f = \lambda \cdot \frac{1 \text{ cycle}}{2\pi \text{ rad}} = \frac{w}{T(1-w)} \cdot \frac{1 \text{ cycle}}{2\pi \text{ rad}}$$



Calculating Velocity

```
/******
```

```
hapticCallback()
```

Main callback that sets the force that the user will feel. It gets the current position and velocity of the device.

This is what you want to edit to change the system's haptic feedback.

```
*****/
```

```
HDCallbackCode HDCALLBACK hapticCallback(void *data)
```

```
{
```

```
    // Local variables.
```

```
    hduVector3Dd position;
```

```
    hduVector3Dd velocity;
```

```
    hduVector3Dd force;
```

```
    hduVector3Dd extraForce;
```

```
    hduVector3Dd proxyPosition;
```

```
    HDint currentButtonState;
```

```
    HDint lastButtonState;
```

```
    double stiffness = 0.25; // Units are newtons per millimeter.
```

```
    // Local variables for custom velocity calculation.
```

```
    static bool firstTime = true;
```

```
    static hduVector3Dd lastPosition; // mm
```

```
    hduVector3Dd rawVelocity; // mm/s
```

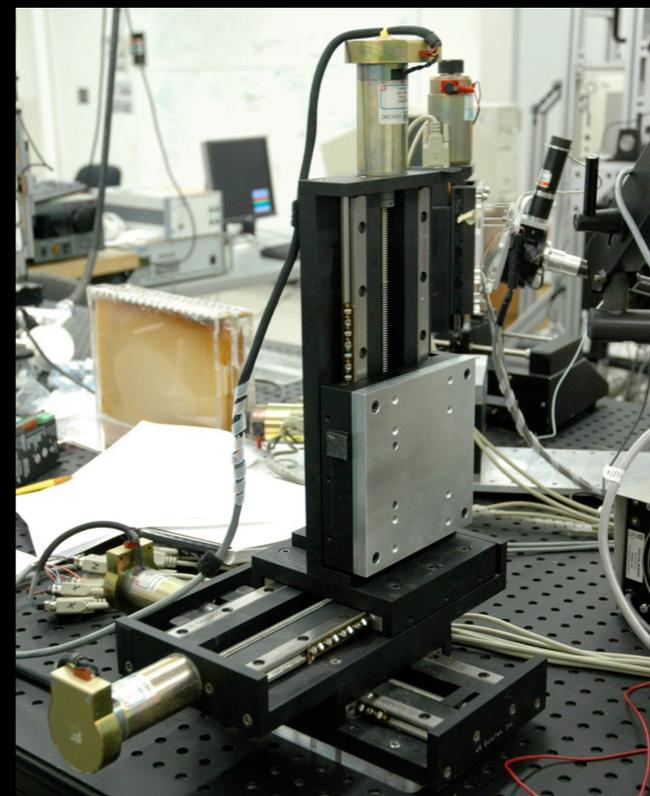
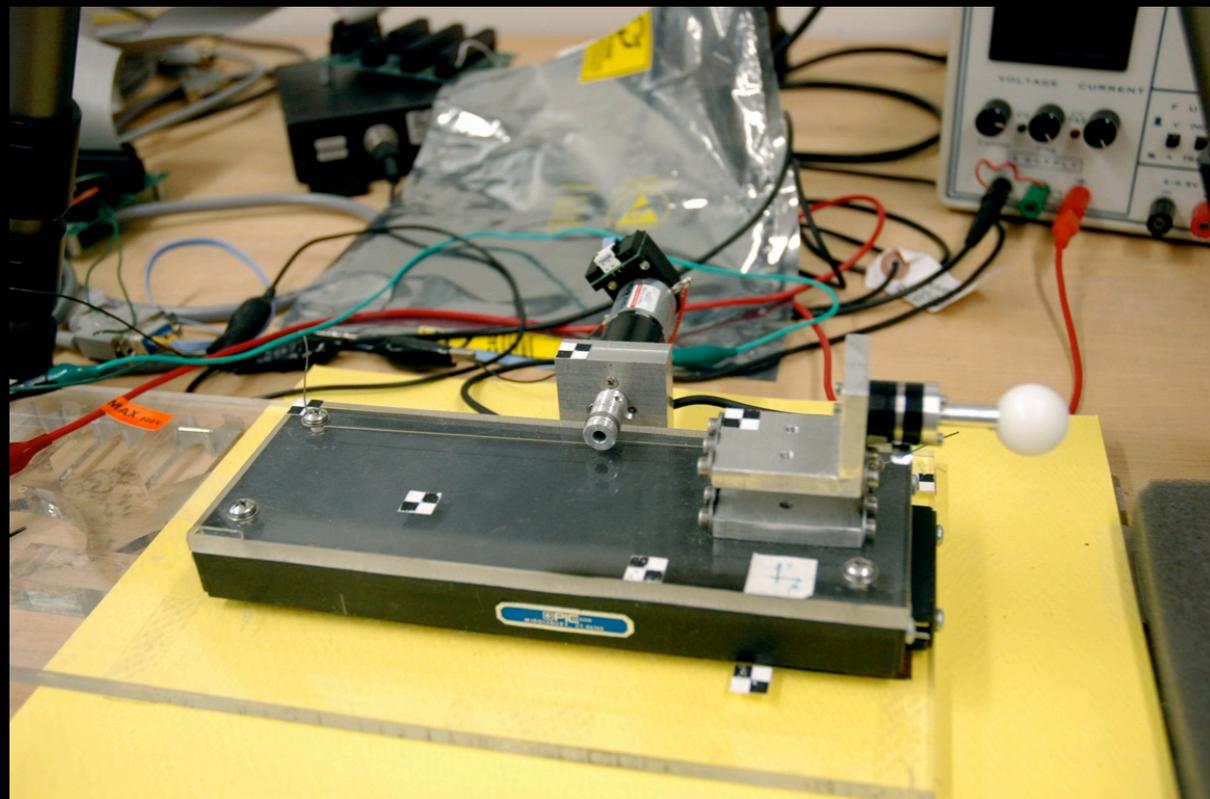
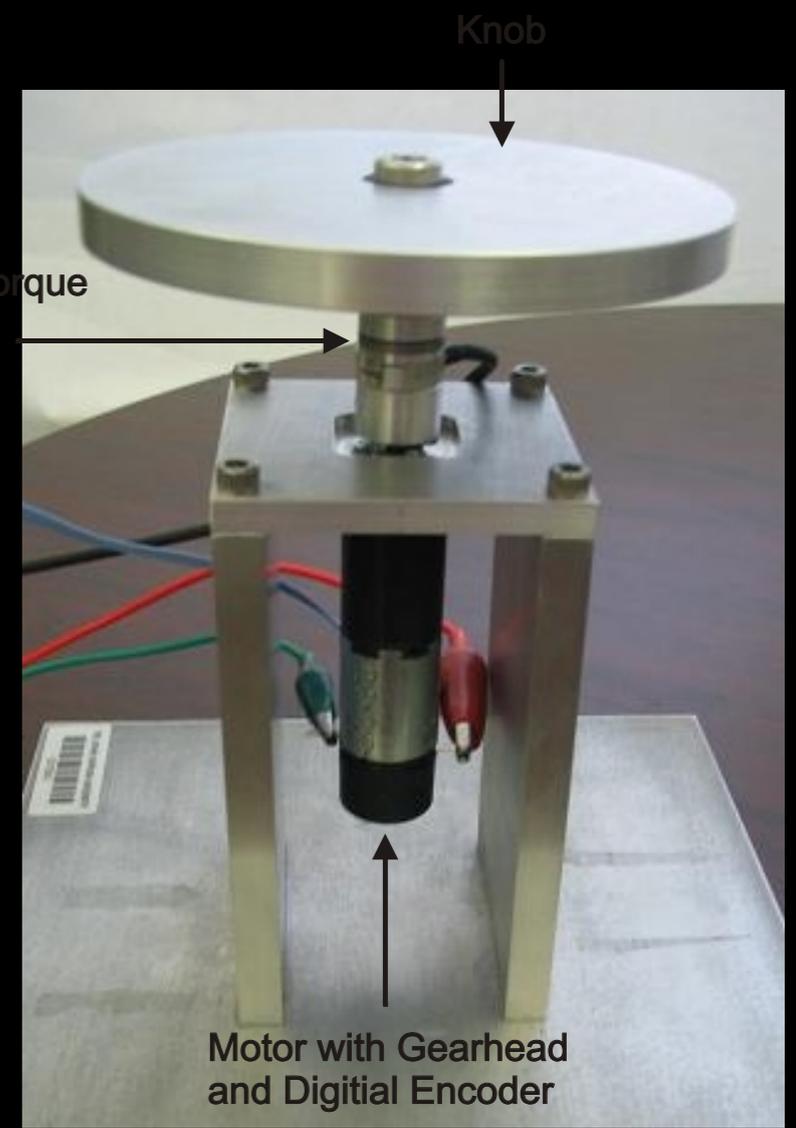
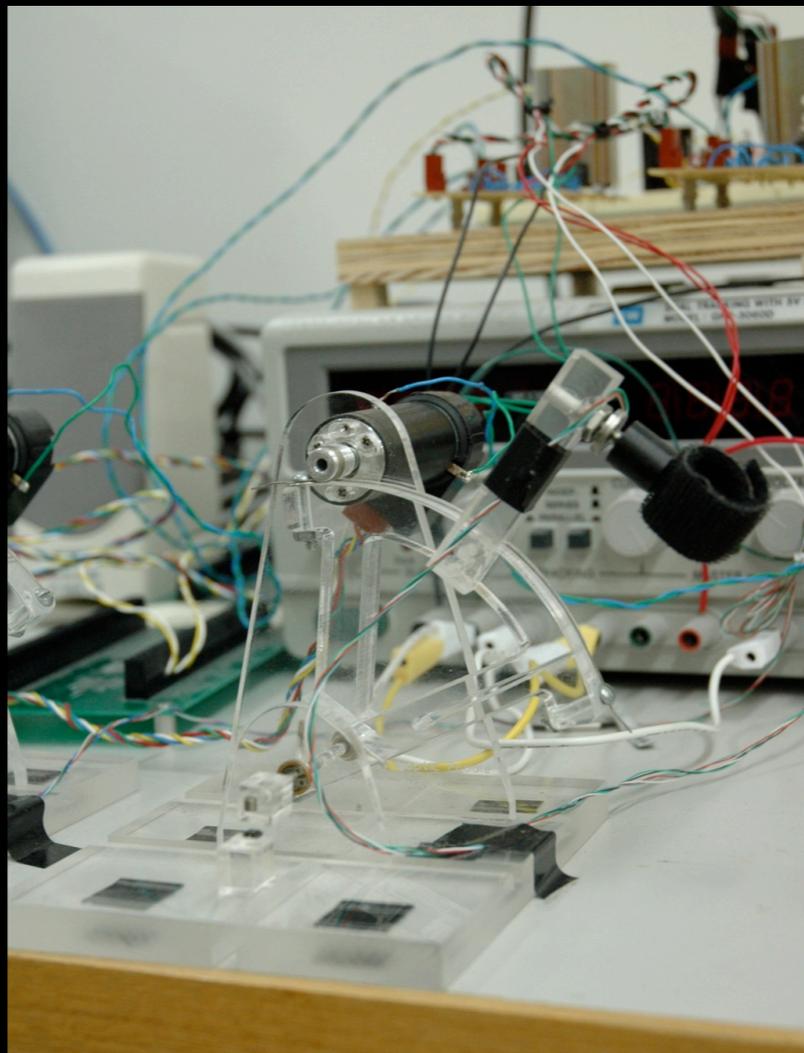
```
    static hduVector3Dd filteredVelocity(0.0, 0.0, 0.0); // mm/s
```

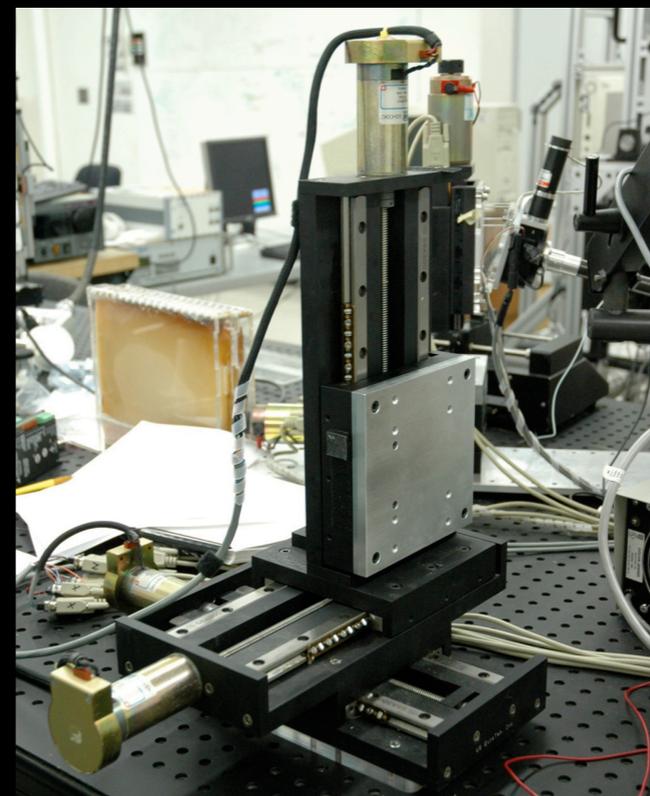
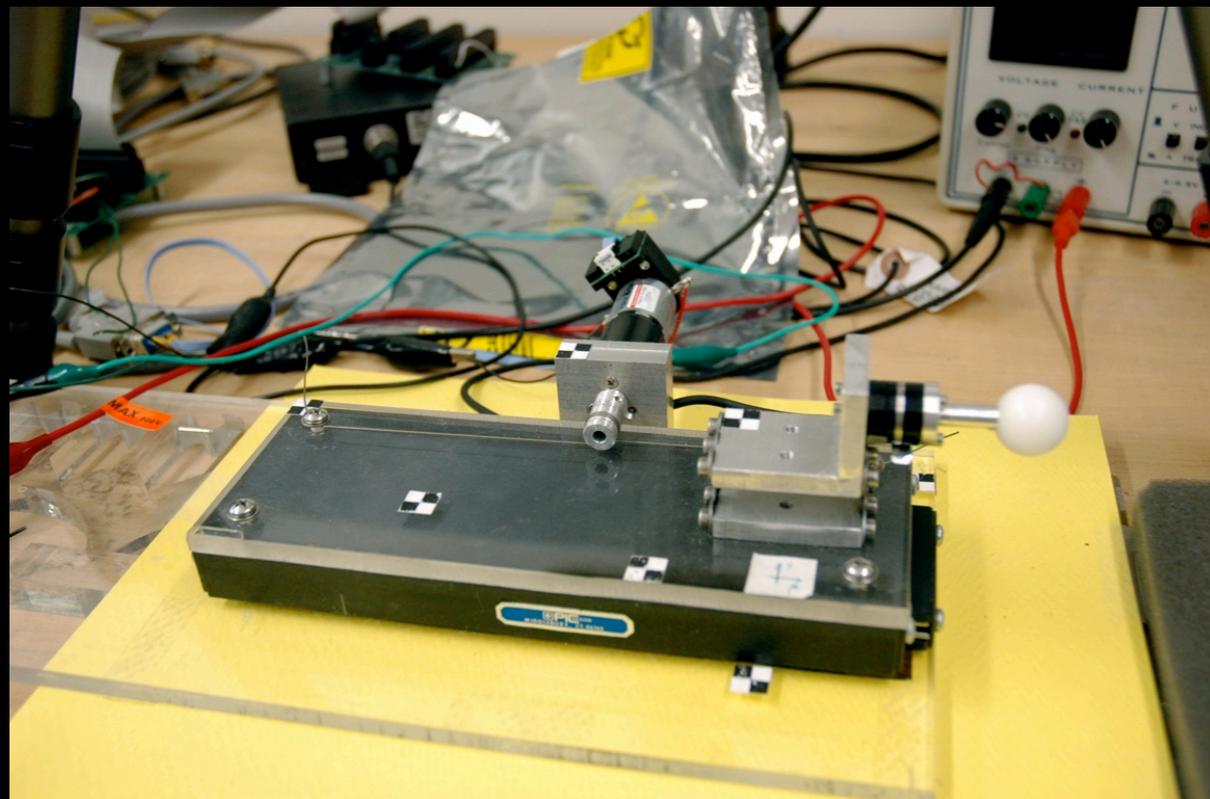
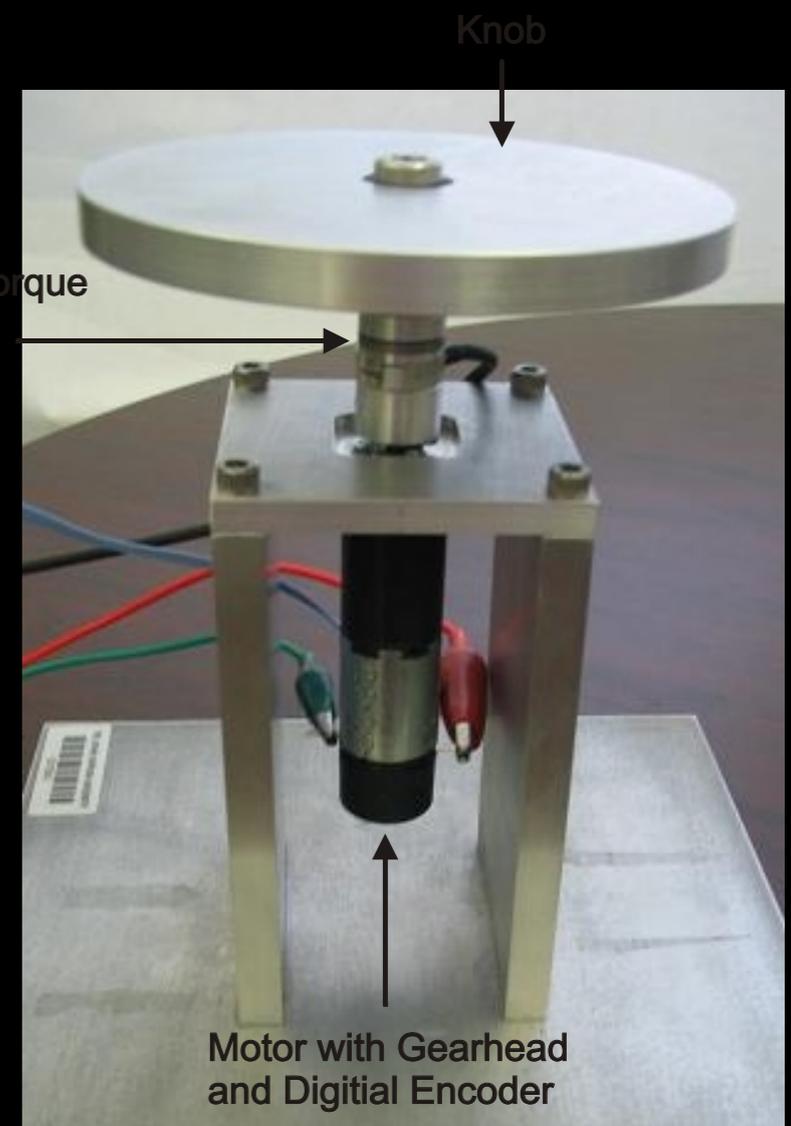
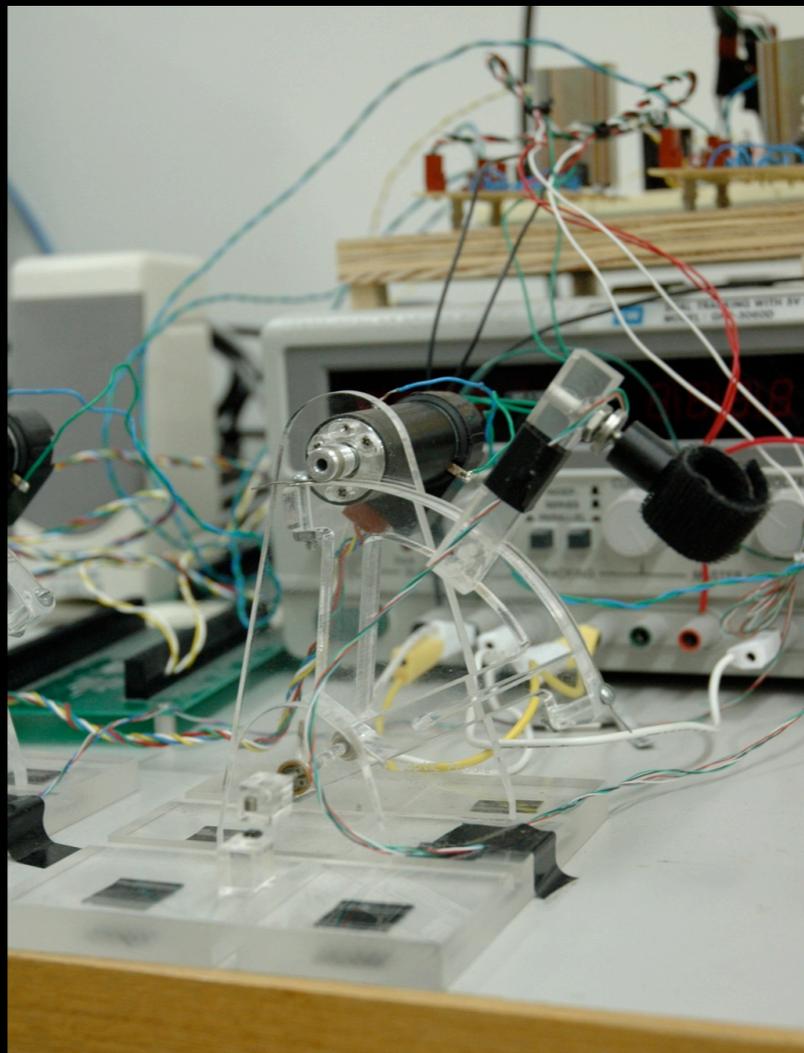
```
    float filterWeight = 0.03;
```

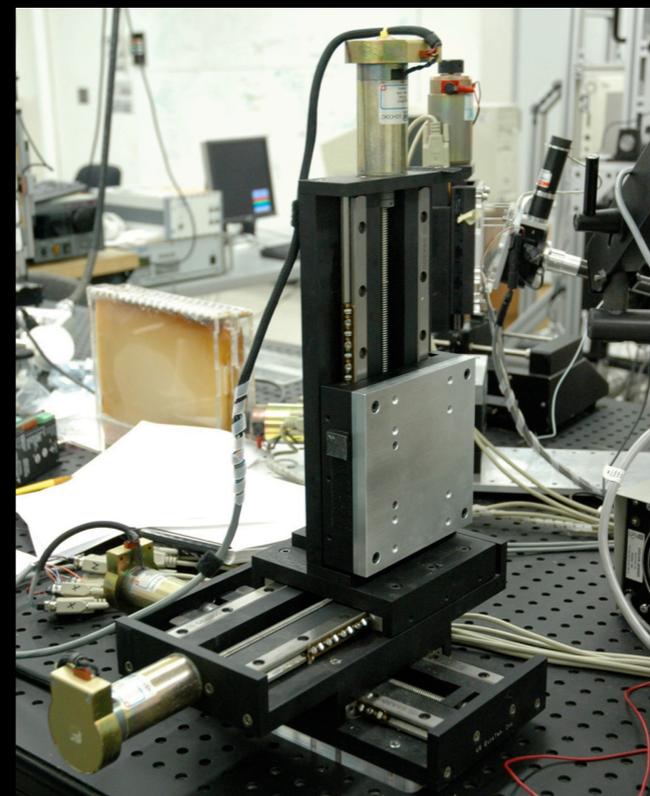
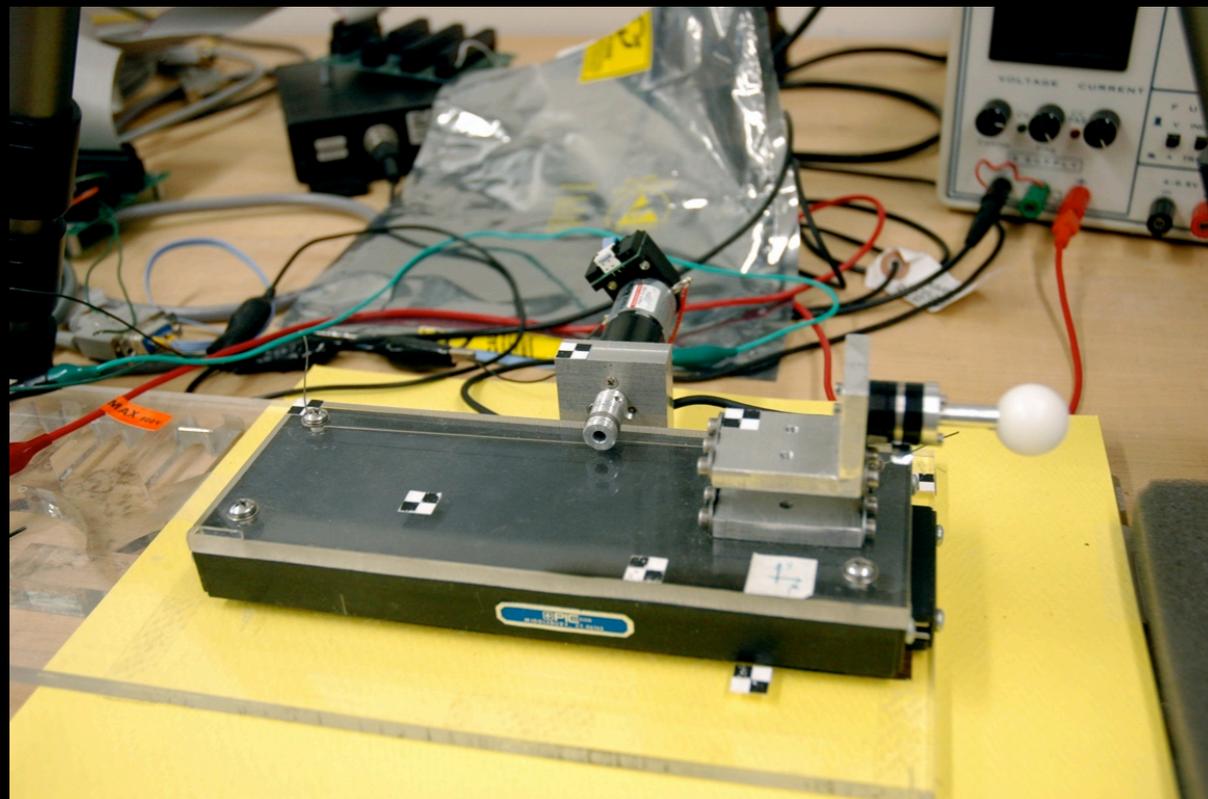
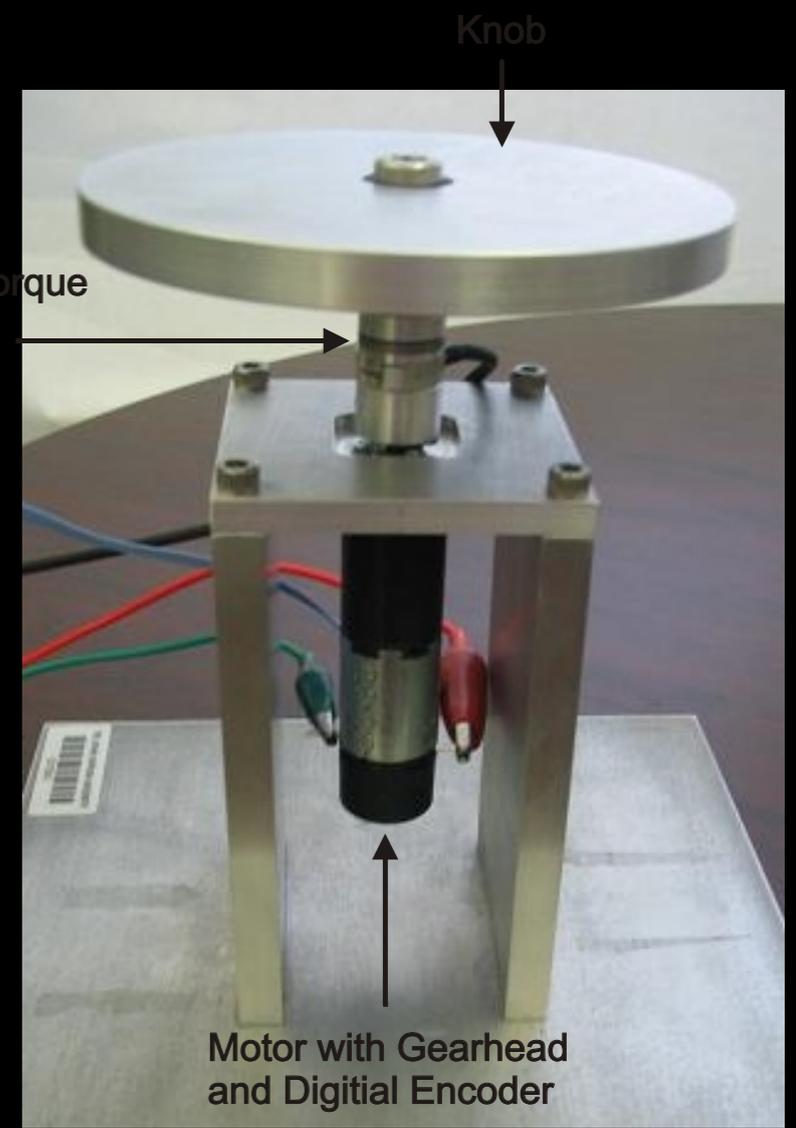
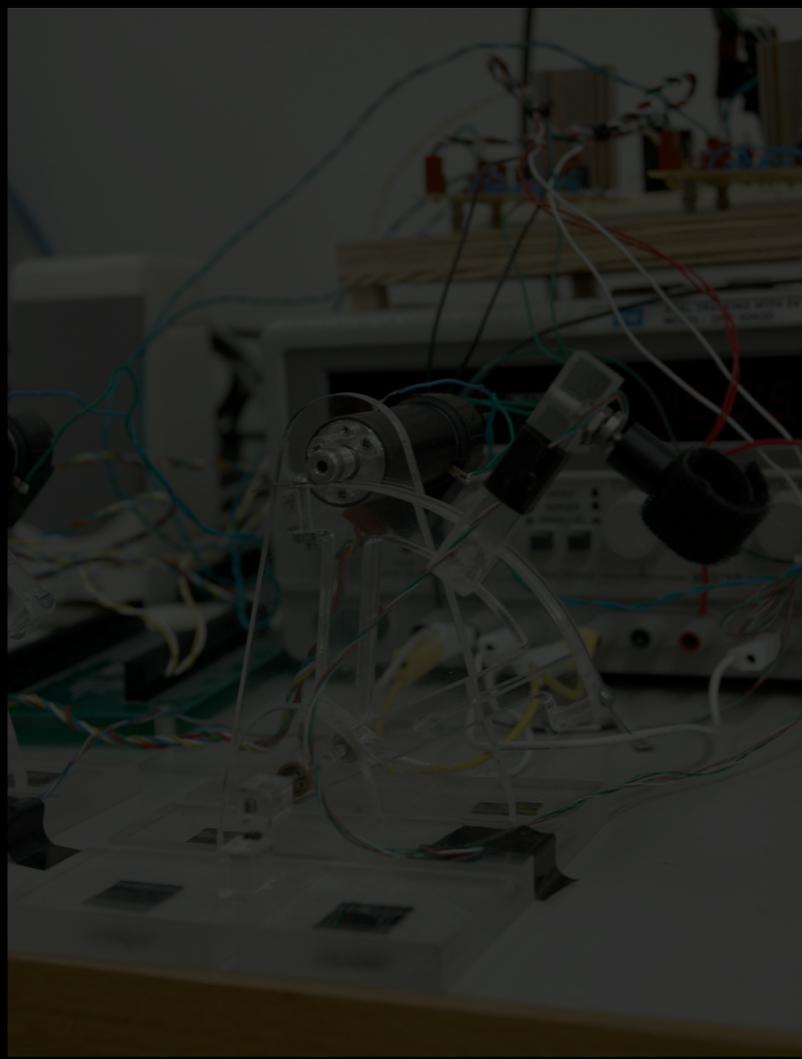
```
    float dampingCoefficient = 0.01; // N/(mm/s)
```

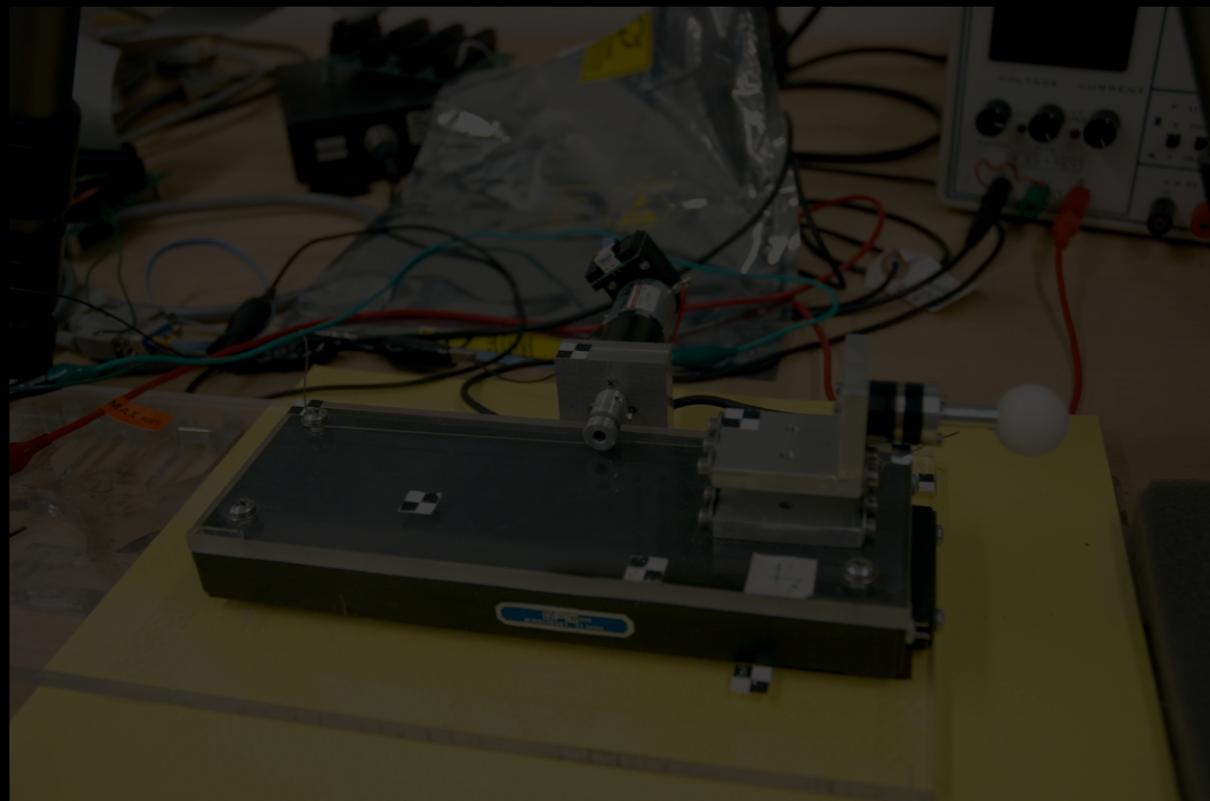
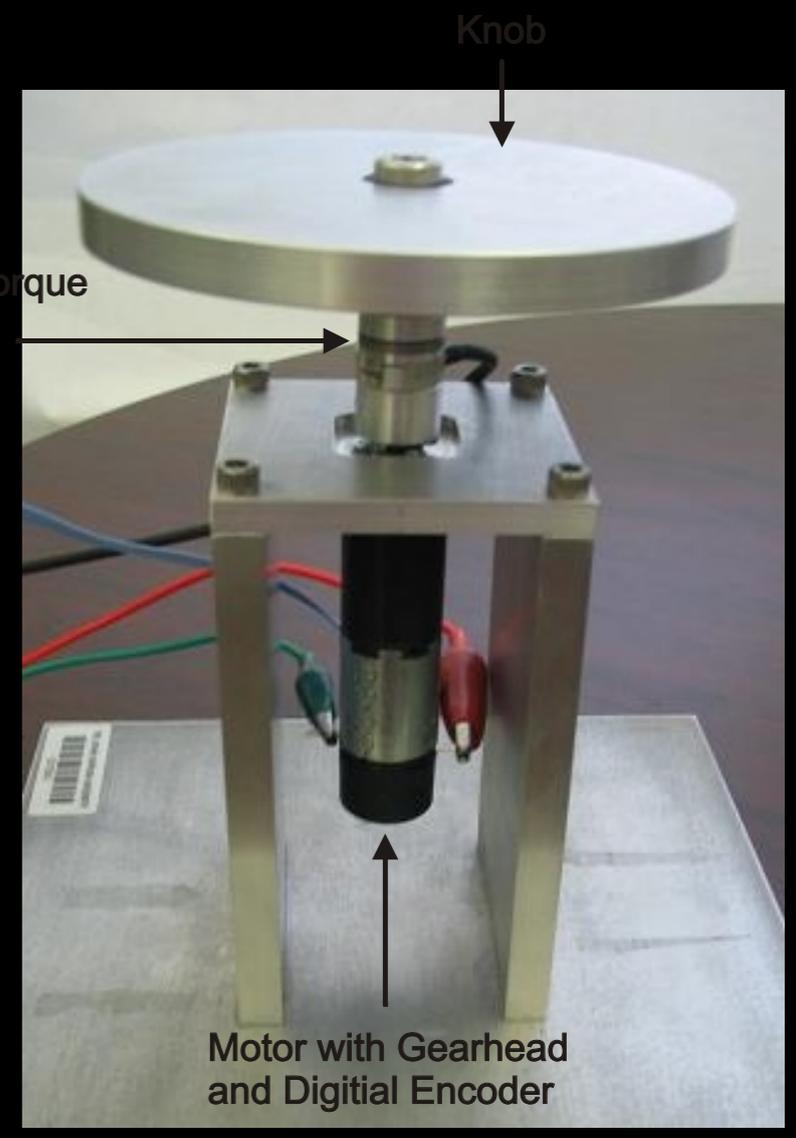
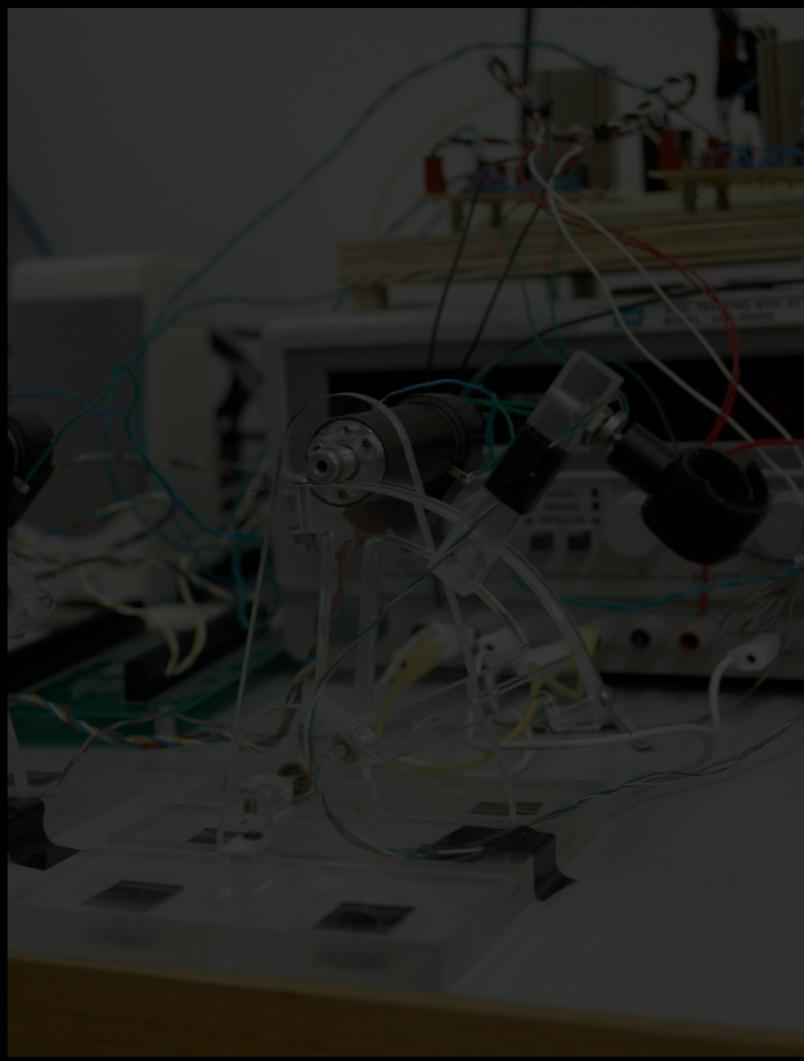
```
    hduVector3Dd dampingForce; // N
```

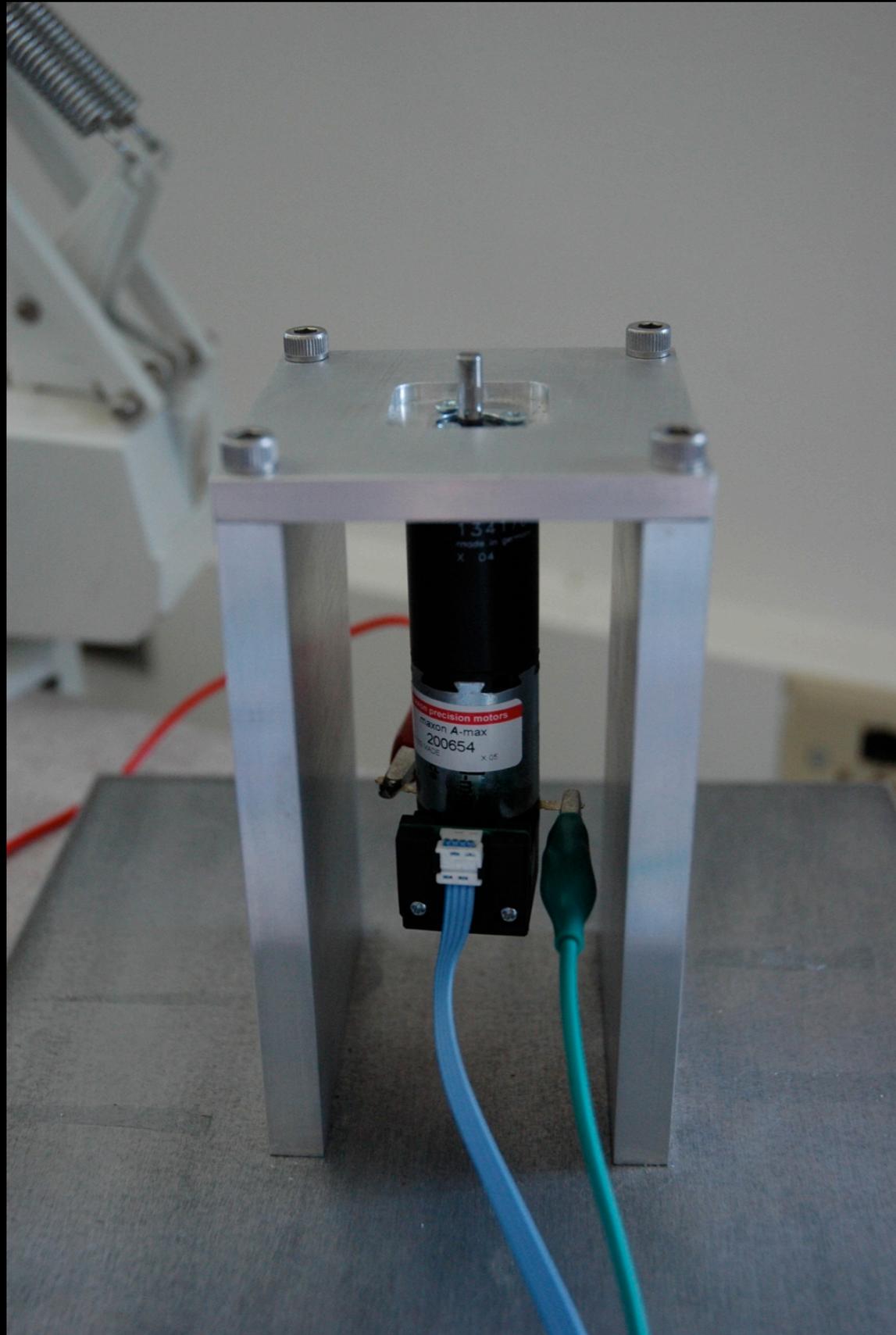
A sample custom haptic device

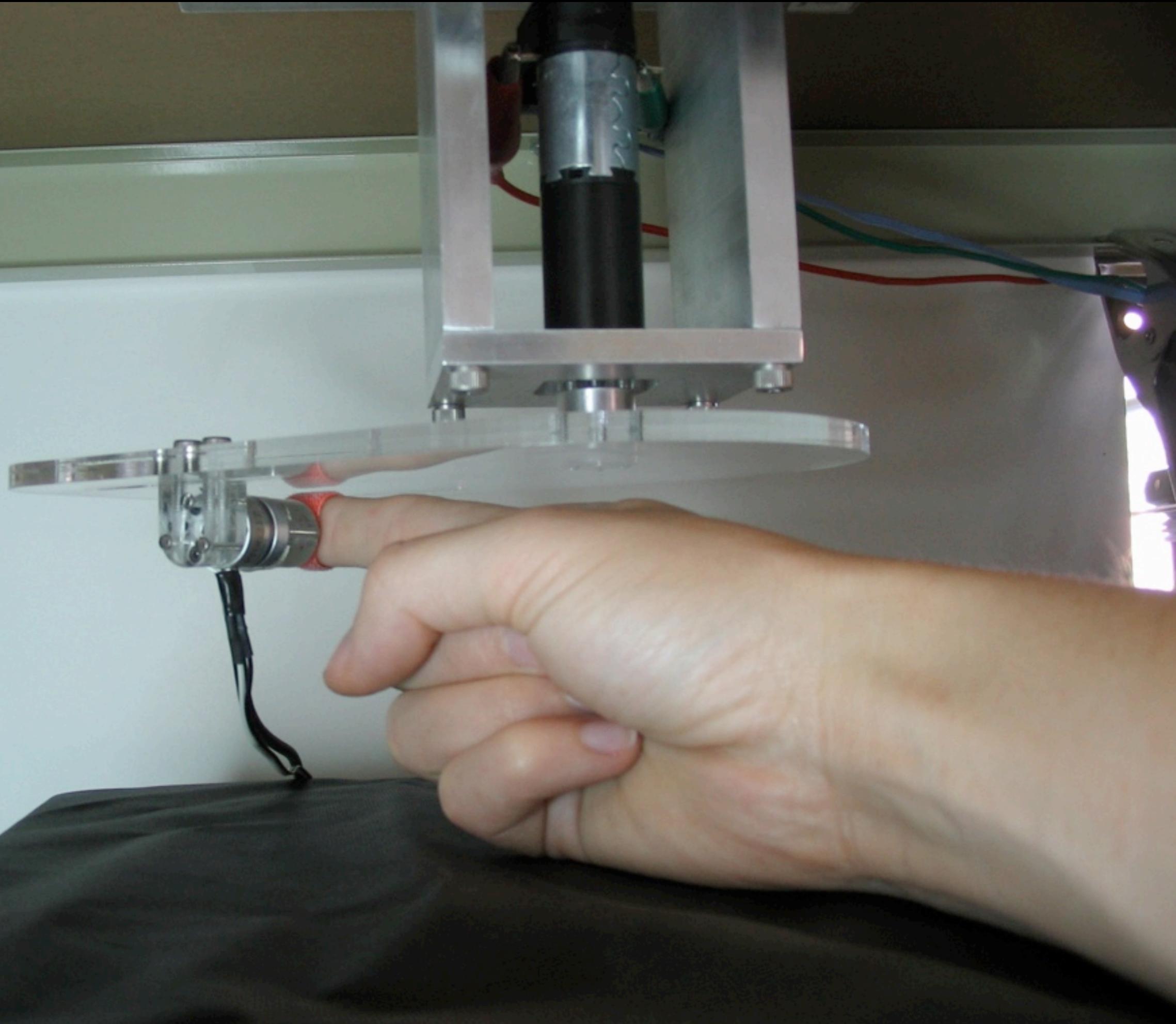






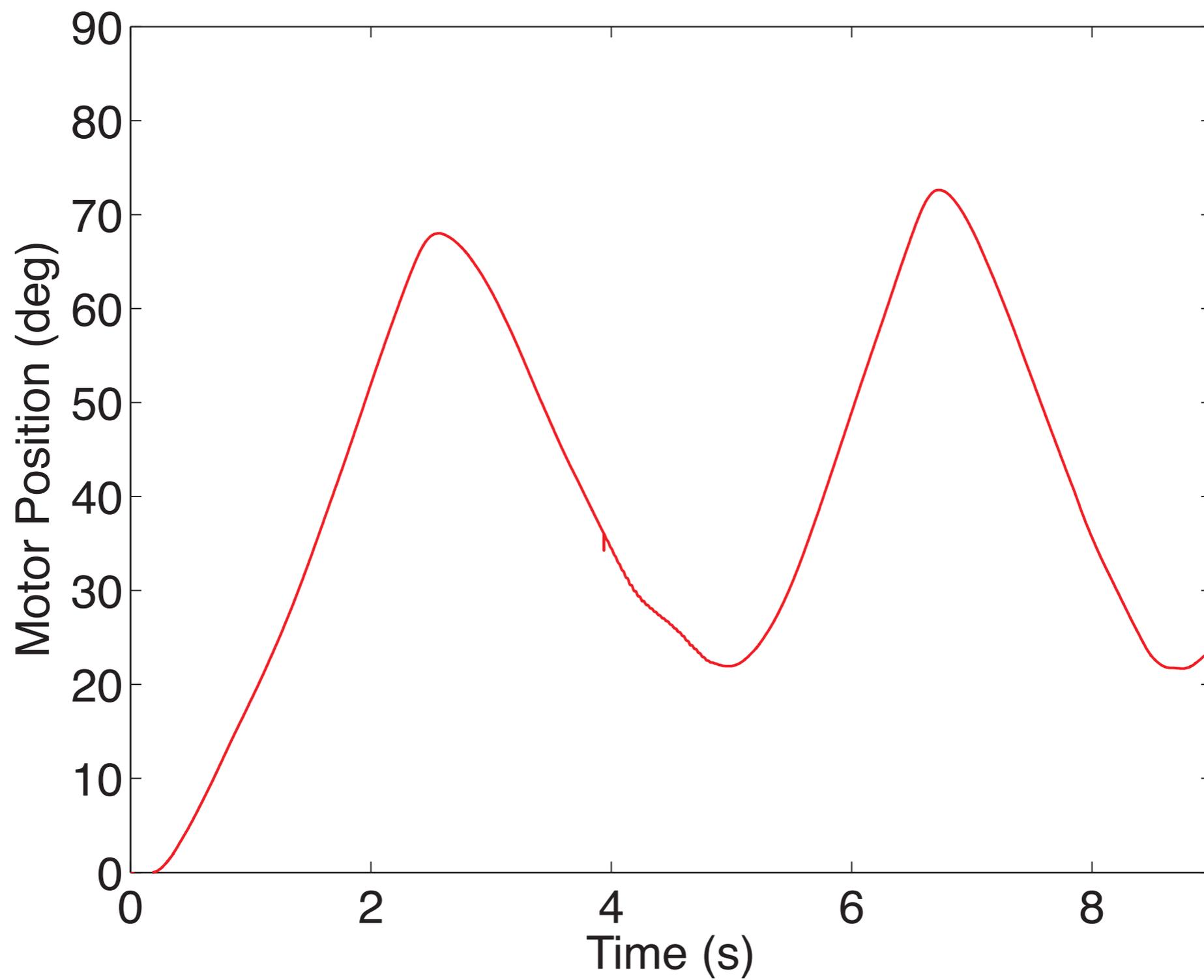


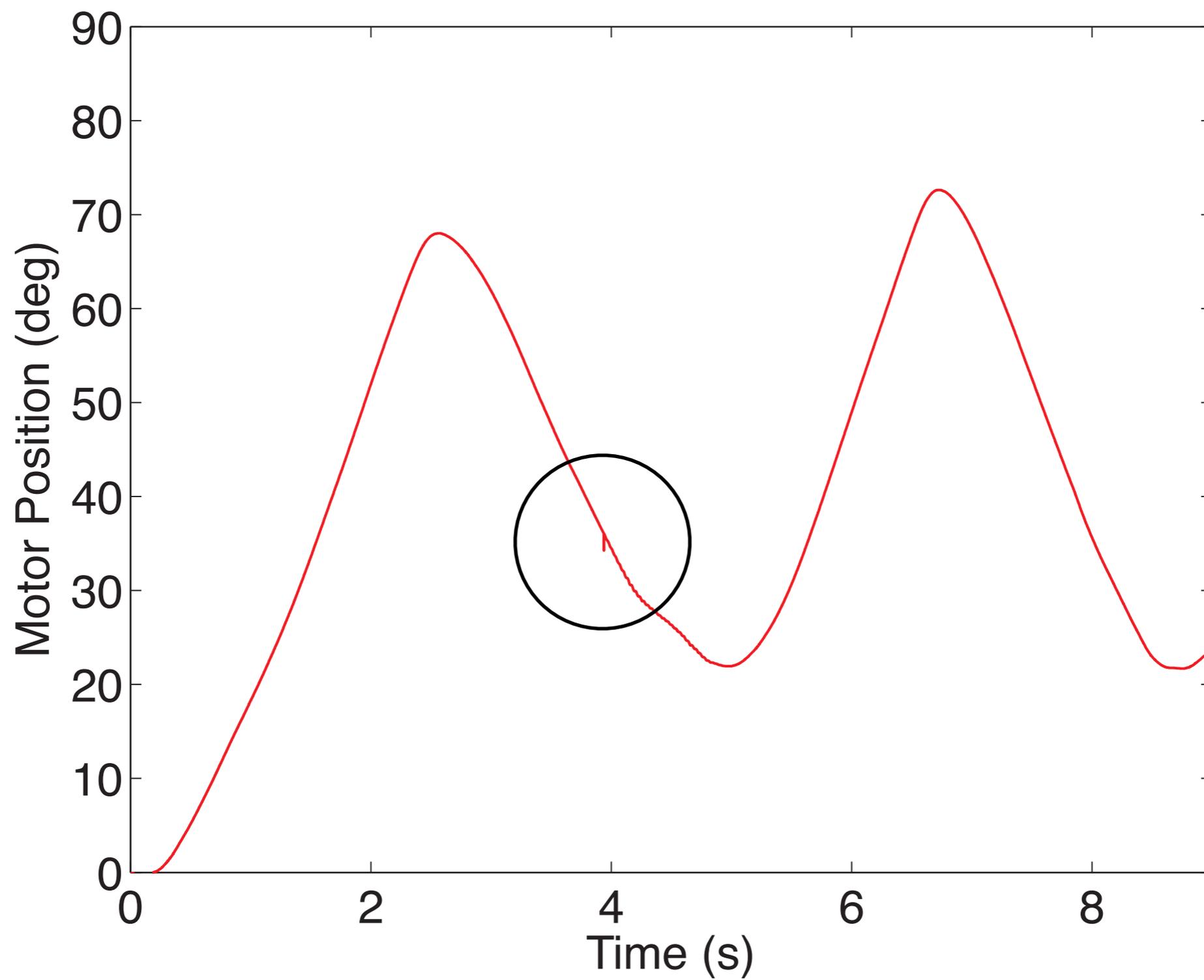


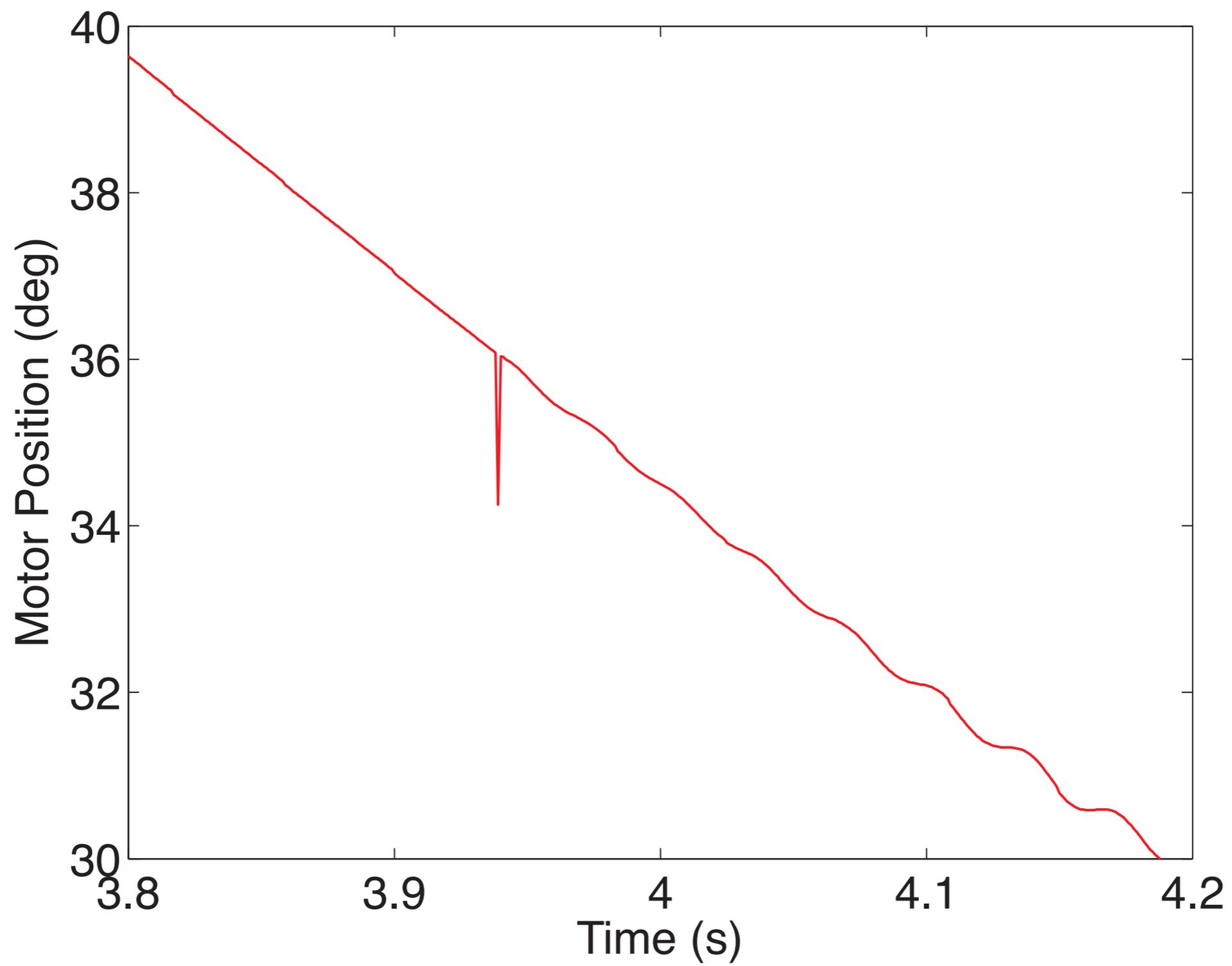


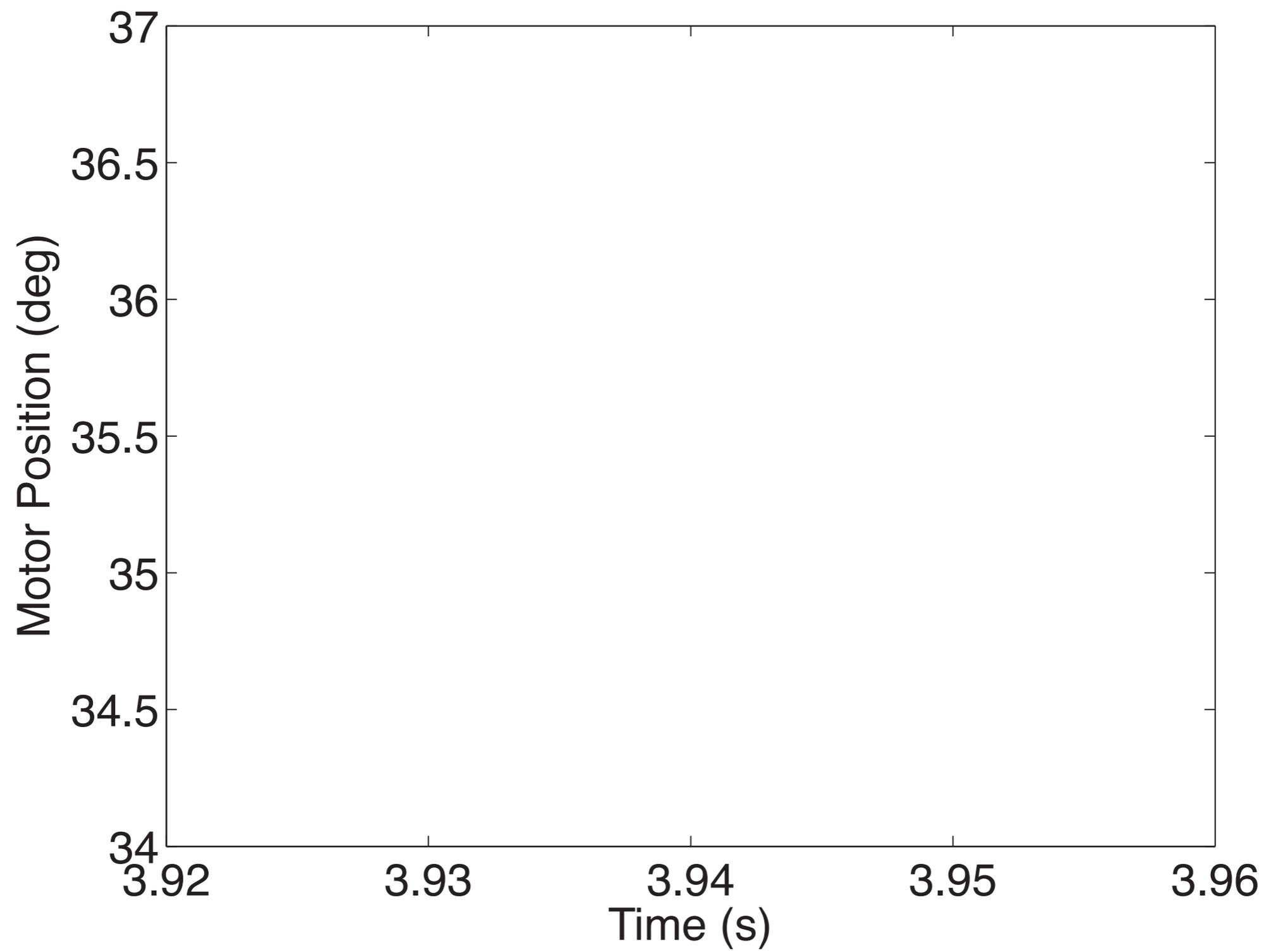
$$\tau_m = k_p(\theta_d - \theta_m) + k_d(\omega_d - \omega_m)$$

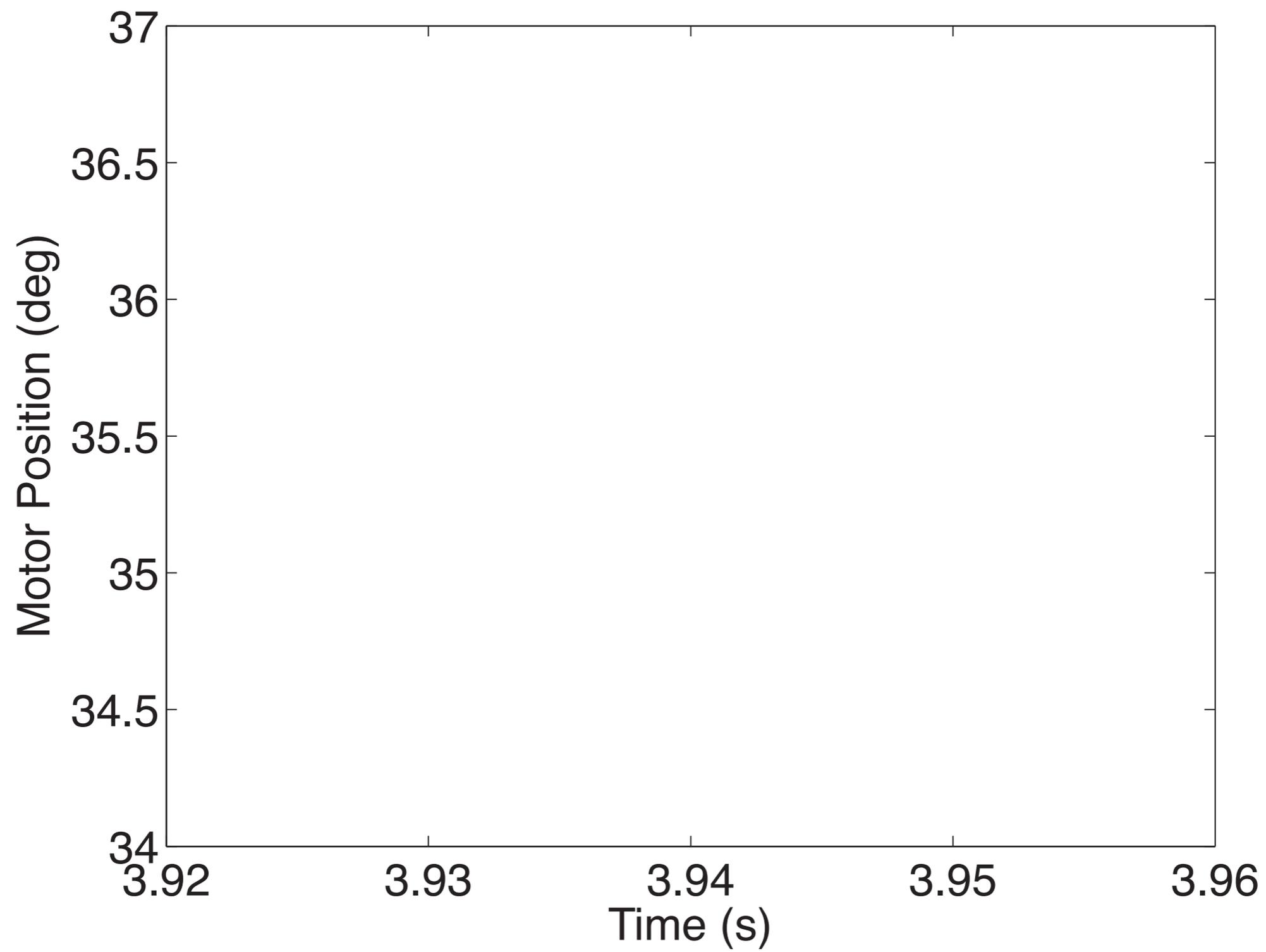
$$\tau_m = k_p(\theta_d - \underline{\theta_m}) + k_d(\omega_d - \underline{\omega_m})$$

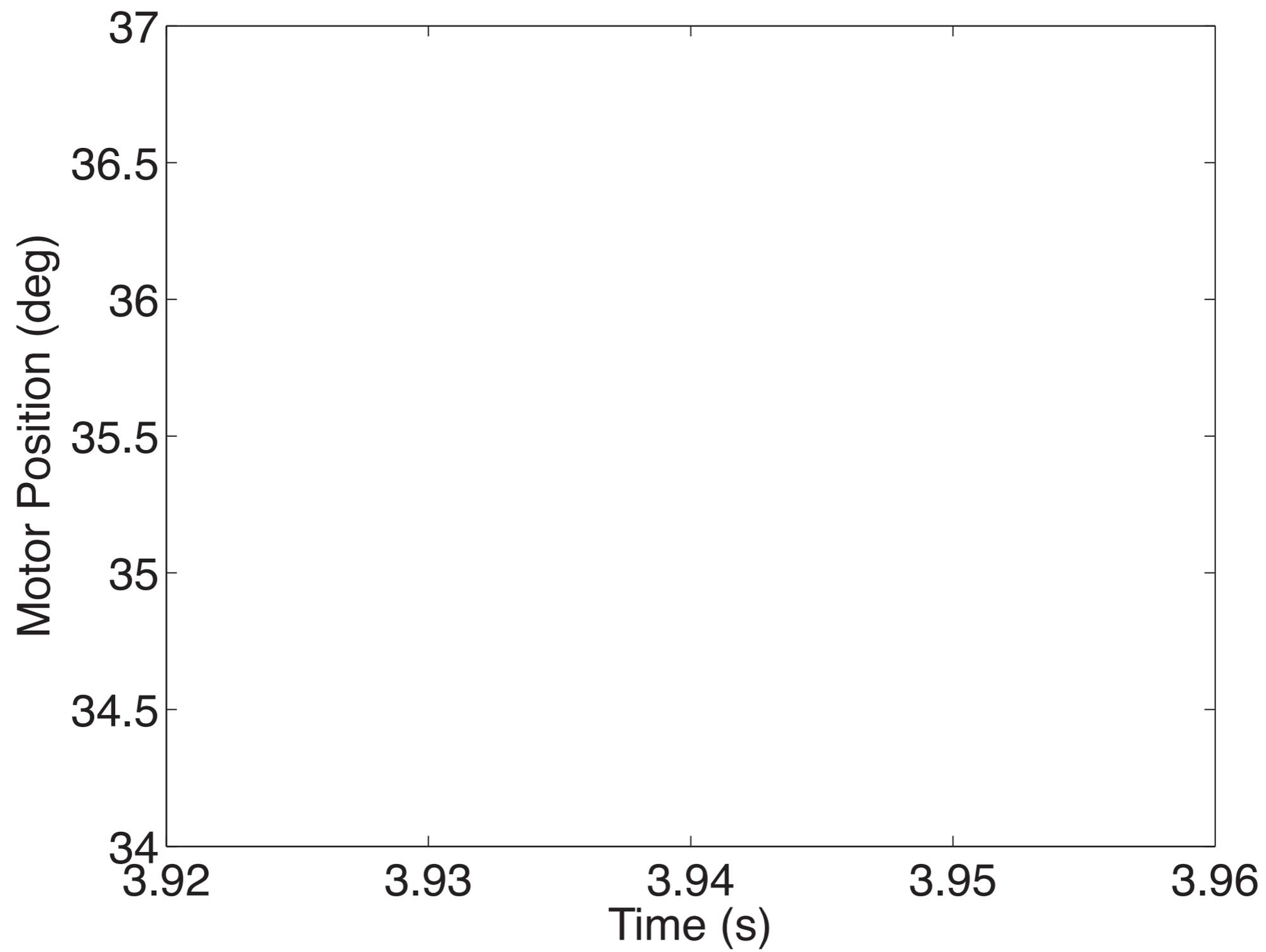


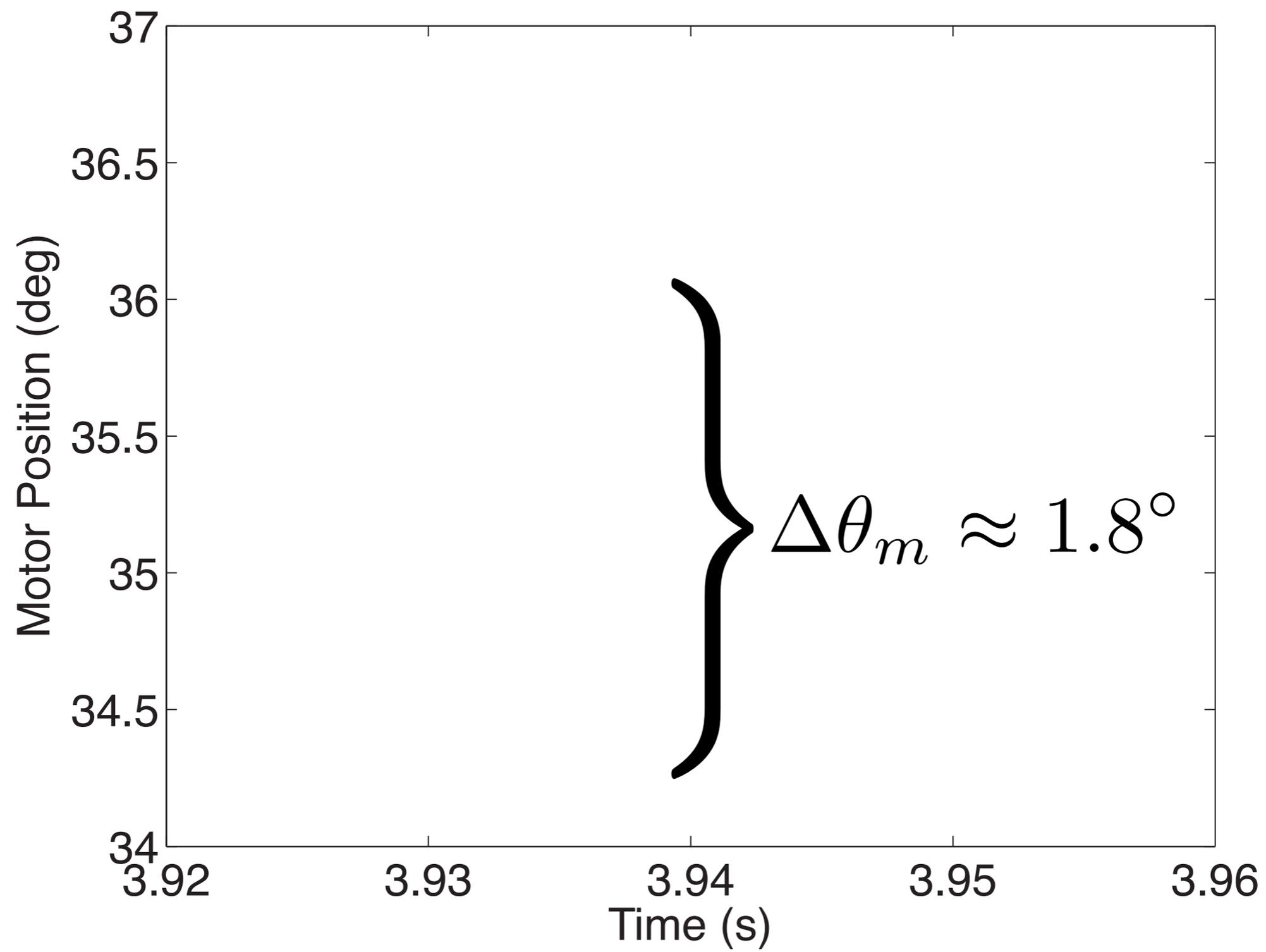




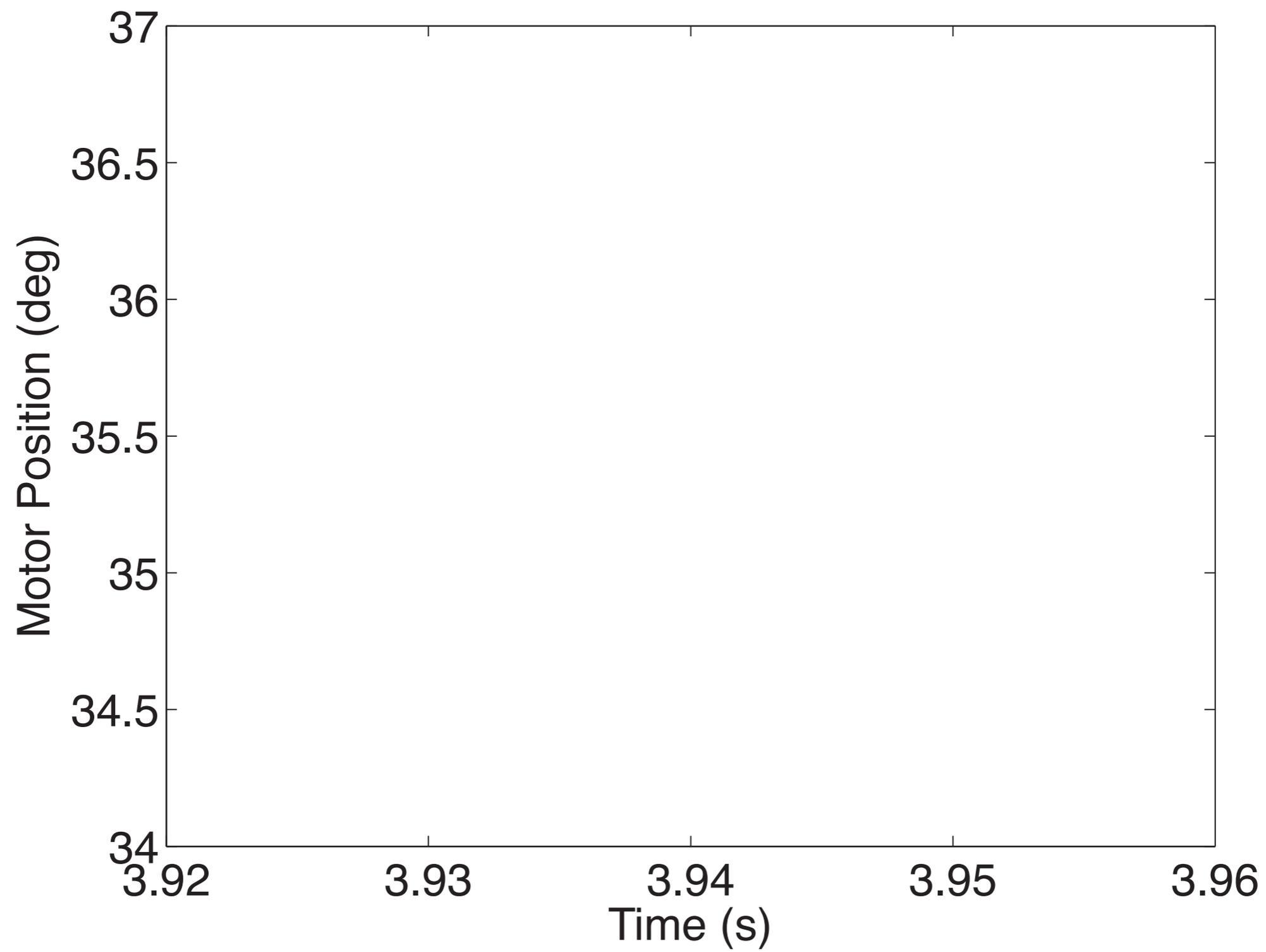


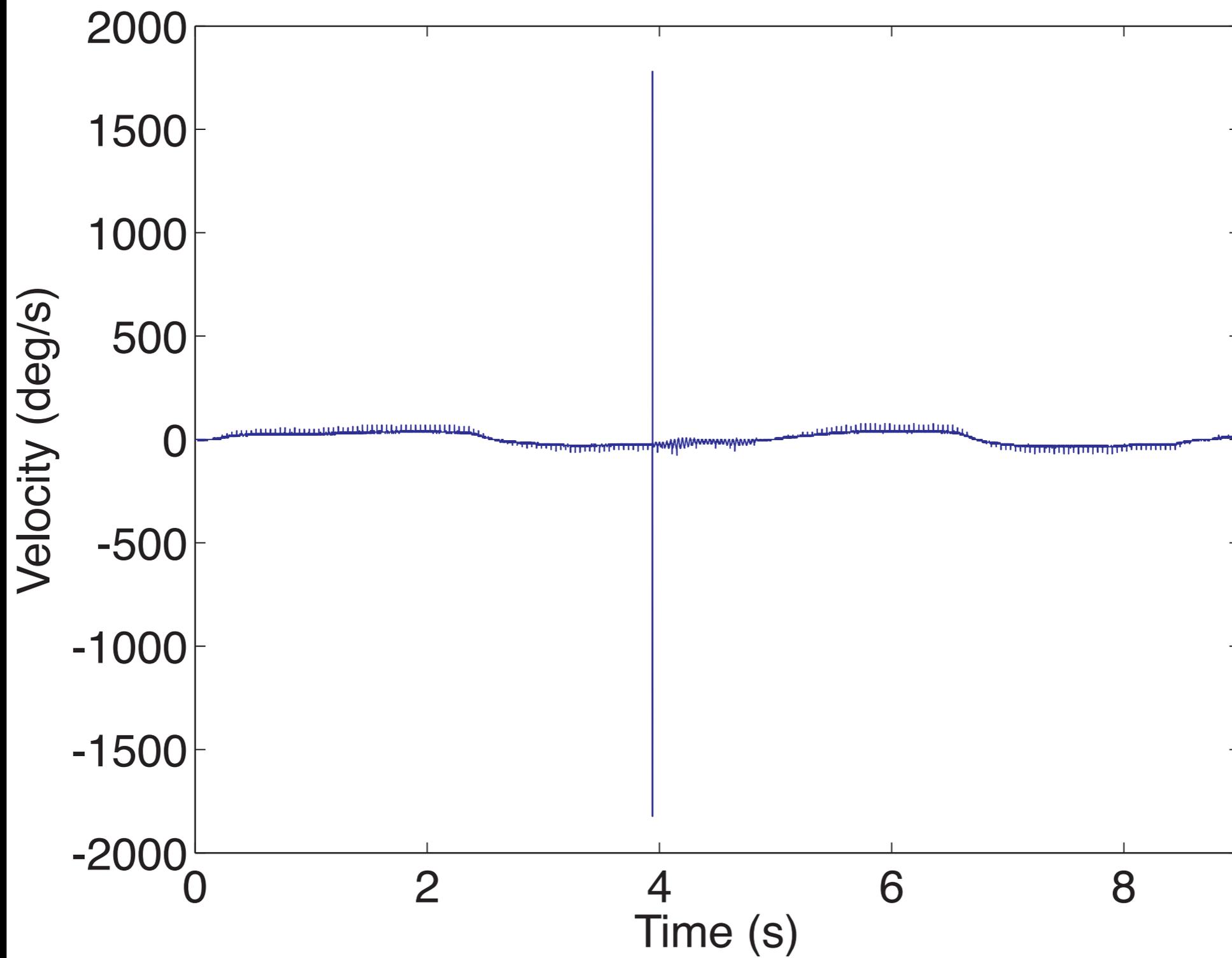


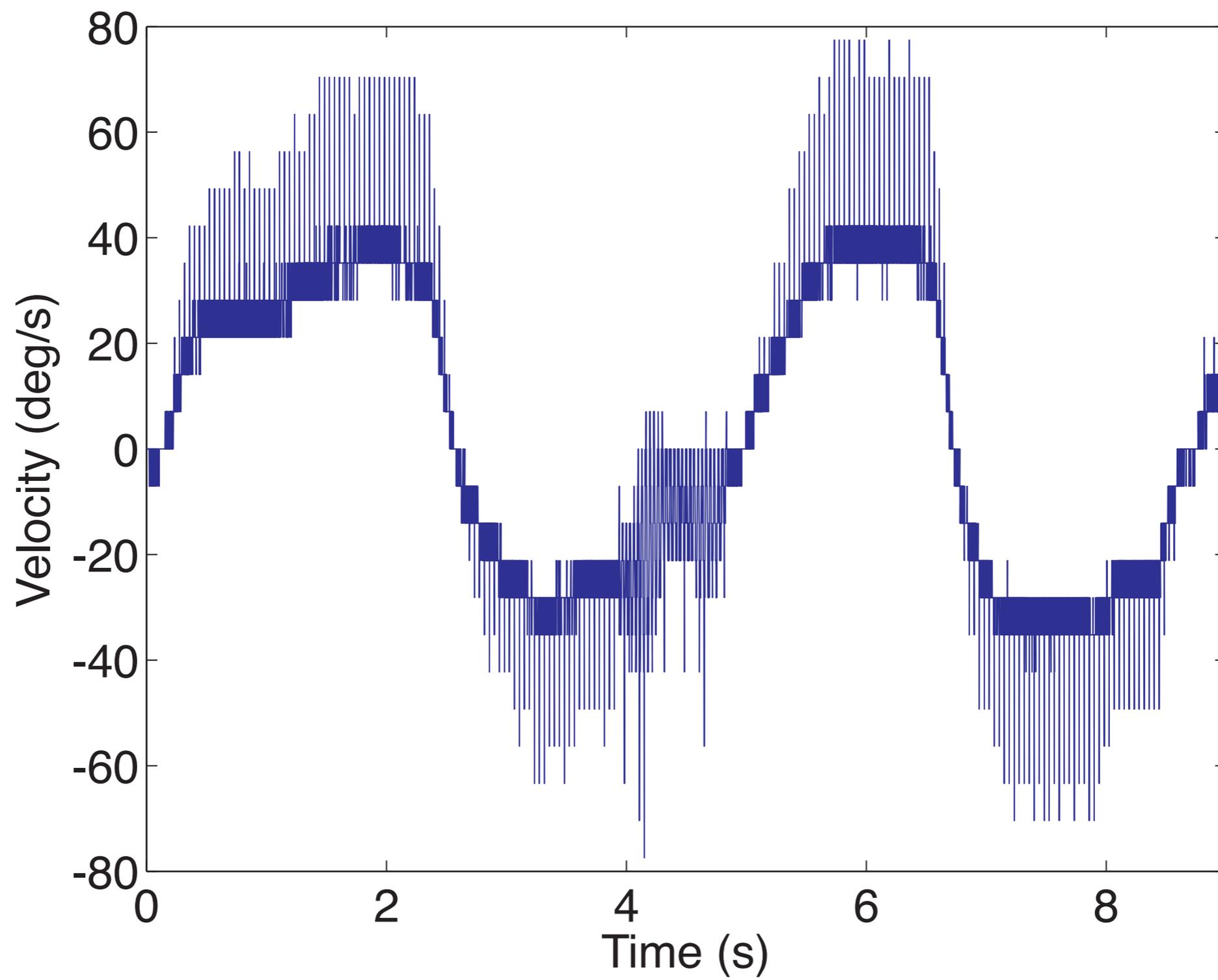


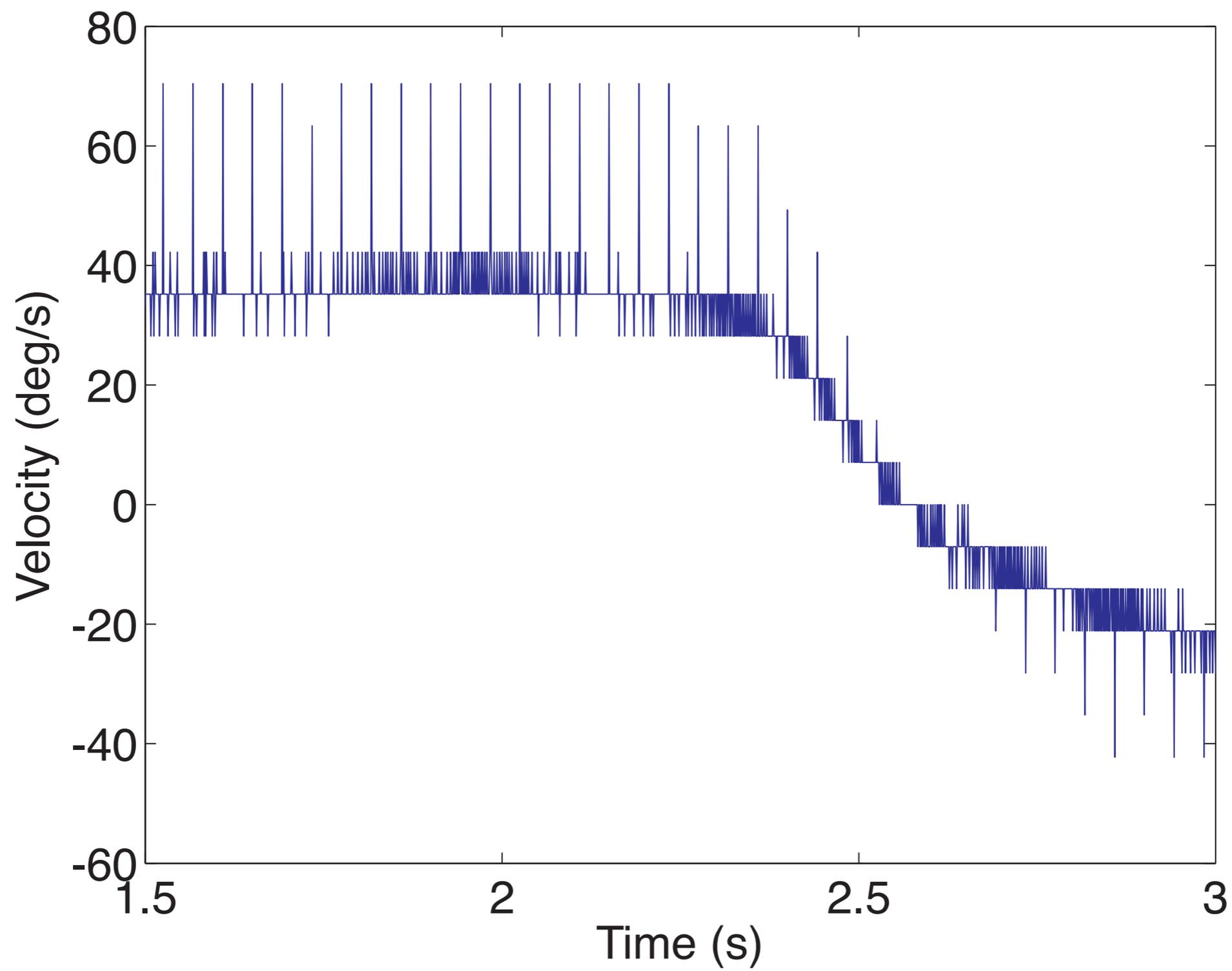


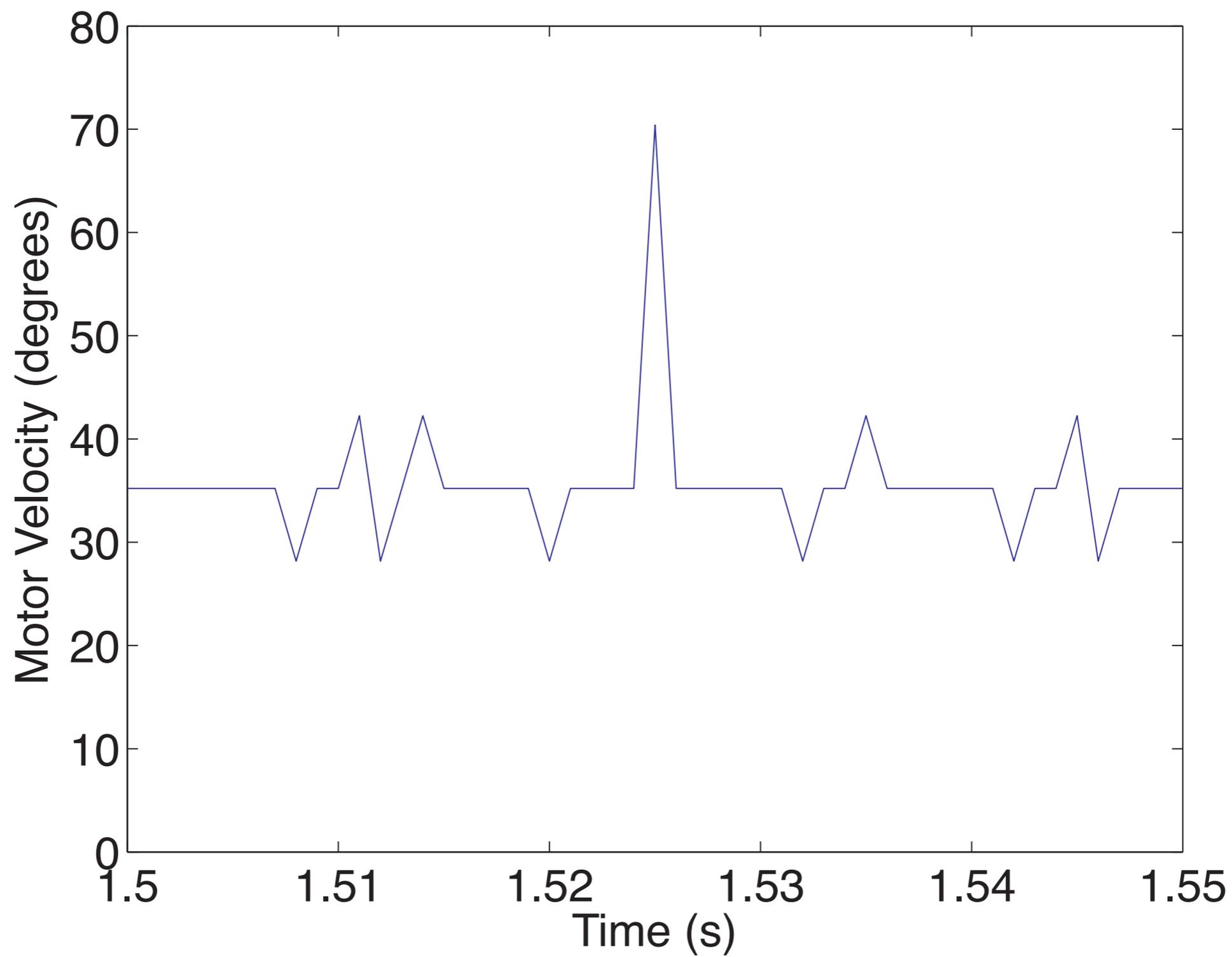
$$\Delta\theta_m = 1.8^\circ \cdot \frac{51200 \text{ counts}}{360^\circ} = 256 \text{ counts}$$

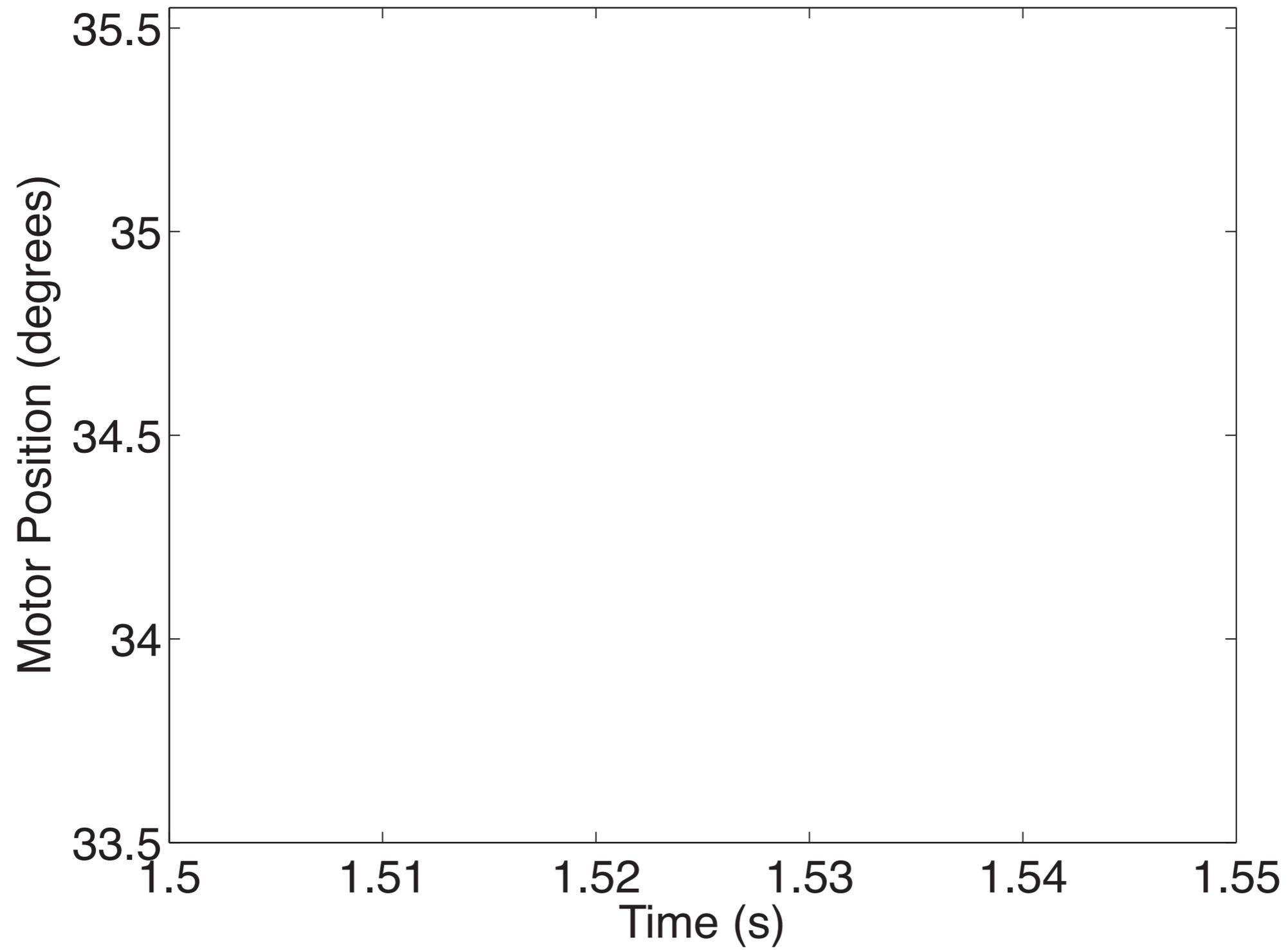


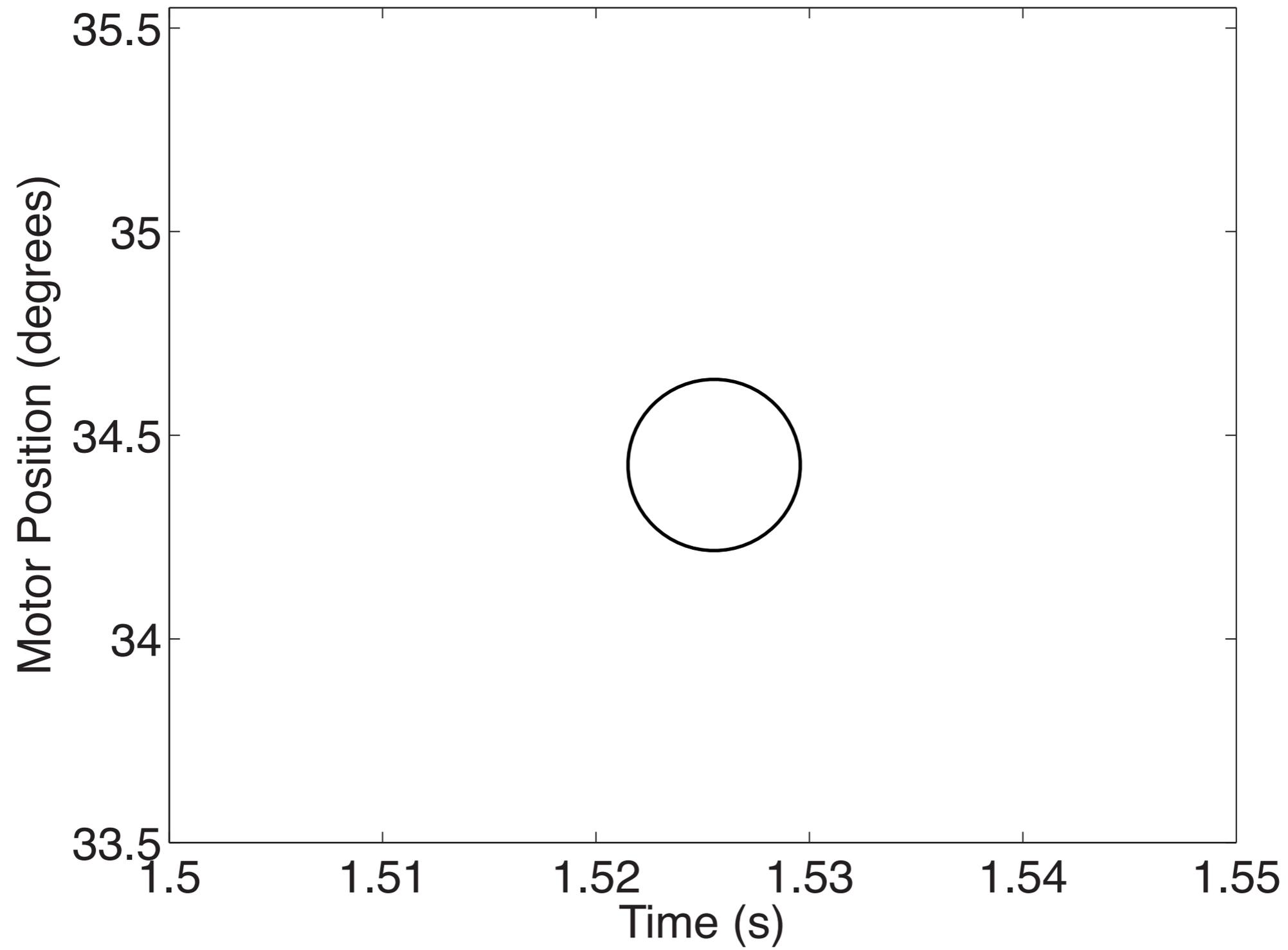












```
        PostMessage(win, WM_DESTROY, NULL, NULL);
    }
    force_bias_initialize = true;

    // Configure quadrature board.
    ULStat = cbC7266Config (QUAD_BOARD_NUM, MOTOR_ROT, X4_QUAD, NORMAL_MODE, BINARY_ENCODING,
        INDEX_DISABLED, DISABLED, CARRY_BORROW, DISABLED);

    // Initialize the quadrature board
    LoadValue = 800000;
    ULStat = cbCLoad32 (QUAD_BOARD_NUM, COUNT1, LoadValue);
    ULStat = cbCLoad32 (QUAD_BOARD_NUM, COUNT2, LoadValue);
    ULStat = cbCLoad32 (QUAD_BOARD_NUM, COUNT3, LoadValue);
    ULStat = cbCLoad32 (QUAD_BOARD_NUM, COUNT4, LoadValue);

    ULStat = cbCLoad(QUAD_BOARD_NUM, PRESCALER1, 1);
    ULStat = cbCLoad(QUAD_BOARD_NUM, PRESCALER2, 1);
    ULStat = cbCLoad(QUAD_BOARD_NUM, PRESCALER3, 1);
    ULStat = cbCLoad(QUAD_BOARD_NUM, PRESCALER4, 1);

    // Get the high resolution counter's accuracy.
    QueryPerformanceFrequency(&ticksPerSecond);
    sprintf(clockResult, "There are %I64d ticks per second", ticksPerSecond.QuadPart);

    // Seed the random-number generator with current time.
    srand((unsigned)time(NULL));

    // Start the graphics timer
    SetTimer(win, 0, GRAPHIC_UPDATE_PERIOD, NULL);

    // Start the haptic thread
    g_HapticThread.Start(HAPTICS_UPDATE_PERIOD, Haptic_Function, NULL);

    return 0;

case WM_MOUSEMOVE:

    SetCursor(LoadCursor(NULL, IDC_ARROW));
    return 0;

case WM_DESTROY :

    // Stop the Haptic Thread
    g_HapticThread.Stop();
```

```

/*****
Haptic_Function
  This is the function that updates the system's forces
*****/

void __stdcall Haptic_Function(void *pv)
{
  int i;
  static double timer = 0; // Used as a timer for several different purposes.

  //////////////////////////////////////
  // *** TIMING ***

  // Cache the time of the previous haptic function call.
  lastTime = thisTime;

  // Find out what time it is now. This information facilitates accurate velocity calculation.
  QueryPerformanceCounter(&thisTime);

  // Calculate time since last call in clock cycles and then convert to seconds.
  deltaTime.QuadPart = (thisTime.QuadPart - lastTime.QuadPart);
  deltaTimeS = (float) deltaTime.LowPart / (float) ticksPerSecond.QuadPart;

  //////////////////////////////////////
  // *** FORCE/TORQUE MEASUREMENTS ***

  // Get present voltage values from f/t sensor
  RawVoltage(tempRawVoltage);

  // Filter voltage
  for (i=0 ; i<7 ; i++) {
    filteredRawVoltage[i] = LowPass1((double)1.0/(2.0*PI*50.0), deltaTimeS, (double)tempRawVoltage[i], (double)filteredRawVoltage[i]);
  }

  // Handle initialization of force/torque sensor
  if ((force_bias_initialize) && (filter_wait > 50))
  {
    if (Number_of_Samples < MAX_NUMBER_OF_SAMPLES) {
      for (int CONV_r = 0; CONV_r < 7; CONV_r++) {
        VoltageBiasTemp[CONV_r][Number_of_Samples] = filteredRawVoltage[CONV_r];
      }
      Number_of_Samples++;
    }
  }
}

```

```

// *** MOTOR CONTROL ***

// Save last position for velocity computation.
lastPosDeg = curPosDeg;

// Read in encoder signals from the QUAD04 board
ULStat = cbCIn32 (QUAD_BOARD_NUM, MOTOR_ROT, &rot_cts);

//Convert to signed counts
rot_cts_signed = rot_cts;

// Convert signed counts to degrees
curPos = rot_cts_signed - LoadValue;
curPosDeg = curPos / CTS_PER_DEG;           // Converts position to units of degrees

// Check for freak position reads - if change is too much, discard this reading, and use the last
one.
if (fabs(curPosDeg - lastPosDeg) > 1) {
    curPosDeg = lastPosDeg;
}

// Compute velocity and low-pass filter.
unfiltVelDeg = (curPosDeg - lastPosDeg) / deltaTimeS;
curVelDeg = LowPass1(1/(2*PI*50), deltaTimeS, unfiltVelDeg, curVelDeg);

// F/T transducer safety checks.
if(fabs(FTValues[0])>200 || fabs(FTValues[1])>200 || fabs(FTValues[2])>500 || fabs(FTValues[3])>1500 ||
00 || fabs(FTValues[4])>1500 || fabs(FTValues[5])>2000) {
    // If over limits, make desired position present position with no output.
    desPosDeg = curPosDeg;
    desVelDeg = curVelDeg;
    current = 0;
    voltage = 0;
} else {
    // Calculate the proxy's position and velocity during a trial for all of the different sta
sites.
    switch (state) {
    case waitingForParameters:
    case ready:
        // Trial set will start soon. Keep proxy at zero position.
        proxyPosDeg = 0;
        proxyVelDeg = 0;
        break;
    case showingCommand:
        // Next trial will start soon. Keep proxy at its current position, sitting still.
        proxyPosDeg = proxyPosDeg;
        proxyVelDeg = 0;

```

```
dotFeedback ? 'D' : 'd', proprioceptiveFeedback ? 'P' : 'p', tactileFeedback ? 'T' : 't', commandPosDeg, co
commandWidthDeg);
    //      return;
    //}

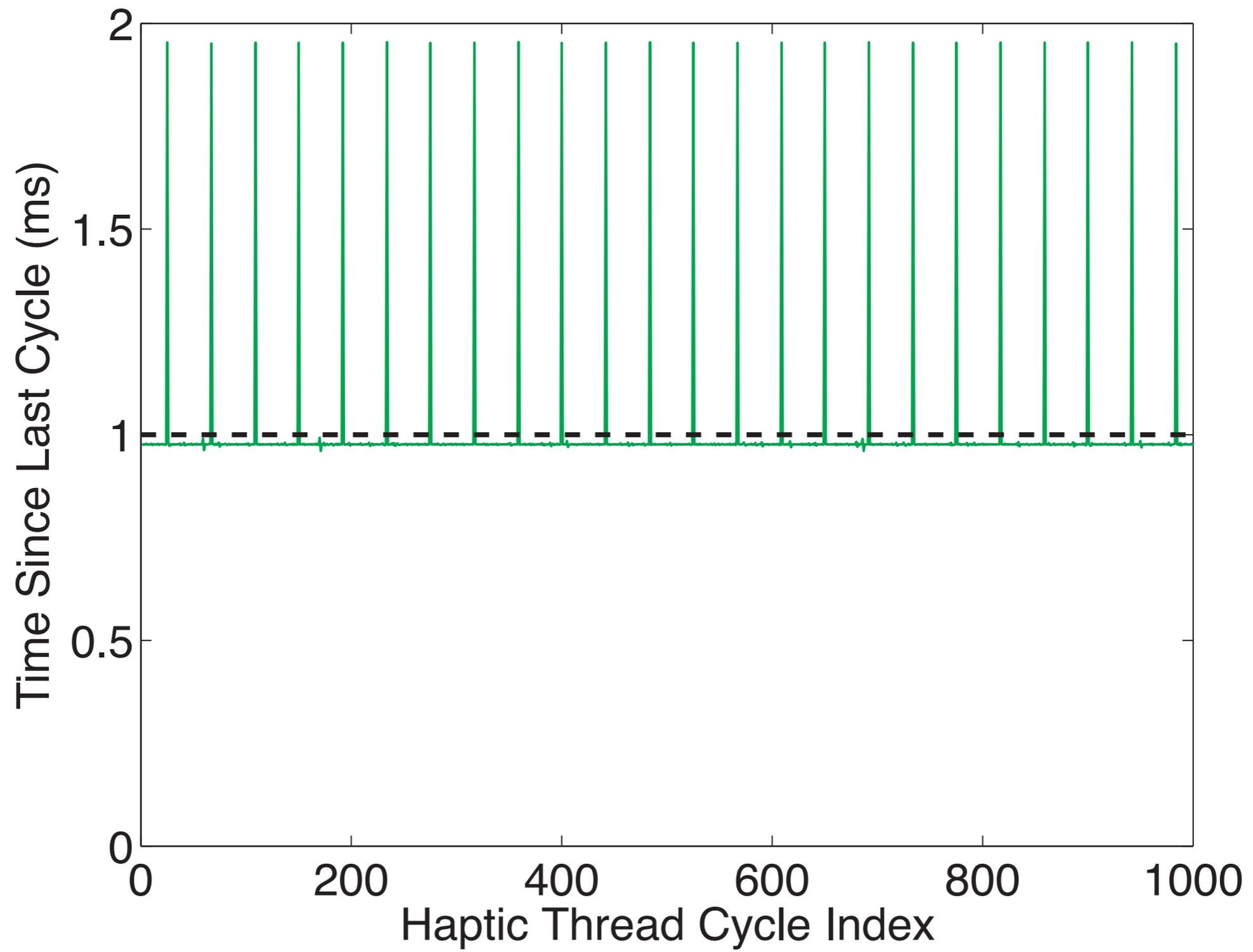
    // Output the desired values to the file.
    // Write parameters.
    fprintf(output_file, "subjectNumber = %d;\n\n", subjectNumber);
    fprintf(output_file, "setNumber = %d;\n\n", setNumber);
    fprintf(output_file, "trialNumber = %d;\n\n", trialNumber);
    fprintf(output_file, "lineFeedback = %d;\n\n", lineFeedback);
    fprintf(output_file, "dotFeedback = %d;\n\n", dotFeedback);
    fprintf(output_file, "proprioceptiveFeedback = %d;\n\n", proprioceptiveFeedback);
    fprintf(output_file, "tactileFeedback = %d;\n\n", tactileFeedback);
    fprintf(output_file, "commandPosition = %d;\n\n", commandPosDeg);
    fprintf(output_file, "commandWidth = %d;\n\n", commandWidthDeg);
    fprintf(output_file, "proxyAdmittance = %f;\n\n", proxyAdmittance);
    fprintf(output_file, "k = %f;\n\n", k);
    fprintf(output_file, "b = %f;\n\n", b);

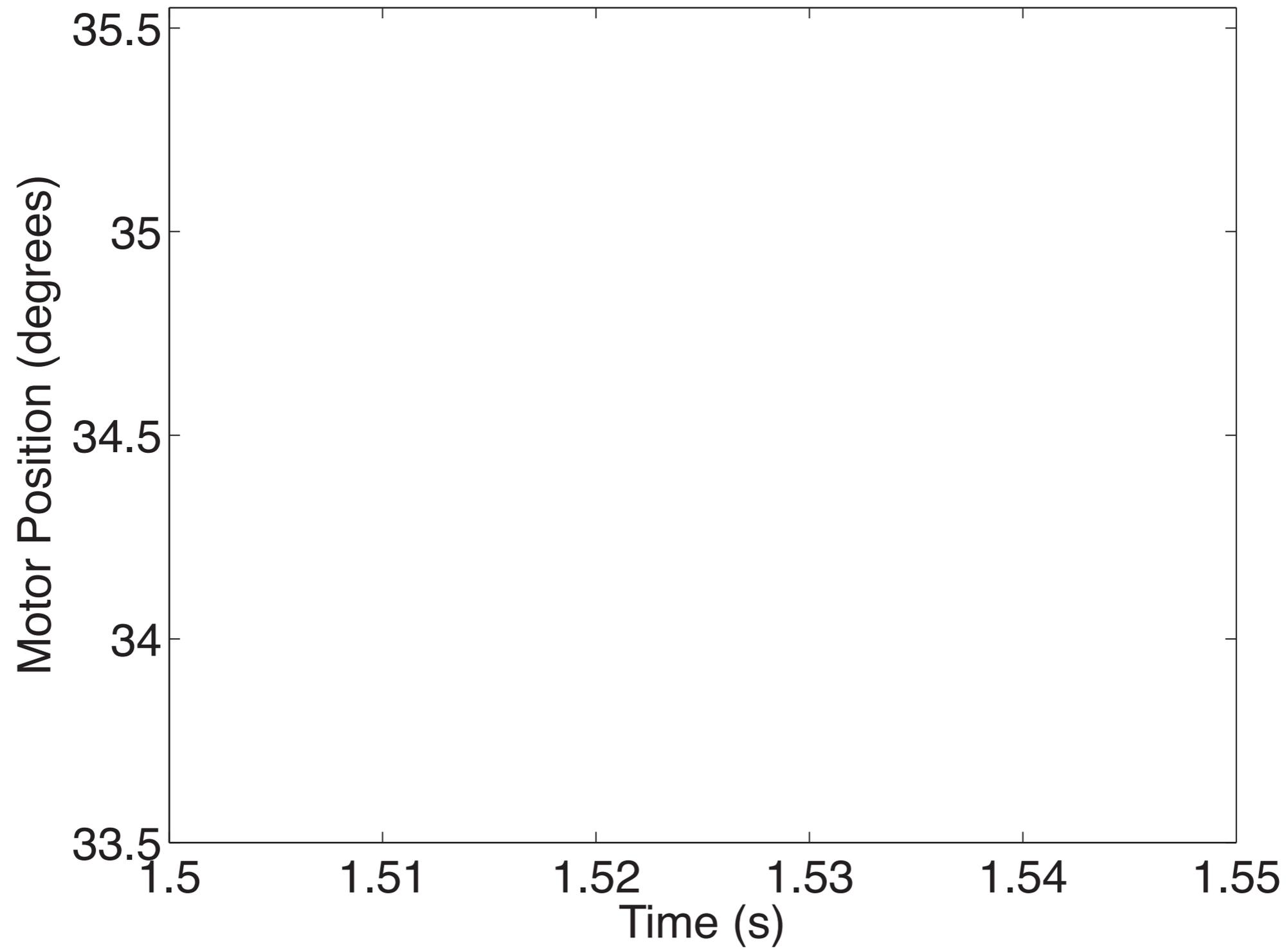
    // Write the real time vector.
    fprintf(output_file, "clockTicksPerSecond = %I64d;\n\n", ticksPerSecond);
    fprintf(output_file, "tClock = [");
    for(i=0; i<dataIndex; i++) {
        fprintf(output_file, "%I64d\t", timeArray[i]);
    }
    fprintf(output_file, "]" - %I64d;\n", timeArray[0]);
    fprintf(output_file, "t = tClock / clockTicksPerSecond;\n\n");

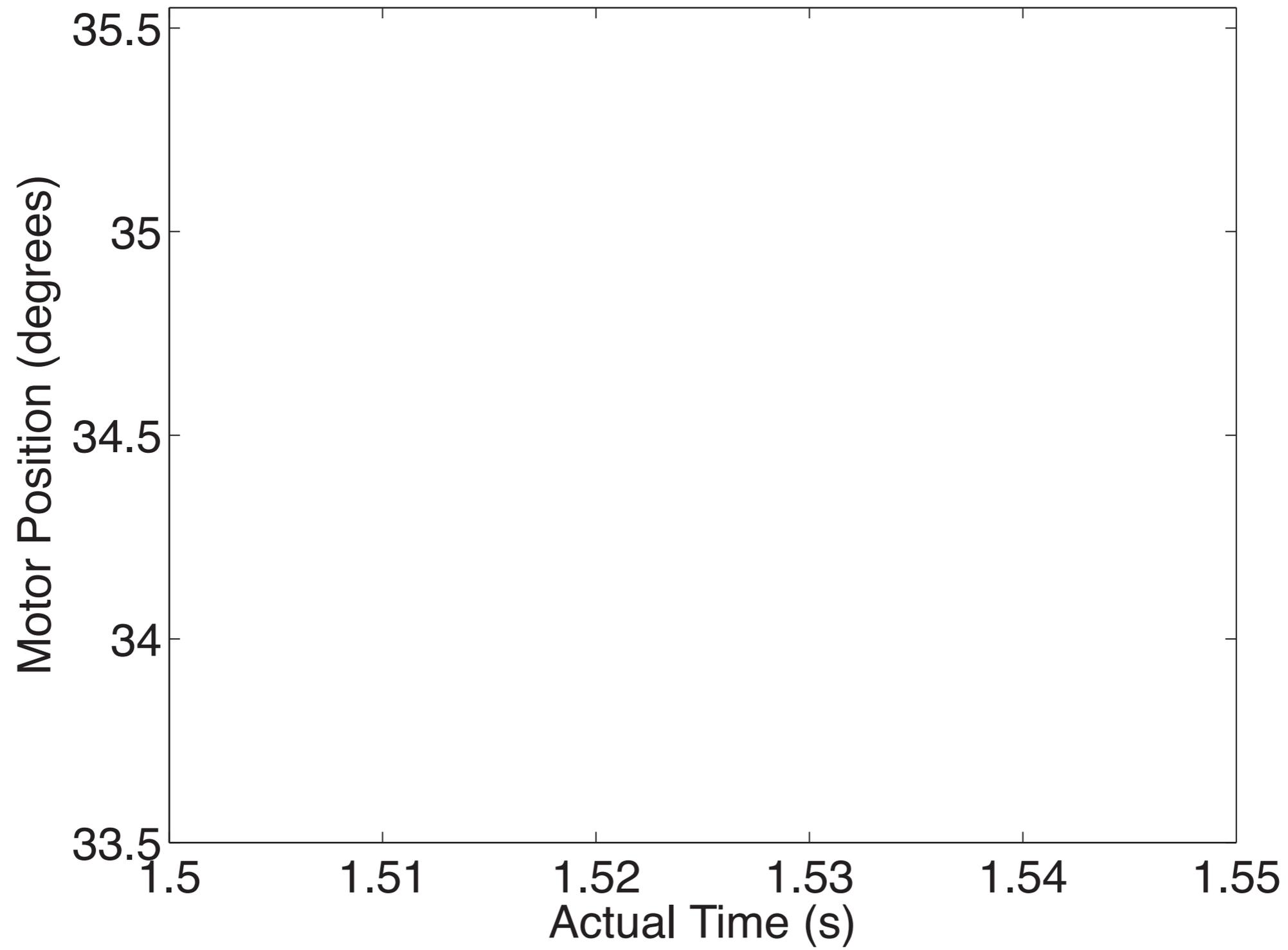
    // Write time-varying data.
    fprintf(output_file, "dacVoltage = [");
    for(i=0; i<dataIndex; i++) {
        fprintf(output_file, "%.9f\t", dacVoltageArray[i]);
    }
    fprintf(output_file, "];\n\n");

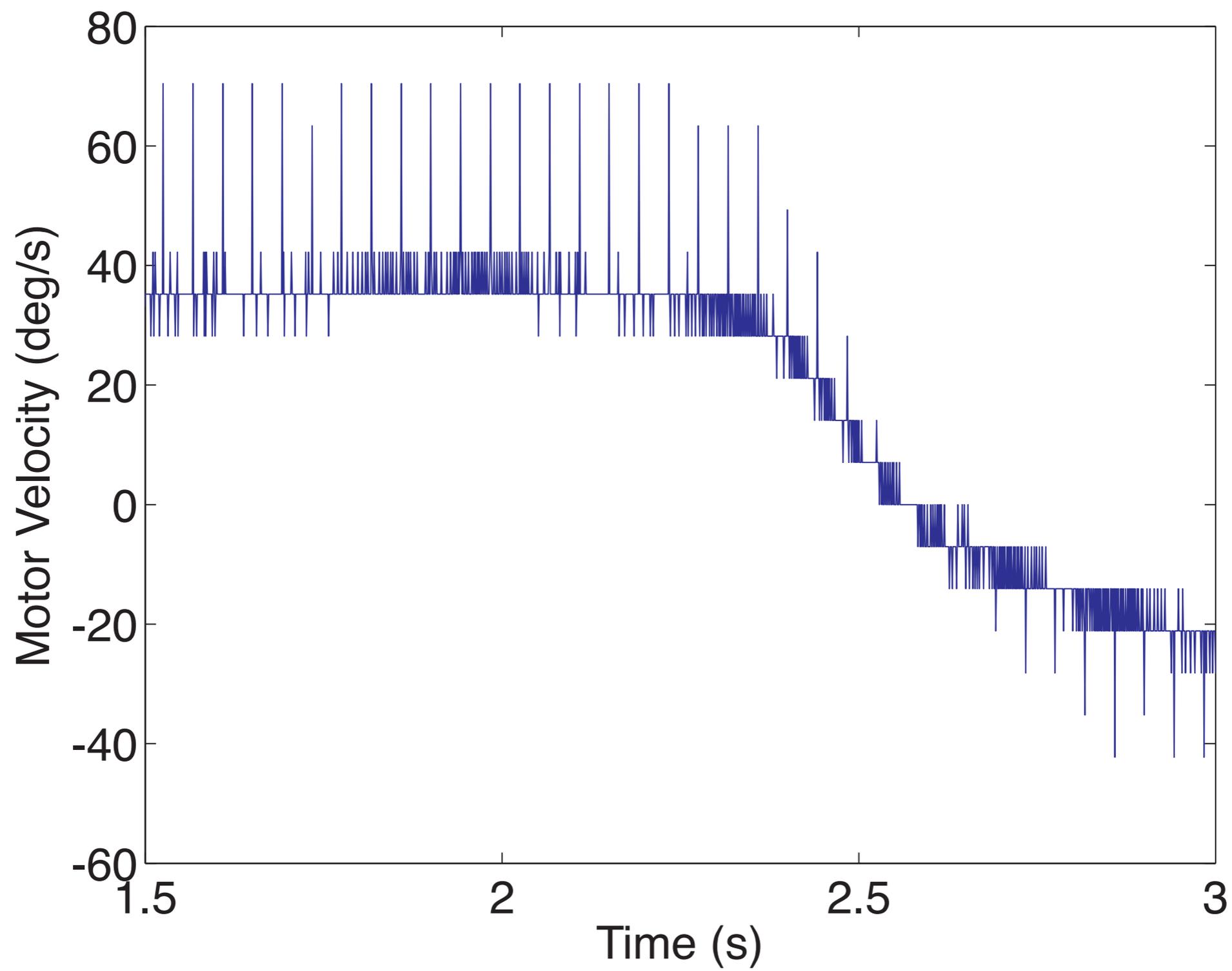
    fprintf(output_file, "fingerForce = [");
    for(i=0; i<dataIndex; i++) {
        fprintf(output_file, "%.9f\t", fingerForceArray[i]);
    }
    fprintf(output_file, "];\n\n");

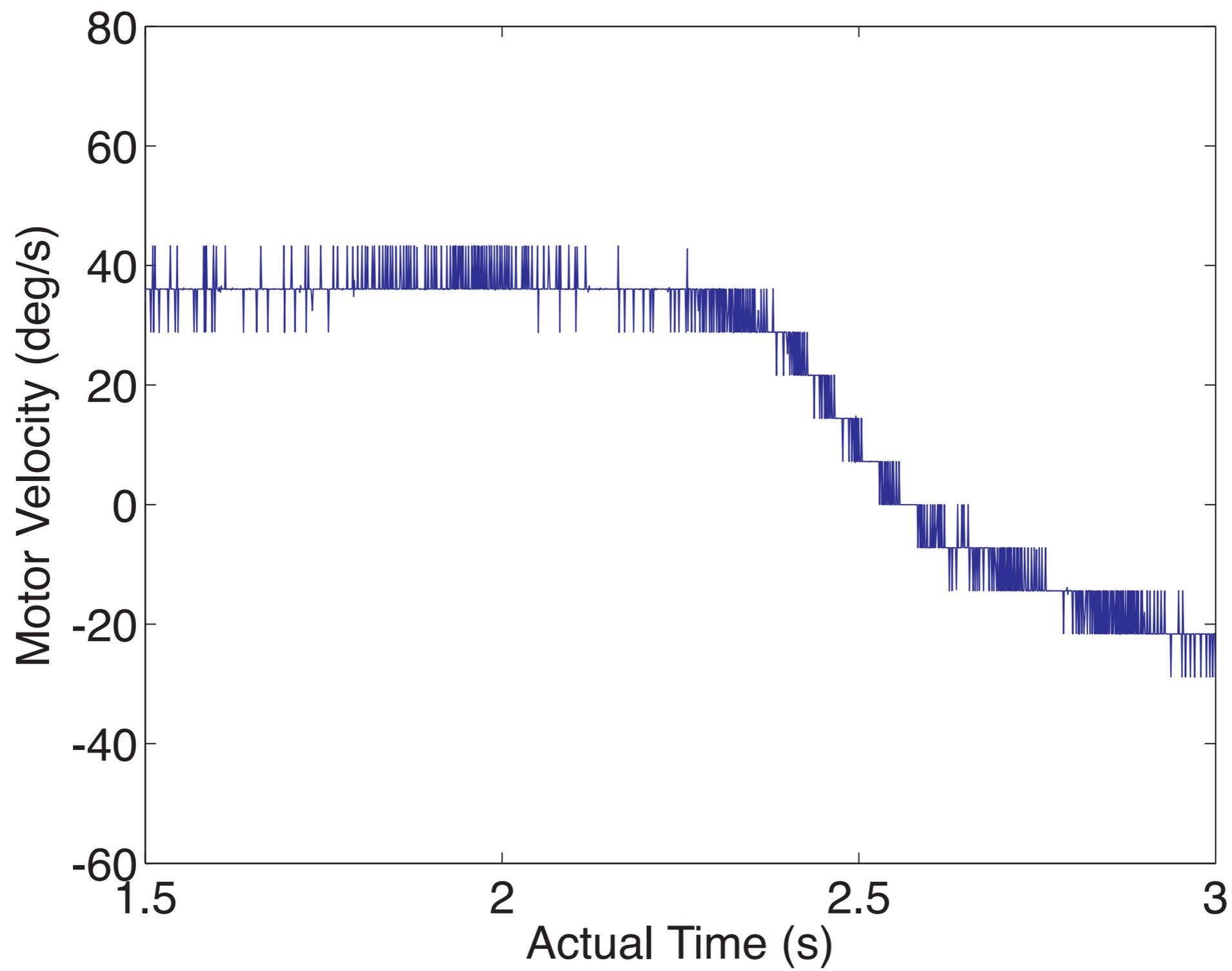
    fprintf(output_file, "motorPosition = [");
    for(i=0; i<dataIndex; i++) {
        fprintf(output_file, "%.9f\t", motorPositionArray[i]);
    }
    fprintf(output_file, "];\n\n");
```











Know your sensors and your signals.

Thank You



Questions?



kuchenbe@seas.upenn.edu
<http://haptics.grasp.upenn.edu>